GTI 5G Device RF Component Research Report

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1 Executive Summary

How to realize "high efficiency and low power consumption" device is a technical issue which should be emphasized on throughout the 5G RF component R&D process. The power consumption should be optimized based on the deployment plan of operators and the requirements of customers. This process should involve not only RF component vendors, but also chipset vendors and device vendors.

RF FEM is one of the most popular solutions to realize 5G NR RF components, especially for the large volume of high-end devices, due to its smaller layout area, better inter-stage matching, less design inputs, shorter test process and faster time to market. So FEM is a research and development direction worthy of attention.

According to 3GPP's schedule, the first version of 5G standard R15 will be completed in the middle of 2018 and R16 is going to be completed by the end of 2019. The 5G+ technical specification will be constantly updated since 2020. It is hoped that RF components vendors could actively participate in and track 3GPP's discussion on the specifications of 5G RF components as well as establish theoretical basis for the final specifications based on the prospective simulation and test data. In order to guarantee commercial RF components in time, RF components designers and manufactures should work together with operators, chipset vendors, device vendors and test instrument vendors to make sure the system verification and the pre-commercial trial could be completed in 2018 and 2019 separately The high performance and low cost front-end RF components are expected to be provided in proper time and volume. So the RF component vendors are supposed to cooperate with the whole industrial chain to accomplish the goal of 5G's commercialization by the end of 2020.

GTI 5G Device Component Research Report is expected to help people to develop 5G devices and to promote industrial development. This report may also help people to know more about the industrial status of 5G device RF components. Meanwhile, it may also help readers interested in 5G device RF components to gain from the further thinking.

2 Introduction

4G has completely changed our lives. While, as the society becomes much more informative, people's requirements increase rapidly. Devices are supposed to have better performance and provide more qualified service. Thus more and more opportunities and changes are created for mobile communication. Compared with 4G, 5G would have higher experiencing speed, higher connection density and lower latency. Not only the connections between people and people, but also people and things, things and things would be included into 5G scope. Aiming at constructing a cross industry ecosystem and further changing people's lives, 5G sets its sights on enhanced Mobile Broad Band (eMBB), massive Machine Type Communication (mMTC) as well as Ultra Reliable and Low Latency Communication.

China Mobile plays an important role in prompting 5G to enter the commercial stage before 2020. As the leader of the IMT-2020 requirement group, China Mobile led to complete '5G Vision and Requirement' White Paper as well as the 5G requirements in NGMN and the 5G requirements and scenarios in 3GPP. Aiming for 5G's commercialization in 2020, sub-6GHz is the focus at this moment. Considering the millimeter Wave spectrum won't be used for mobile telecommunication until 2019 and after that 2~3 years will be needed for spectrum allocation in China, the commercialization of 5G mmWave might be 2022 or even later.

Before the commercialization in 2020, China Mobile will complete the 3-phase validation of 5G, the key technology test, the system test and the large-scale test. The key technology test and the system test has been completed by 2017. The large-scale test has started in 2018. With the purpose of specifying the direction in developing testing prototypes, China Mobile jointly released the 'GTI Sub-6GHz 5G Device Whitepaper' with GTI industrial partners in Nov. 2017 and kicked off "GTI 5G S-Module Initiative" in Jun. 2018. The white paper analyzed the key technologies as well as the hot topics and difficult problems in the implementation of 5G pre-commercial/commercial devices. Many problems are related to 5G device RF components. So the implementation of RF components has become the key link to realize the 5G devices.

Therefore, co-operating with China Mobile 5G Innovation Center, GTI Device Working Group leads to write this "GTI 5G Device RF Component Research Report" with the industrial partners. This report mainly focuses on the 5G device RF components and has been carried out in two directions respectively, the sub-6GHz RF components and the millimeter wave RF components. Combined with the consideration of integrated circuit technology, the report analyses the industrial status, key technologies, design challenges, alternative process and research progress of core 5G RF components, such as power amplifier, filter, low noise amplifier and switch. Some related 'Black Technologies' which may have great influence on future RF components are also introduced in the report.

We sincerely thank all the contributors for their hard work in writing this report.

Chapter 5 5G Device RF Component Industry Status: HiWafer, Soitec, Qorvo, Skyworks, TAIYO YUDEN, Murata, VanChip and Smarter Micro, etc.

Chapter 6 Sub-6GHz 5G Device RF Component

6.1 Sub-6GHz 5G Power Amplifier: Skyworks, Qorvo, VanChip, HiWafer, and Smarter Micro, etc.

6.2 Sub-6GHz 5G Filter: TAIYO YUDEN and Qorvo, ect.

6.3 Sub-6GHz 5G Low Noise Amplifier: Qorvo and HiWafer, etc.

Chapter 7 mmWave 5G Device RF Component: HiWafer, Murata and Qorvo, etc.

Chapter 8 Related 'Black Technologies': Soitec, Qorvo and Skyworks, etc.

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This report will be continuously updated according to the research and development progress.

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4 Abbreviations

Abbreviation	Explanation
BAW	bulk acoustic wave
CC	Component Carrier
CMOS	Complementary Metal Oxide Semiconductor
DC	Dual Connectivity
eMBB	Enhanced Mobile Broadband
ESD	Electro-Static discharge
FBB	Forward Back Gate bias
FBAR	Film Bulk Acoustic Resonator
FD	Fully Depleted
gNB	NR node
HEMT	High Electron Mobility Transistor
HSP	Harmonic Suppression Process
HPUE	High Power UE
IPD	Integrated Product Development
LTCC	Low Temperature Co-fired Ceramic
MEMS	Micro-Electro-Mechanical System
MIMO	Multiple-Input Multiple-Output
mMTC	Massive Machine Type Communication
mmWave	Millimeter Wave
MMMB	Multimode Multiband
MMIC	Monolithic Microwave Integrated Circuit
MOSFET	Metal–Oxide–Semiconductor Field-Effect Transistor
MU-MIMO	Multi-User MIMO
NSA	Non-Standalone
OFDM	Orthogonal Frequency Division Multiplexing
pHEMT	Pseudomorphic HEMT
PPAC	Performance, Power, Area, and Cost
PAE	Power Added Efficiency
PD	Partially Depleted
RFeSI	RF enhanced Signal Integrity
RFFE	Radio Frequency Front-end

SAW	surface acoustic wave
SA	Standalone
SOI	Silicon on Insulator
SIMOX	Separation by Implantation of Oxygen
SU-MIMO	Single-User MIMO
UE	User Equipment
URLLC	Ultra-Reliable and Low Latency Communications
UTBB	Ultra Thin Body and Box
3GPP	The 3rd Generation Partnership Project

5 5G Device RF Component Industry Status

Based on the Navian predication, the total market size of RF front-end modules for mobile communications devices will grow from $ 9.2 billion in 2014 to $ 17 billion in 2019.

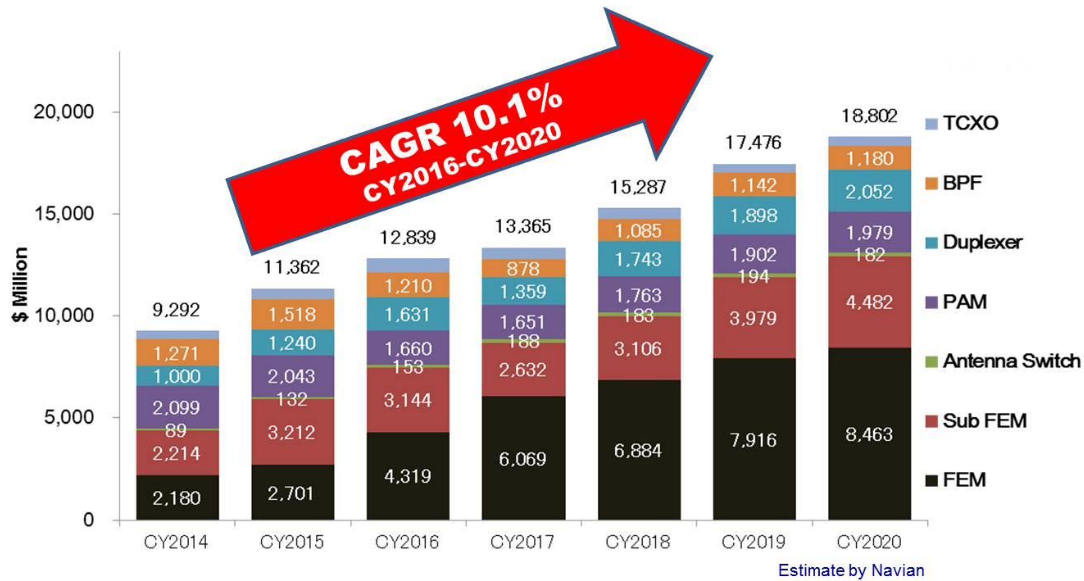


Figure 5-1 Navian Predication on RF Front End Module Market (2017)

At present, the RF front-end chip market is mainly divided into two categories: a class of acoustic technology-based filters to surface acoustic wave filter (SAW) and Bulk acoustic wave (BAW) as the representative, one is the use of semiconductor technology Manufactured circuit chip, with power amplifier (PA) and switch circuit (Switch) as the representative.

The traditional SAW filter market has become saturated, with Murata, TDK and Taiyo Yuden accounting for more than 80% of the global market. Murata Manufacturing Co., Ltd. (Kabushiki-gaisha Murata Seisakusho) is a famous Japanese manufacturer of passive electronic components, such as capacitors and inductors, which is founded in 1940s. Ever since the beginning of the era of communications, Murata started business in RF aspects as well. After expanding the product lineup of filters, Murata achieved acquisition of Renesas Electronics and Peregrine Semiconductor, which leads to an integration of the lineup of RFFE products. Nowadays the product lineup of wireless communications department of Murata has almost covered all of the RFFE products including SAW and Multi-layer filters, RF switches, modules of either transceiver-end or receiver-end, power amplifiers, and RF connectors, etc. TAIYO YUDEN, after acquired Fujitsu Media Devices Ltd. in Y2010, has extended its technology portfolio by adding SAW and FBAR technologies in addition to LTCC RF device technology. Now the company is providing various RF devices (Filter, Duplexer, Diplexer, Low Pass Filter, etc.) for 2G/3G and 4G. While the company has already been working on the development of the series of Sub-6GHz filters for 5G since very early stages, it has also completed the initial technology validation to cover up to mmW ranges including both 28GHz and 39GHz frequency ranges in

the light of upcoming 5G requirement which is being standardized within 3GPP group at this time. These three core technologies, SAW/FBAR/LTCC RF technologies, are indispensable for the implementation of upcoming 5G standard and the company will continue to enhance these technologies and develop new products through integrating three technologies.The current BAW core technologies are mainly in the hands of Broadcom (Avago) and Qorvo, as shown in figure 5-2. According to HIS data, Broadcom (Avago) and Qorvo have almost split their market share.

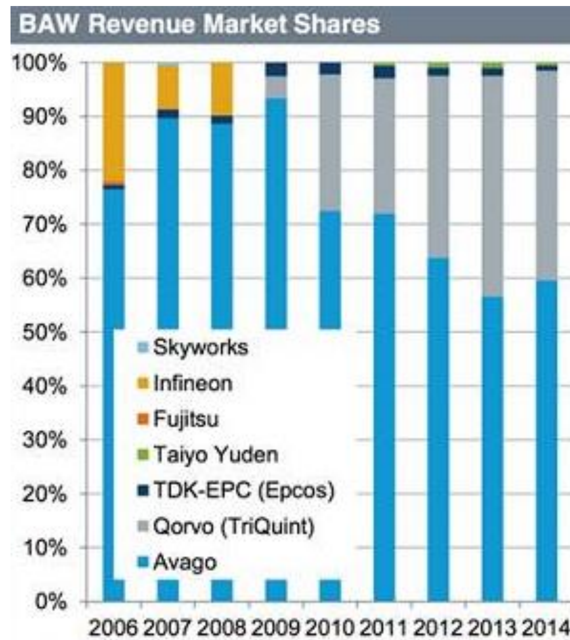


Figure 5-2 HIS Statistics on BAW Market Share (Up to 2014)

As shown in figure 5-3, based on Navian's 2017 statistics, the device power amplifier market, forms the oligarchical competition between Skyworks, Qorvo and Broadcom (Avago), which together accounted for 90% of the market share. Founded in 1962, Skyworks is an industry-leading RF front-end semiconductor solution provider that designs and manufactures radio frequency (RF) for mobile handsets, cellular network equipment, automotive, energy management, industrial and medical applications And complete semiconductor system solutions, products include amplifiers, filters, switches, attenuators, diodes, directional couplers, front-end modules. Qorvo is the new merger of RF Micro Devices and TriQuint Semiconductor, two of the industry's leading RF solutions companies. The combined Qorvo has two key product lines: the Mobile Device Product Line, the Base Station and the Military Device Product Line, both of which Line for different markets, but also in complementary areas of advanced technology research and development. Broadcom, a maker of acquisition chips for Avago Technologies, has been renamed Broadcom Limited to focus on III-V compound semiconductor design and process technology, providing a broad range of analog, mixed-signal and optoelectronic components product and system design and development. At present, major product lines include Wireless communications, cable infrastructure, enterprise storage, industrial and others.

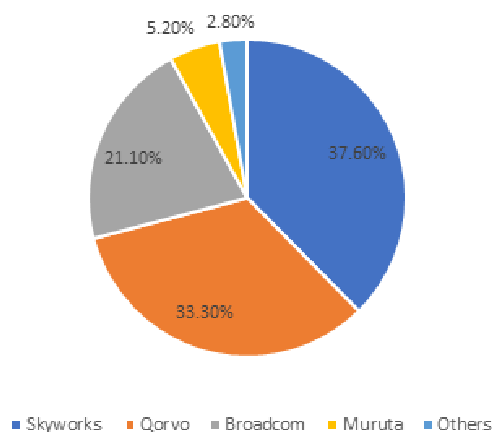


Figure 5-3 Navian Statistics for the Device Power Amplifier Market (2017)

RF-device market is almost dominated by the International RF-device companies. As the developments of 4G and 5G communication networks, the domestic RF-device companies get more opportunities. Vanchip, a company running the IC design, measurement and sale business, has lots of products used in 2G/3G communications. Lansus developed domestic PA and RF switch in 2010. Its NZ5081 PA has been used in Yulong Coopad 8180 TD-SCDMA, which is the first PA used in domestic smart phone. The customer of Lansus includes Mi, Coolpad, ZTE and MEIZU. Hunstersun, a domestic 2G/3G/4G RF front end IC supplier, 600 millions sales in 2015. Products involved 3-mode-8-frequency, 5-mode-17-frequency, 2G CMOS and 3G CMOS TxM RF front end ICs. SmarterMicro, a domestic 4G/5G RF front end fabless IC supplier, has developed the world first reconfigurable RF front end platform, called AgiPAM®. This platform utilize the flexibility of the software and high performance hard ware for the RF front end design, which can make the RF front end more intelligent and have higher performance and lower cost. This technology is very suitable for the 4G and 5G wireless system. Based on this platform, SmarterMicro has developed a series of products, which have been shipped to many countries and regions around the world. So, the domestic RF IC companies have strong ability of product developing.

RFIC manufacturing industry is accelerating while the RFIC design houses are blooming. In the sub-6GHz band of 5G, HiWafer has developed 2um GaAs HBT process. As the mainstream technology, this process realized the monolithic integrations of the active and passive devices, which can provide better linearity, stability and reliability, This process also fits for the 3G/4G cellphone, Wifi/WiMAX, used as power amplifiers. The high frequency bands of 5G communications are near the 30GHz, 40GHz, 70GHz and 80GHz, which is a hard work for industry. HiWafer developed 0.15um GaAs pHEMT/ED HEMT process for high frequency bands of 5G. This process will support 20-60 GHz, which can be used for the high-speed data transmission in small base station, user end, IOT. With the advantages of high breakdown voltage, high electron saturation velocity and channel carrier mobility, low cost, the InP HBT and GaAs mHEMT process will get more attention.

Manufacturing process is developing to adapt to the demand .In sub-6GHz band, GaAs HBT is the main technology .In the Millimeter wave, that has not come to an agreement between

pHEMT, CMOS or else. HBT process technology of HiWafer is aimed at sub-6GHz market and pHEMT process is aimed at 5G high-frequency bands market.

Consumers usually prefer the devices having advantages of lower price, higher efficiency, better performance and lower power consumption etc. The soi technology provides possibilities for devices to realize those characteristics. Besides, SOI technology can shorten time to market and require small design modification with low cost. With the advantages mentioned above, SOI technology has attracted more and more attentions in semiconductor industry.

As a semiconductor materials vendor, Soitec designs and manufactures engineered substrates that are then patterned and cut into chips to make circuits for electronic components. In meeting the technical and economic challenges of mainstream electronics, SOI is helping to speed up the mobile and digital revolutions as below:

- FD-SOI and PD-SOI: for Processors & connectivity SoCs up to mmW;
- RF-SOI and POI: for RF Front-end Modules;
- Photonics-SOI: for Optical Transceivers;
- Power-SOI: for Smart Power ICs;
- Imager-SOI: for Imagers

In Front End Module, substrate is the foundation of each key device. In the following report, silicon (RF-SOI, PD-SOI, FD-SOI) and non silicon (POI, InPOGaAs, etc…) engineering substrate technologies to address 5G challenges are presented.

6 Sub-6GHz 5G Device RF Component

6.1 Sub-6GHz 5G Power Amplifier

Frequency and power is the basic requirement in PA design, also Linearity, along with efficiency and bandwidth, belongs to the fundamental specification of PA design in communication systems. In a sense, efficiency and linearity are contradictory, higher efficiency may lead to worse linearity. These two parties need to be balanced during PA design.

6.1.1 Existing Mobile Device Commercial Power Amplifier

6.1.1.1 Common Mobile Device RF Front-end Architecture

In commercial UE nowadays, PA needs to support 2G/3G/4G. Based on platform requirements, there are difference between 2G linear PA and 2G saturated PA(GSM saturated, EDGE linear) respectively.

In terms of RFFE architecture, usually we can see four mainstream architectures: MMMB PA+ASM architecture, MMPA + TxFEM architecture, PAMiD architecture and MMMB/2G PA + FEMiD architecture.

As shown in figure 6-1, this is block diagram of a commercial MMMB PA. The MMMB PA integrates 2G/3G/4G PA, connect with the antenna switch module ASM through external filters and duplexers.

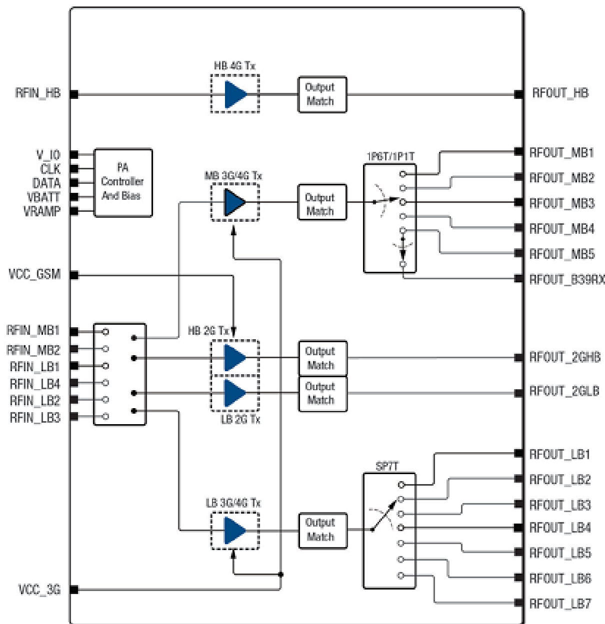


Figure 6-1 Block diagram of a commercial MMMB PA

MMPA+ TxFEM is the most common RF front end architecture especially in the China market. As shown in figure 6-2, MMPA only integrates 3G/4G PA. 2G PA is integrated with ASM, which is called "TxFEM".

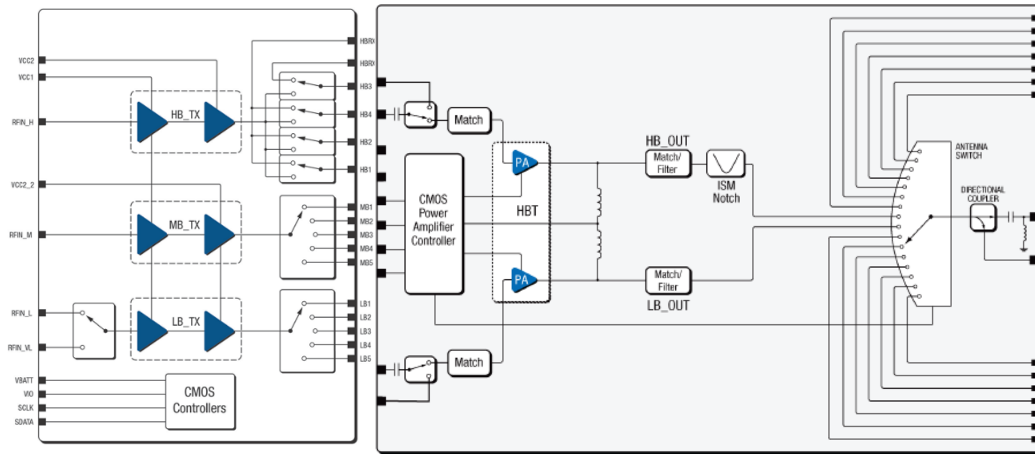


Figure 6-2 Block diagram of a commercial MMPA and TxFEM

Among these topologies, the flagship models that support most of worldwide frequency bands mainly adopt the PAMiD architecture. As shown in figure 6-3, it is a block diagram of a commercial low band PAMiD, integrates all RF and analog content between the transceiver and antenna, reduce complexity, size and time-to-market for customers with demanding architectures for advanced mobile applications.

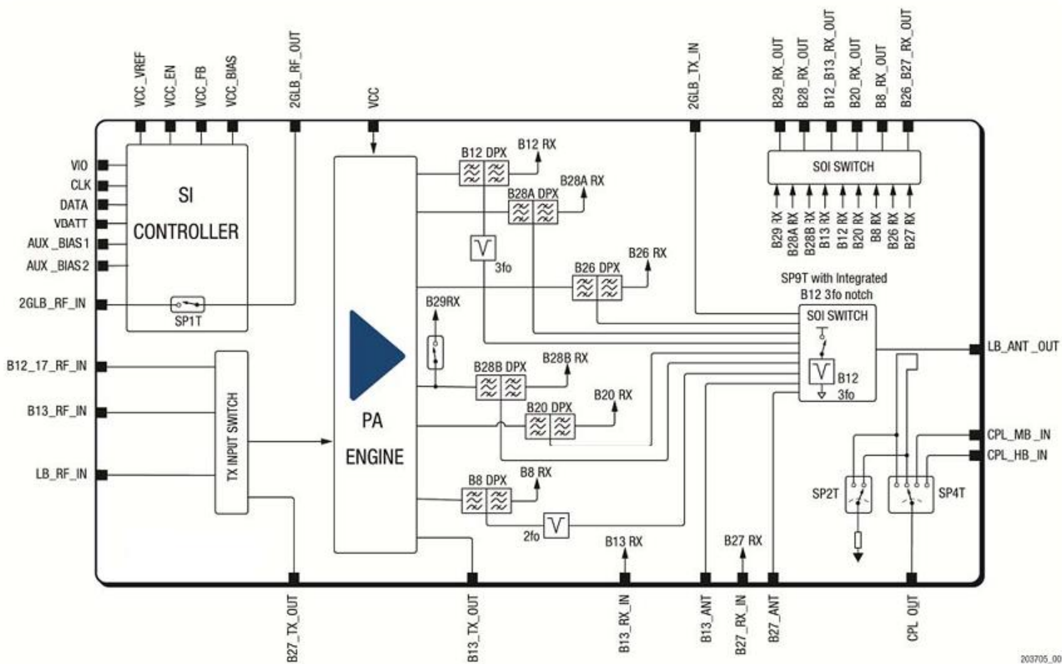


Figure 6-3 Block diagram of a commercial LB PAMiD

PS: all the figures above are provided by Skyworks

For the PAMiD architecture, both PA and filter technologies are needed for the supplier. These requirements resist many new suppliers to enter the market. The MMMB/2G PA+FEMiD architecture, which can separate the requirements of PA and filter, draws a lot of attention of RF front end suppliers.

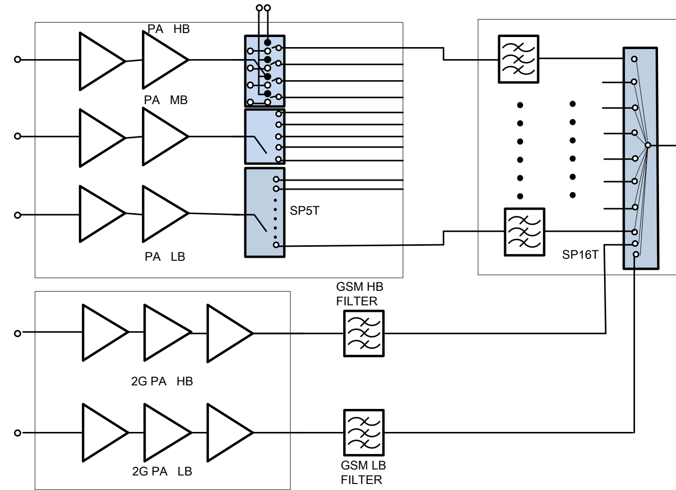


Figure 6-4 Block diagram of MMMB/2G PA+FEMiD

PS: figure 6-4 is provided by SmarterMicro

6.1.1.2 Key Parameters

1) Pout and Gain

The output power required by different systems is not the same. In the LTE UE, there are also different power classes like PC2 (antenna port 26dBm), PC3 (antenna port 23dBm). In order to obtain the output power of this range, the gain of the amplifier is about 20-30dB according to the level of the input signal.

2) Efficiency and PAE

PA converts the DC power from power supply to AC signal power, during the conversion, part of the DC power is converted to useful signal, and the rest is consumed by the PA itself and the parasitic components in the circuit. If use PL to represent the power on the load, PD represents the DC power provided by the power supply; then the efficiency of the PA can be simply defined as PL/PD. But this does not fully reflect the amplification function of PA. Therefore, PAE is introduced to fully reflect the relationship between PA output power and power supply, which is (PL-Pin) /PD.

3) Linearity

The nonlinear distortion produced by PA is reflected on both amplitude and phase. Generally, we evaluate the spectrum expansion by measuring the response of PA to the modulation signal, for example, the Adjacent Channel Leakage Ratio (ACLR).

Due to nonlinear distortion, both amplitude and phase of signal will be distorted at the same

time. Therefore, we use the error between the point of the actual signal and the point of the ideal signal to represent the linearity index, which is the Error Vector Magnitude (EVM).

6.1.1.3 Influence Factors

1) Bandwidth and signal bandwidth

The 3.3-4.2 GHz frequency of 5G NR Band n77 has a total bandwidth of 900MHz, and it is challenging to cover such a wide band with a single PA.

Signal bandwidth is also one of the factors affecting the linearity of PA. The distortion component of the nonlinear characteristic of PA is not constant. For example, the amplitude and phase of the three or five order intermodulation will change with the amplitude and bandwidth of the input signal. This distortion component depends on the amplitude and bandwidth of the input signal, which is often called the memory effect of the power amplifier, which affects the linearity of the PA.

In the LTE system, the signal bandwidth of a single carrier is 20MHz, and in consideration of CA, it can be extended to 2CC 40MHz or even the potential 3CC 60MHz. But in 5GNR, the signal bandwidth will be greatly improved, and the linear deterioration caused by the memory effect will be a key factor in the design. NSA operation of 5G NR also calls for concurrent UL in LTE and NR which further stresses the linearity requirement.

2) PAPR (peak-to-average power ratio)

PAPR is the ratio of peak power to average power. The peak power is the instantaneous peak power that occurs at a certain probability, usually 0.01% of this probability.

Because of the instantaneous high power of the signal, in order to guarantee the linear index at the instantaneous high power level, the power back off is usually used to guarantee the linearity, and it’s related with the PAPR.

The PAPR of the input signal is related to waveform and modulation, from LTE to 5G NR, the UE uplink waveform from single carrier to multi carrier. Considering the higher order modulation, 5G NR PAPR compared to LTE will be significantly increased.

3) Cooling capacity

With the increase of temperature, PA performance including gain, Pout and PAE will degrade in the device product layout, some devices close to PA will deteriorate as the working temperature increases.

HPUE（High Power User Equipment）application need to increase UE Pout from 23dBm to 26dBm, which means the heat generated from PA will also be double if we assume the PAE does not change. Also the smaller PA package size will increase the difficulty of thermal dissipation of PA. When designing PA, it is necessary to improve the heat dissipation ability of PA and reduce the working temperature of PA by reasonable and correct layout, adopting the appropriate PA structure, chip technology and packaging technology.

4) Cost

5G NR Band n77 has total bandwidth of 900MHz, also the PAPR of 5G NR signal is significantly higher than the LTE signal, these challenges will lead to different architectures. Take PA as example, use a single PA single power supply structure, adopts multi PA multi power architecture; bring in ET technology, adding DPD in PA pathway.

The PA performance of different design methods will be different, and the cost of PA will vary greatly. In the process of introducing PA products into the 5G market, excellent product performance and reasonable product cost can make the product get better market recognition.

For the 5G NR RF front end, because of the increasing number of the RF path (more frequency bands, dual connection, MIMO, etc.), the number of RF front end is also increasing obviously. The size and cost of the RF front end must be lower enough, to ensure the terminal's size and cost. For the future RF front end design, the hardware integration and reuse would be the point of concern.

6.1.2 Sub-6GHz 5G Power Amplifier Design

6.1.2.1 3GPP Standard

1) Frequency band

There have been many proposals in 3GPP, with the most emphasis placed on 3300 to 3800 MHz as a primary target with an extension to 4200 MHz to support Japan region. Current 5G NR global major band requirements are shown in figure 6-4.

Region	New		Existing			BW	Total BW
	F_{LOW}	F_{HIGH}	F_{LOW}	F_{HIGH}	Band		
Korea	**3400**	**3700**				**300**	300
EU			2570	2620	38	50	450
	3400	**3800**	**3400**	**3800**	**42+43**	**400**	
Japan			2496	2690	41	194	1494
	3600	**4200**	**3400**	**3600**	**42**	**800**	
	4400	4900				500	
U.S.			2496	2690	41	194	344
			3550	**3700**	**48**	**150**	
China			2300	2400	40	100	790
			2555	2655	41B	100	
	3300	**3600**	**3400**	**3600**	**42**	**300**	
	4400	4500				100	
	4800	4990				190	

F_{HIGH}	Band	BW	Total BW
26.50	**29.50**	**3.00**	3.00
24.25	**27.35**	**3.10**	7.70
31.80	33.40	1.60	
40.50	43.50	3.00	
27.50	**29.50**	**2.00**	2.00
27.50	**28.35**	**0.85**	10.85
37.00	38.60	1.60	
38.60	40.00	1.40	
64.00	71.00	7.00	

Figure 6-4 Current 5G NR global major band requirements

2) Power level

As is in the case for TDD LTE spectrum, we anticipate power class 2 and 3 to be deployed in early 5G systems.

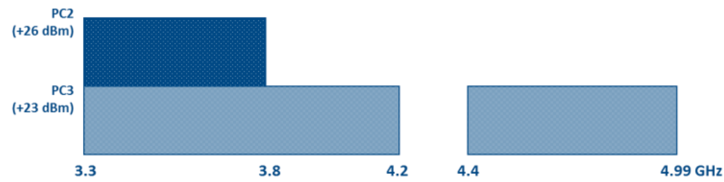


Figure 6-5 Power classes of 5G NR device

3) Signal Bandwidth

In terms of other rough parameters for the sub 6 GHz RF front end, we see consensus building around a maximum channel bandwidth 100MHz.

4) Waveform and modulation

The peak to average ratio of the 5G NR signal is 3dB higher than an equivalent LTE waveform. From that we can expect impact to take the form of higher back off or higher average transmit powers. Another interesting observation is that for 5G CP-OFDM using different modulation, there is no significant difference in the CCDF function- meaning higher-order modulation has minimal impact on MPR and power back-off.

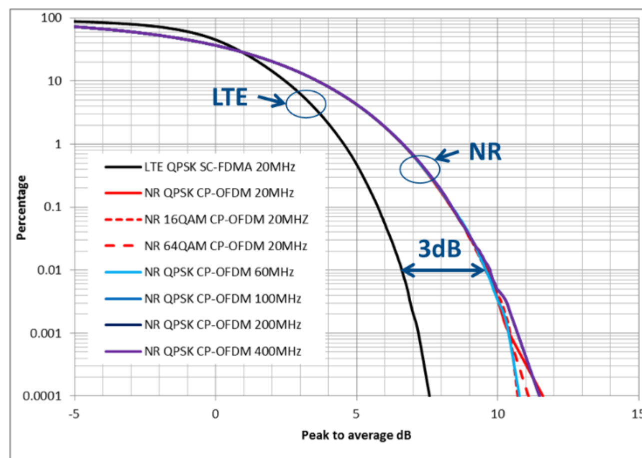


Figure 6-6 CCDF curves of CP-OFDF and SC-FDMA

In figure 6-7 we can find CCDF curves of some lower PAPR options, which can be used in cell edge areas as well as mmWave.

Some observations on lower PAPR aspects:

- DFT-s-OFDM QPSK waveform in UL , exhibits very similar PAPR as the existing LTE SC-FDMA used in UL
- shaped PI/2 BPSK is used for sub-6GHz , also assumed for mm-Waves and provides up to 7.5dB relief

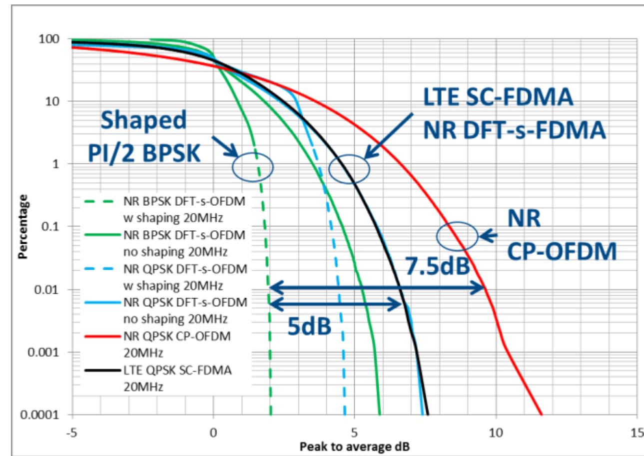


Figure 6-7 CCDF curves of some alternate candidate waveforms

6.1.2.2 Design Challenges

1) RF path Co-banding

The frequency below 6GHz is still scarce resources. There may be LTE and 5G NR working on the same frequency band. Different operators will make different deployment between LTE and 5G NR.

As shown in table 6-1, it is possible for LTE to share the same RF path with 5G NR on UE. The co-path can not only save the hardware cost of the RF front-end devices, but also reduce the PCB area. Of course, this also requires LTE and 5G NR be fully aligned on the time slot, otherwise the coexisting interference problem will be caused.

Table 6-1 LTE and 5G NR frequency band around 3.5GHz

LTE Band number	**UL**	**DL**	**Duplex mode**
B41	2496-2690 MHz	2496-2690 MHz	TDD
B42	3.4-3.6 GHz	3.4-3.6 GHz	TDD
B43	3.6-3.8 GHz	3.6-3.8 GHz	TDD
B48	3.55-3.7 GHz	3.55-3.7 GHz	TDD
NR Band number	**UL**	**DL**	**Duplex mode**
N41	2496-2690 MHz	2496-2690 MHz	TDD
n77	3.3-4.2 GHz	3.3-4.2 GHz	TDD
n78	3.3-3.8 GHz	3.3-3.8 GHz	TDD

There are have many challenges to achieve LTE and NR co-path, not only because the signal bandwidth of NR is much more than that of LTE, but also because NR needs to support PC2, and the peak to average ratio is higher, which leads to slight degradation of efficiency under LTE. At the same time, the coexistence requirement will also require the device to guarantee the intra-band RF performance defined by 3GPP.

For the RF front end, the Power amplifier must support both LTE and NR application in the same power amplifier. The ideal RF front end must be reconfigurable in different applications.

There are many research results about the reconfigurable RF front end, which would be a powerful support for the future RF front end application.

2) Interference in UE

Except the case that NR operation with only one UL band under SA mode, UE may suffer from in-device interference due to simultaneous UL transmissions in the NSA deployment and SUL under SA deployment.

There are three different types of in-device interference due to simultaneous UL transmission over different bands:

- Interference from Intermodulation (IMD)

This kind of interference comes from the intermodulation (IMD) product between lower-frequency and higher-frequency UL carriers, which may fall into the DL carrier. One example is that when a UE is transmitting simultaneously on B3 (LTE) and NR sub-6G band (3.3G~4.2G), interference of IM2/IM4/IM5 will fall into B1 LTE receiver.

- Interference from Harmonic

This kind of interference comes from the harmonic of lower- frequency UL signals to the higher- frequency DL signals when the harmonic of UL frequency falls into the DL frequency. One example is that when a UE is simultaneously transmitting on B3 (LTE) and receiving on NR sub-6G band B42 (3.4G~3.6G), interference from H2 of B3 will fall into NR receiver.

- Interference from Harmonic mixing

This kind of interference comes from higher frequency UL signals to the lower- frequency DL signals when the higher frequency is multiple of the lower frequency. One example is that when a UE is simultaneously transmitting on NR 3.3GHz~4.2GHz and receiving on LTE B26, interference from NR UL will fall into LTE B26 receiver and be demoded by receiver which causes sensitivity degradation.

3) Thermal Distribution

PA (Power amplifier) performance will degrade as temperature rises due to its device properties. Specifically, the higher the temperature, the lower its Gain, Output Power and Power Added Efficiency. In the end user equipment, some components such as Duplexers that are physically in adjacent with PA will experience performance degradation too. With the requirement of HPUE(High Power User Equipment) on devices, the output power at antenna will be increased from 23dBm to 26dBm, which means heat generated from PA will double assuming PA maintains same power added efficiency. In addition, a smaller footprint of PA makes heat dissipation even worse.

As a consequence, when designing a PA, one needs to take into account the architecture, process and assembly to improve the PA thermal distribution.

4) Cost

5G NR band 77 has large bandwidth (3.3-4.2GHz). Its signal has higher PAR (Peak to Average Ratio) than that in LTE. Furthermore, different frequency bands inside 3.3GHz-4.2GHz have different output power requirements. These challenges call for different PA architectures, for example, single PA with single supply, or multiple PA paths with multiple supplies, EER (Envelop Elimination and Restoration) with traditional supplies or ET (Envelop Tracking) , DPT(Digital Pre-Distortion) in the PA signal path, etc.. All these factors will impact PA cost and performance, a good balance of which will help the acceptance by the marketplace of such 5G PAs.

6.1.2.3 Alternative Processes

There are only two foundries in China can provide the GaAs pHEMT process now, one is Hiwafer in Chengdu, the other is Sanan in Xiamen.

6-inch 2um GaAs HBT process named as HBT02, can be used in high-frequency, high-linearity PA applied in cell phone, WiFi, Pad and other. This process is fit for sub-10GHz region: 4G LTE, 3G/2G, WiFi and base station. And provides two kinds of HBT, one is high β version, the other is low β version.

The BiHEMT process of HiWafer, which can be used to produce logic module and RF module simultaneous, is now under research. The development of BiHEMT process can increase the IC functional complexity and integration density.

The performances and measurement results of 6-inch 2um GaAs HBT process are given in table 6-2 and figure 6-9:

Table 6-2 Performances of 6-inch 2um GaAs HBT process

Parametre	**HiWafer**	
	HBT02	
Beta(V)	120（@1kA/cm^2）	75（@1kA/cm^2）
BVcbo(V)	24（@2kA/cm^2）	24（@2kA/cm^2）
BVceo(V)	13（@2kA/cm^2）	13（@2kA/cm^2）
ft/fmax(GHz)	40/60	40/60
ResistorTaN（Ω/□）	50	50
Capacitor（pF/mm^2）	600/930	600/930
Au: M1/M2(μm）	1/2	1/2

The key parameters in table 6-2 are explained as follows:

- Beta(β): current gain, the 75-Gian transistor is commonly used in 3G, the 120-Gain transistor is commonly used in 4G and the later generations.
- BVcbo, BVceo: the breakdown voltage, the higher breakdown voltage means higher work voltage.
- ft: current cut-off frequency. The higher the ft, the better frequency characteristics.
- fmax: highest oscillation frequency, where the power gain of the transistor decreases to 1.

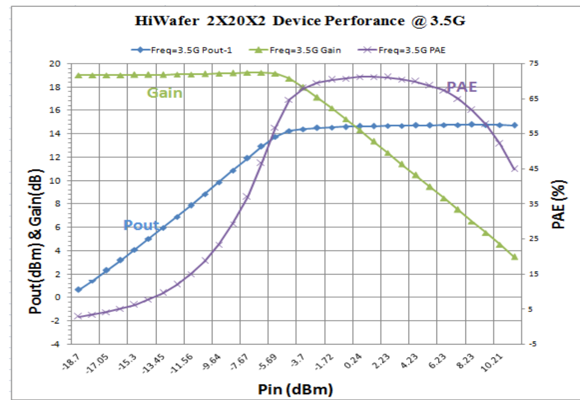


Figure 6-8 Measurement results of 6-inch 2um GaAs HBT process

GaAs device have the advantages of high electron mobility, low loss semi-insulating substrate, high linearity, high cut-off frequency, and high breakdown voltage, making them superior to CMOS in power performance. Therefore, GaAs device holds a dominant position in performance advantages over CMOS in the 4G PA market. For the future 5G PA market, the standard GaAs based modules will continue to maintain their advantages in power performance. In the whole market, compared with the highly integrated CMOS device and high power performance GaN device, GaAs device can continue to play its performance advantages by increasing its level of integration through processing and packaging.

Considering the fact that GaAs and silicon-based devices are still able to meet the cost and performance requirements. GaN device will not be used in 4G mobile phones for its still high working voltage. However, with the development of GaN technology, GaN device may be used in 5G mobile phone RF front-end module. Compared with high frequency devices such as GaAs and InP, the power density of GaN devices will be greater, which will help reducing the chip area of the PA. Compared with LDCMOS and SiC, GaN has better frequency characteristics; GaN device also has wider the instantaneous bandwidth, thus fewer amplifiers are needed to cover all bands and channels. GaN device has many other advantages, such as higher output impedance. High output impedance makes it easier for impedance matching and power combining of GaN device, and to cover a wider frequency range and improve the applicability of RF power amplifiers.

GaN applied in 5G phones, there are several problems need to be solved:

- GaN devices work in low voltage.
- The high thermal conductivity in cell phone
- High cost

6.1.2.4 Existing Sub-6GHz 5G Power Amplifier Products

- **n41 PA**

1) Solution of n41 NR PA

Below chart is an example of a n41 dedicated Tx/Rx solution to be commercialized for 2019.

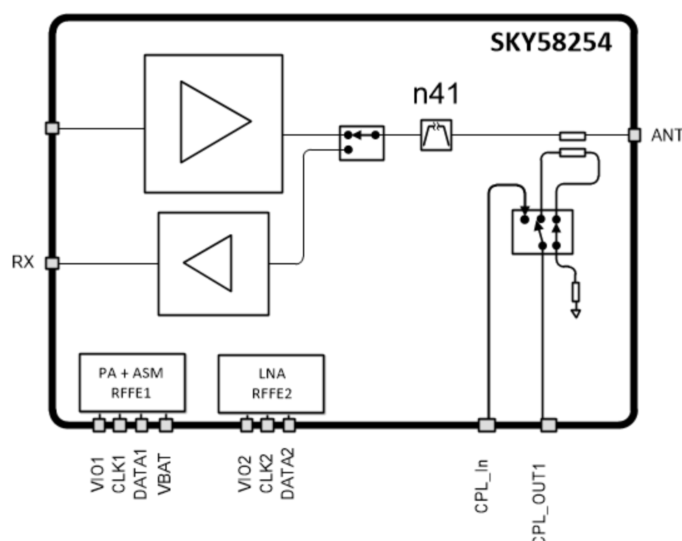


Figure 6-8a An example of a n41 dedicated Tx/Rx solution to be commercialized for 2019

The 5GNR capable FEM contains a full band n41 transmit PA, a receive LNA, a Tx/Rx switch and integrated filter. Dual directional coupler for power control and independent MIPI registers for Tx and Rx control.

The SKY58254 feature list is:

- 3 x 5 x 0.7 mm max
- Latest PA Engine supporting 100MHz BW
- Full PC2 power and BW support with APT 5V operation
  - DPD is not necessary, but can be used as an adjunct to improve efficiency.
- Dual ET/APT modes are supported with internal APT CAP switch – can be enabled for optimized APT Operation using a large external cap on board for APT modes. The external path is disabled for ET use case.
- Full B41 Filter HPUE capable
- FOR/REV CPL with CPL Switch and CPL_In
- Full BW LNA

This represents the mainstream performance, and we would expect variants to be developed as market matures.

2) Target APT Performance of n41

100MHz SCS30KHz MPR0=	28.5	4.2V				
signal	Pout	ACPL	ACPH	EVM	Current	3GPP MPR
QPSK DFT-S-OFDMA	27.5	-38	-38.9	1.5	845	1
QPSK CP-OFDM	25.5	-37.8	-38.5	1.9	739	3
64 QAM DFT-S-OFDMA	26	-39.8	-40.1	1.64	770	2.5
64 QAM CP-OFDM	25	-39.4	-39.2	1.85	720	3.5
256 QAM DFT-S-OFDMA	24	-42	-42	1.34	690	4.5
256 QAM CP-OFDM	22	-42.7	-43.2	1.38	639	6.5

Table 6-8b Target APT Performance for n41

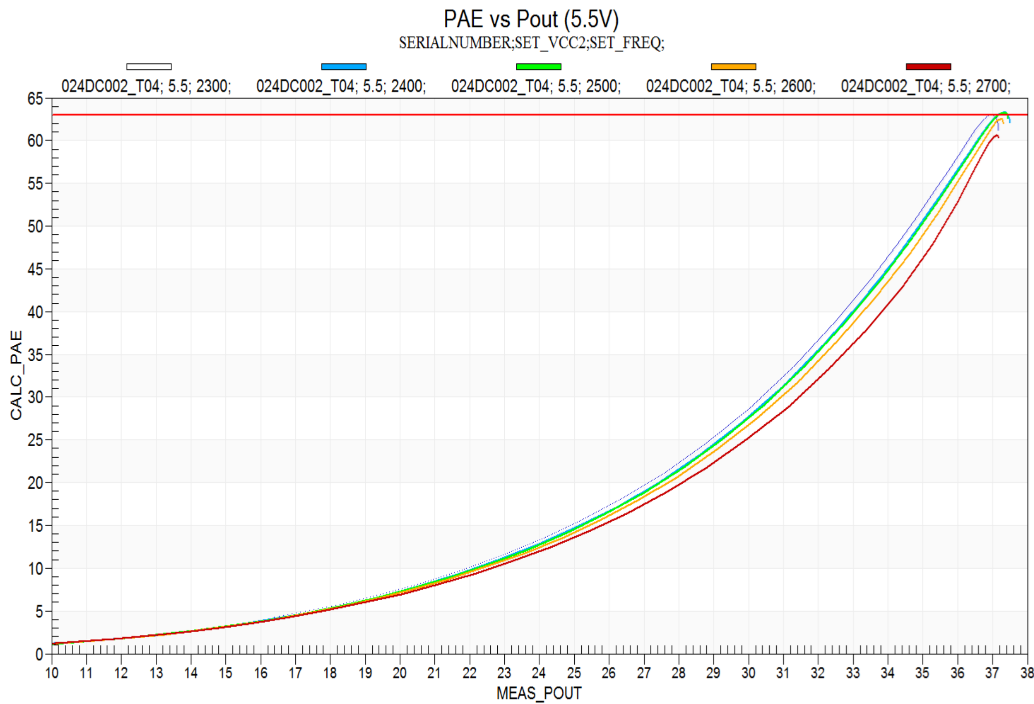


Figure 6-8c PAE Curves of n41 PA (5.5V)

Note: Freq Centering needed to improve/optimize PAE from 2.4GHz-2.6GHz to 2.5GHz-2.7GHz

PAE low by 2-3%, future MCM update will address the increase to PAE from this initial sample.

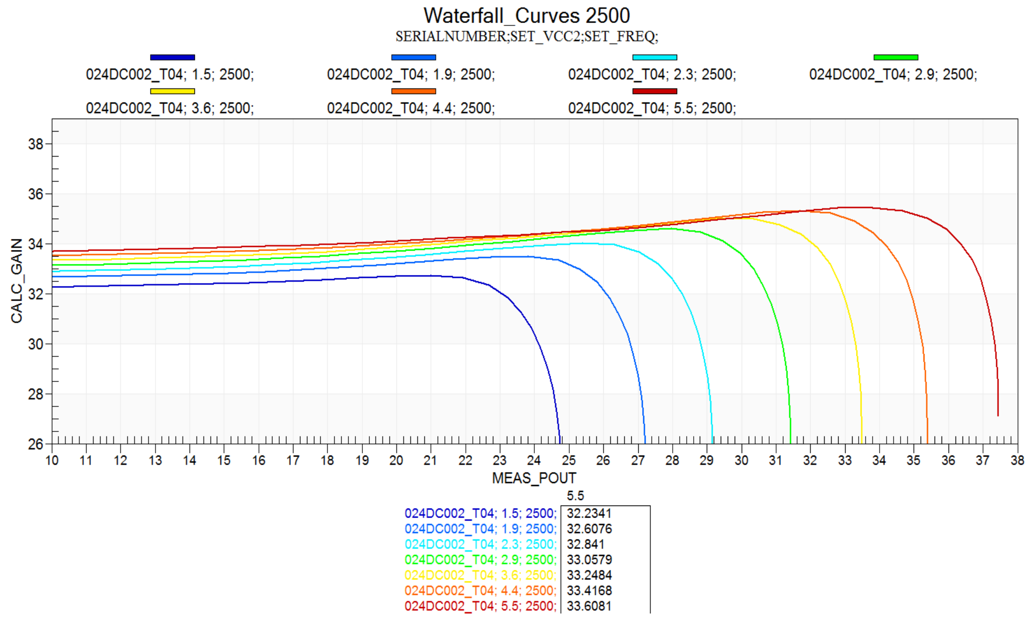


Figure 6-8d Gain/PSAT @ 2500 MHz

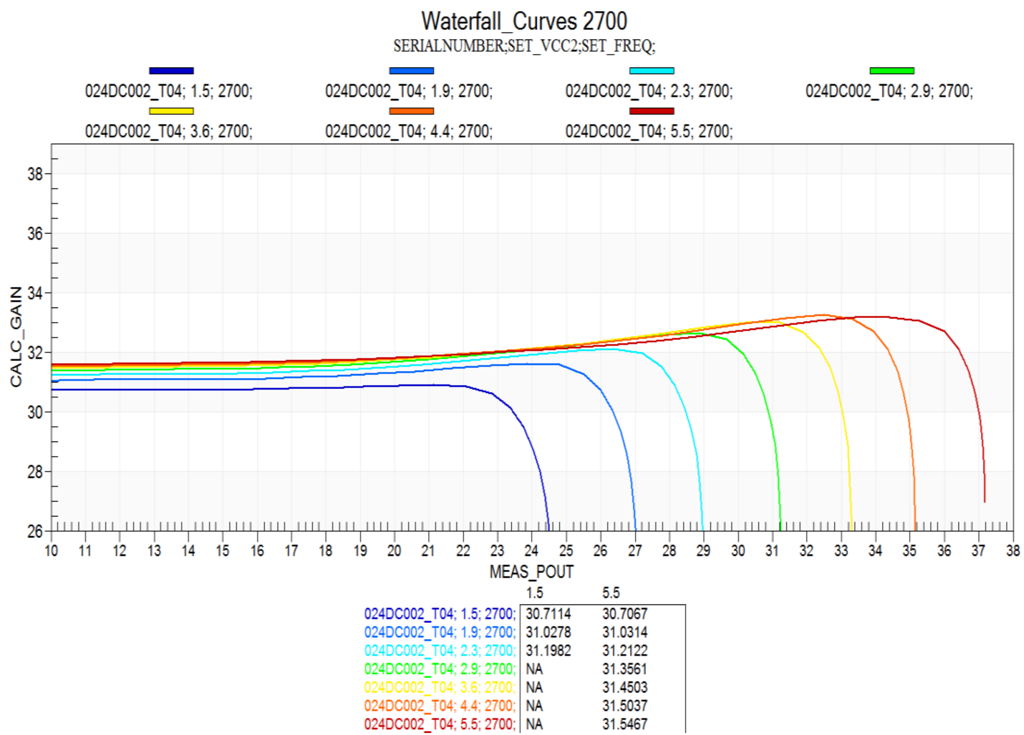


Figure 6-8e Gain/PSAT @ 2700 MHz with slight Load line Adjustment relative to 2500 MHz

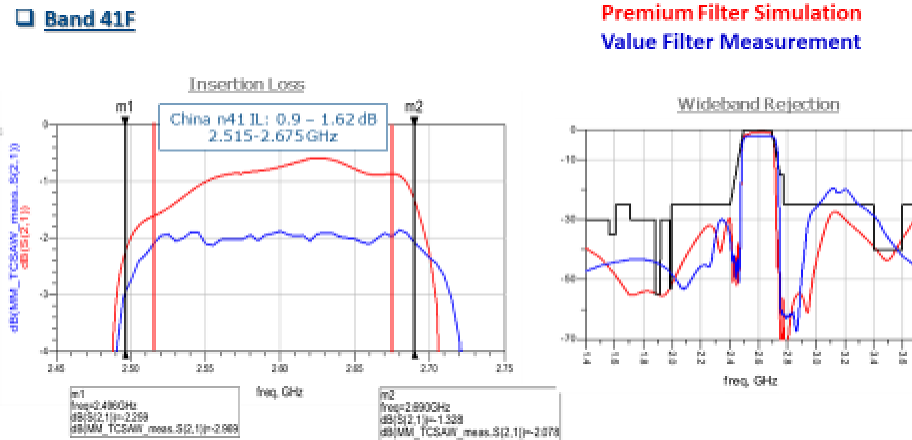


Figure 6-8f Expected performance of filter in n41

3) Challenges from intra band EN DC, B41+N41:

The B41/n41 Dual Connectivity Use Case : DC_B41_n41

The existing B41 supporting LTE, and the 4G services will be appended with 5G services and migrate over time to eventually become an entirely 5G band.

Leveraging the existing wide LTE coverage, capacity, and customer base, along with the established LTE enhanced core packet (EPC) network, the build-out of the Non-Stand-Alone (NSA) architecture option 3 serves to enable continued use of the LTE back-haul and incrementally add NR radio heads on existing towers in a cost effective and rapid roll-out of 5G services.

This approach drives the intra-band EN-DC use case of DC_B41_n41, where 2 non-contiguous synchronous TDD channels; one LTE at one frequency and one 5G at a different frequency, operate concurrently within the same band. During uplink (UL) these 2 modulation clusters are transmitted concurrently and will encounter nonlinearities within the RF front-end, producing intermodulation products. The concentrated IMD products must be low enough in amplitude at the transmitting antenna that the UE is enabled to pass radiated emissions requirements at the problem offset frequencies where the IMD are generated. The 2 architectural options are:

1) single PA transmitting to a single antenna.

2) Dual PAs each transmitting separate signals (one for 4G, one for 5G) to 2 dedicated/separate antennas.

The single PA solution clearly has BW and linearity challenges in transmission of potentially widely spaced channels at vastly different frequencies within this 160MHz band, the penalty of higher peak-to-average for the 2CC channel vs. each separate signal alone which forces MPR and additional headroom and lower efficiency in order to transmit the combined signals linearly. Additionally, the forward IMD which is a huge challenge to manage the concentrated

emissions at the antenna.

The Dual PA/2Antenna solution addresses many of these issues with more manageable instantaneous modulation BW of each channel separately, the peak-to-average and power capability is much more optimum for the separate signals and lower peak-to-average, and the IMD products are no longer a result of running the 2 signals through the nonlinear gain of a single PA with a strong forward IMD nonlinear mechanism, but instead dominated by the finite antenna isolation and an attenuated version of the other Tx path signal then back-injected at the output of the active PA and a Reverse IMD mechanism.

The reverse IMD mechanisms is slightly better/lower relative to the worse Forward IMD mechanism, and the fact that the back-injected aggressor from the other antenna is lower by the amount of the antenna-to-antenna isolation makes a large difference overall in the Reverse IMD generation. As shown in figure 6-8g, the various RF leakage paths at the inputs of the PAs and at the outputs due to finite antenna isolation are illustrated for the 2PA/2Antenna solution.

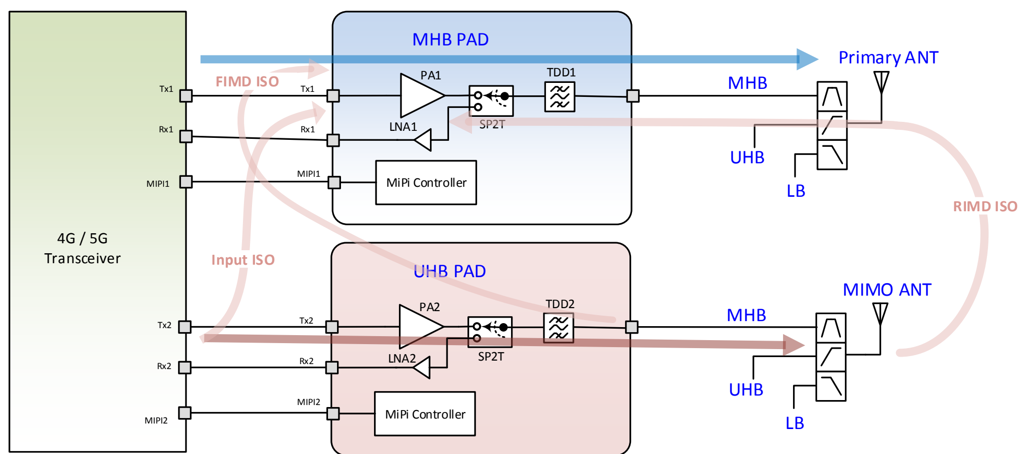
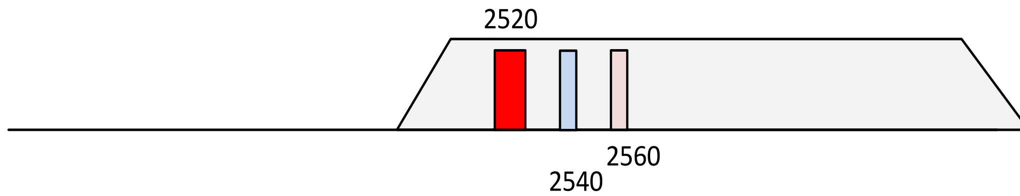


Figure 6-8g 2PA/2Antenna architecture with indications of the transceiver and antenna isolations at the inputs and outpus, respectively, of the PA RF paths

The other critical aspect of the IMD that is then created and present at the output of the PA may get attenuated on its way to the antenna where we must meet the emissions requirements.

As shown in figure 6-8h, if the LTE and NR channels are offset from one another by a large frequency difference, then the resulting IMD products will also be further away, and in some cases far enough away that the B41 filter can provide some strong selectivity and attenuation to easily meet the antenna emissions. The more difficult cases tend to be those produced by closely spaced LTE and NR channels that then fall in band and do not benefit from such filter selectivity.



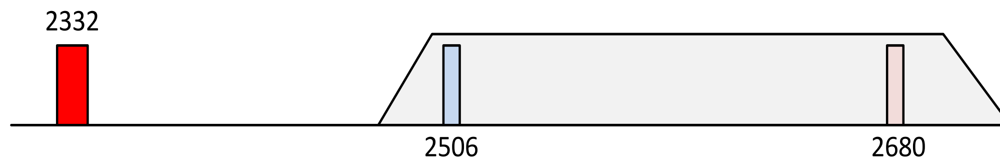


Figure 6-8h Channel location and resulting IMD in-band or out-of-band cases, demonstrating the opportunities for OOB IMD to easily pass antenna emissions requirements

The magnitude of the IMD products will depend as indicated on the architecture, but also the behavior of the power amplifier itself. This is particularly true when considering saturated PAs in Envelope Tracking (ET) solutions, where the intrinsic PA nonlinearity is worse than the linear fixed Vcc supply voltage solution of an APT PA. Bandwidth capabilities are also more relaxed for the APT linear PA as an additional advantage for that PA solution, but with some degradation in overall efficiency and current consumption.

- **n78/n79 PA**

1) Solution for n78/n79

Currently, the RF front-end module that supports 3.3GHz-4.2GHz and 4.4GHz-5GHz for 5G NR 3GPP standards is under develop, and a conceptual image of the fully technology demonstrator for sub 6 GHz TDD systems in 3.5/4.5 GHz could look like this. Actual Implementation is likely to vary, but the main concepts remain intact.

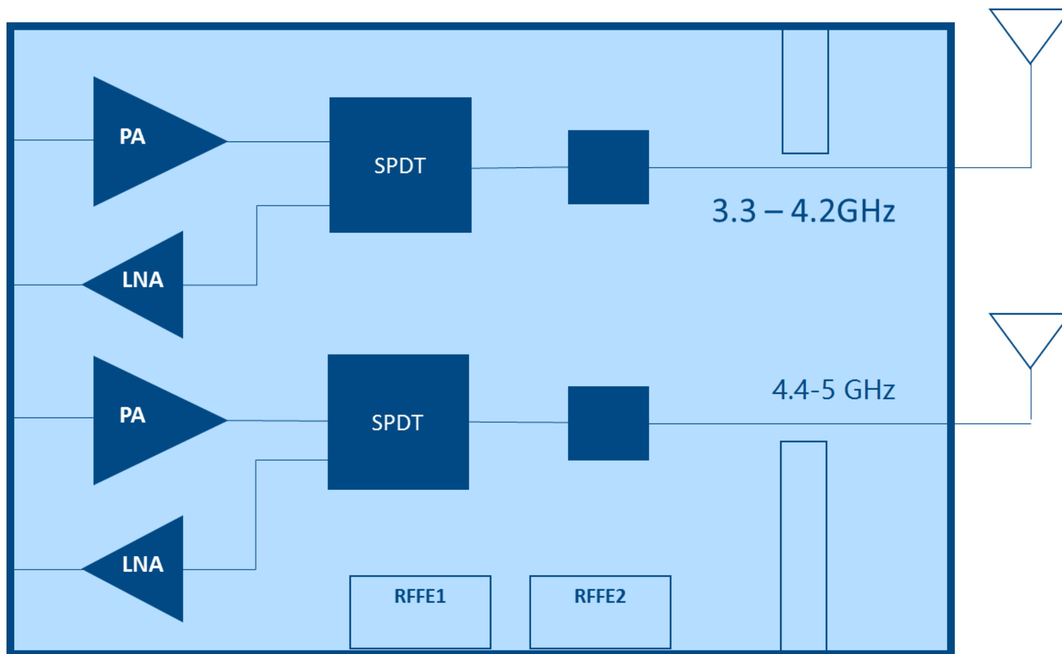
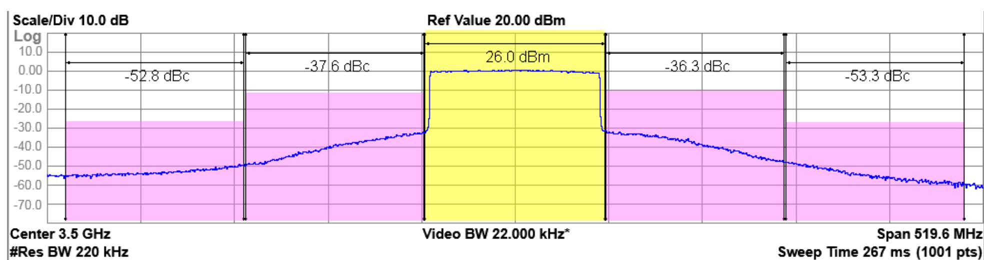


Figure 6-9 Block diagram of RFFE module support 3.3GHz-4.2GHzand 4.4GHz-5GHz

The PA in the sub-6 GHz module will be assumed to be LTE and 5G NR compatible. The PA will have to be designed to support power class 2 HPUE in at least some sections of the band. In general, Support for:

- LTE and 5GNR PC 3 and PC 2
- CP-OFDM and DFT-s-OFDM waveforms
- Full and Partial allocations (at channel edge and in-channel)
- 20MHz and 100MHz bandwidths
- QPSK, 16QAM and 64QAM
- Normal, clipped or low PAPR waveforms

As shown in figure 6-10, we use CP-OFDM QPSK Full RB waveform and 3.8V power supply, PA Engine can achieve 26.9dBm@100MHz for -36dBc ACLR, almost same power capability is maintained for 200MHz and 400MHz channel bandwidths.



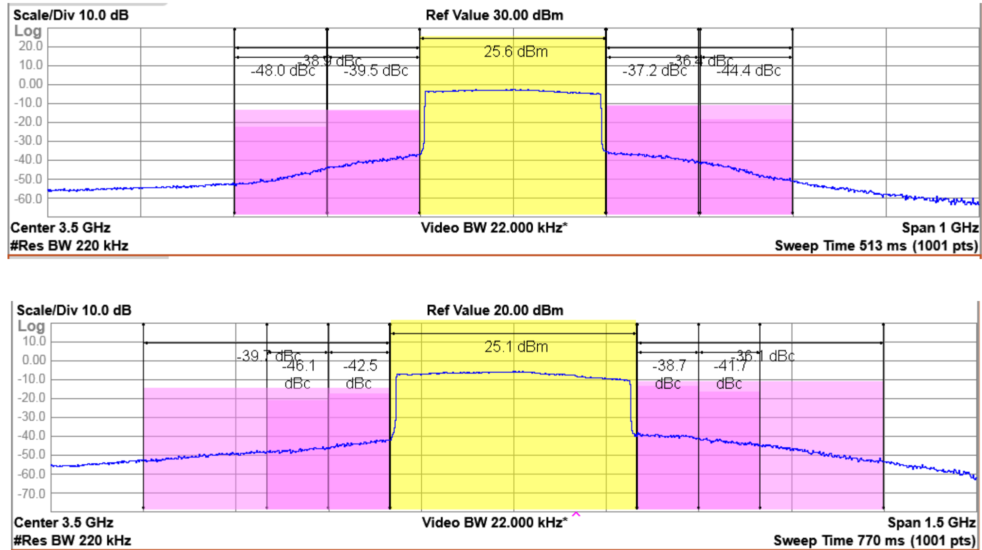


Figure 6-10 ACLR test results based on MP PA engine

In figure 6-11, shows the corresponding changes of linearity and efficiency

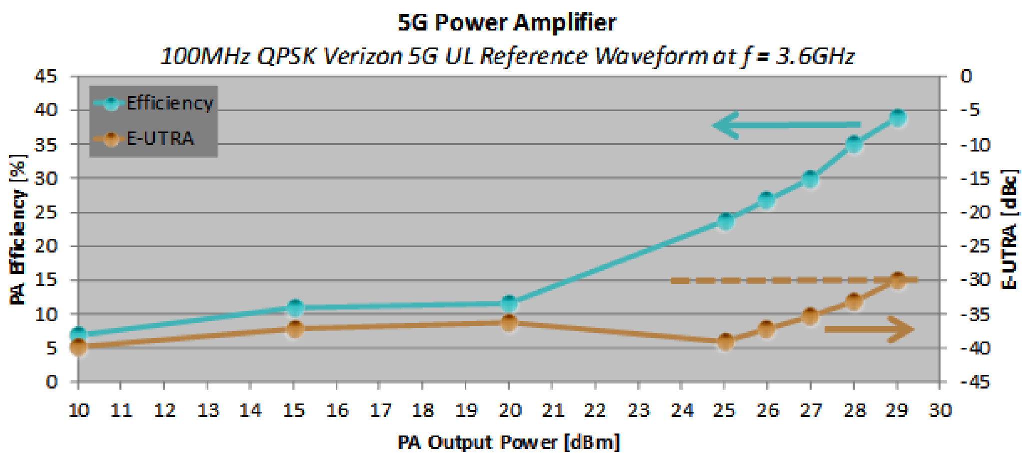


Figure 6-11 Efficiency and ACLR test results based on MP PA engine

PS: all the figures above are provided by Skyworks.

2) Measured Data of Sub-6GHz 5G NR PA

Now according to 5G NR Standalone 3GPP specification, supporting Band n77 3.3GHz-4.2GHz 900MHz bandwidth RF front end module is already developed. The block diagram is in figure 6-12

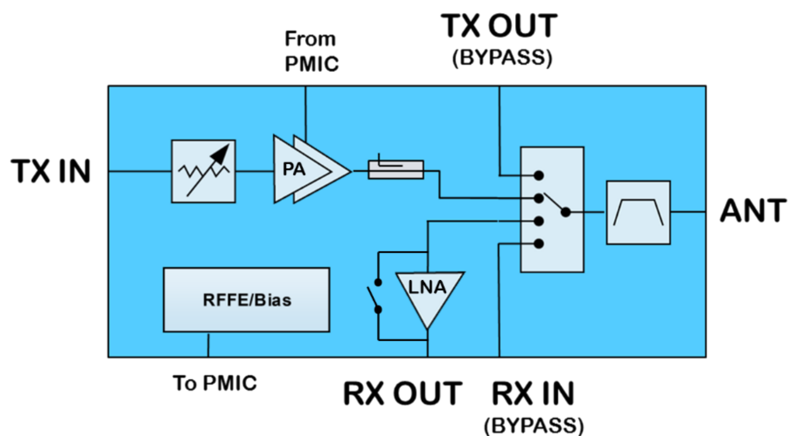


Figure 6-12 5G NR RF Front End Module Block Diagram

This RF Front End Module integrates power amplifier, Tx/Rx pass band filter, LNA, Switch and coupler.

Supporting linear output power 24.5dBm (Power Class 3) at Ant port.

a） Supporting high PAR of ~9dB 5G CP-OFDM modulation

b） Supporting max CA bandwidth of 400MH, 4CC

c） Supporting QPSK/16QAM/64QAM modulation signal

d） Supporting 2dB max power back off to 22.5dBm （single carrier 100MHz bandwidth and 64QAM modulation signal）

e） Supporting 3dB max power back off to 21.5dBm （4CC 400MHz bandwidth and 64QAM modulation signal）

f） Supporting APT technology

Detailed RF front end module measurement condition and data are as below:

a） Test Condition

- Linear 22.5dBm output power at Ant port
- CP-OFDM 5GNR input waveform
- Single carrier 100MHz bandwidth
- 64QAM modulation
- 4.5V constant supply voltage

b） Test Data

The module Tx Gain from 3.3-4.2GHz 900MHz bandwidth is from 24-26dB

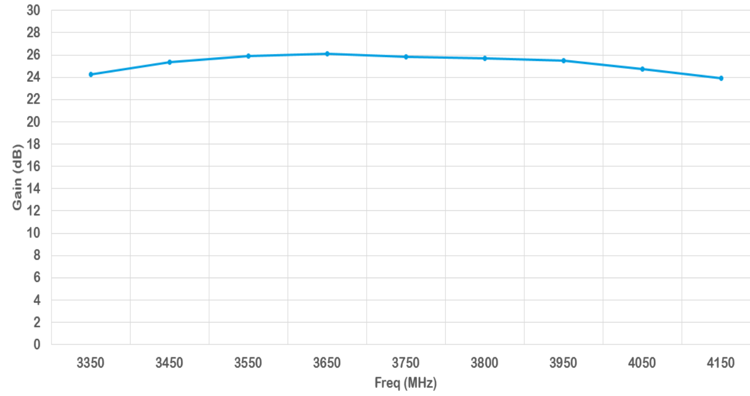


Figure 6-13 5G NR RF Module Gain data

RF Module power consumption based on different duty cycles.

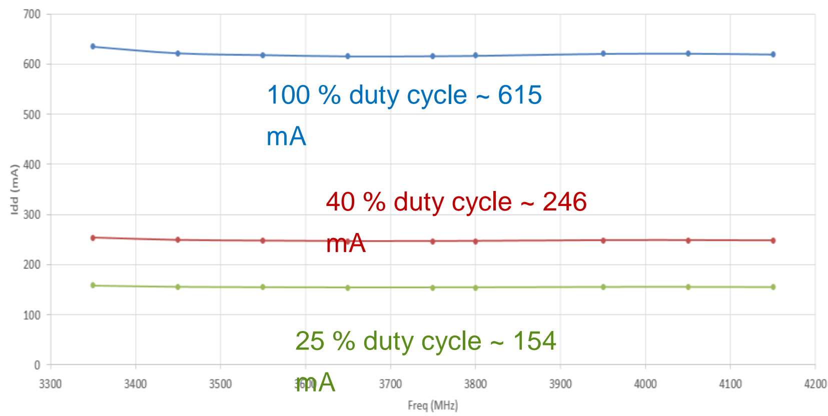


Figure 6-14 5G NR RF Module power consumption based on different duty cycles

F Module ACLR within 3.3-4.2GHz is less than -36dBc.

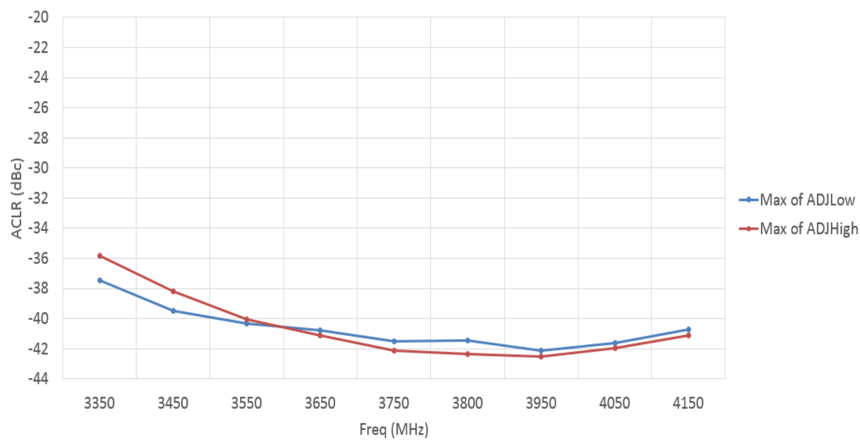


Figure 6-15 5G NR RF Module ACLR

RF Module EVM within 3.3-4.2GHz is less than 3.5%.

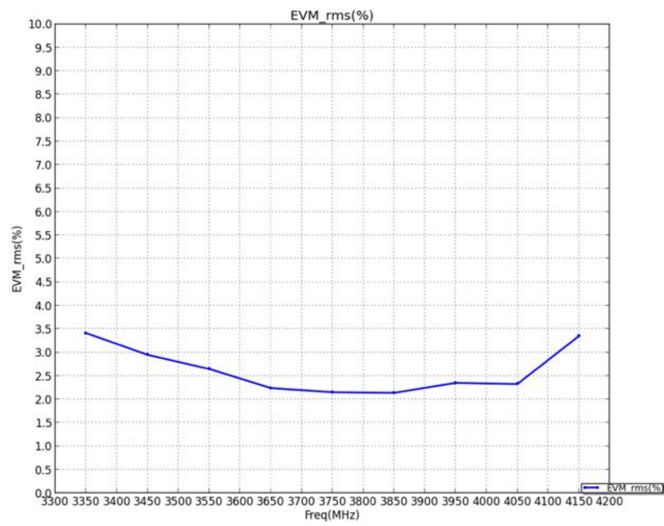


Figure 6-16 5G NR RF Module EVM Data

Note: Above RF Module information and data are provided by Qorvo.

Currently, for the 5G-NR Standalone 3GPP specification, an RF front-end module supporting Band n41 2.5GHz -2.7GHz 200MHz bandwidth has been developed. The block diagram is shown in figure 6-25.

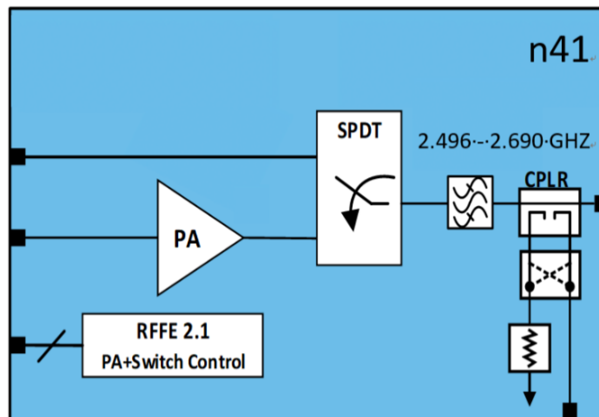


Figure 6-16a Internal architecture of the 5G NR PA module

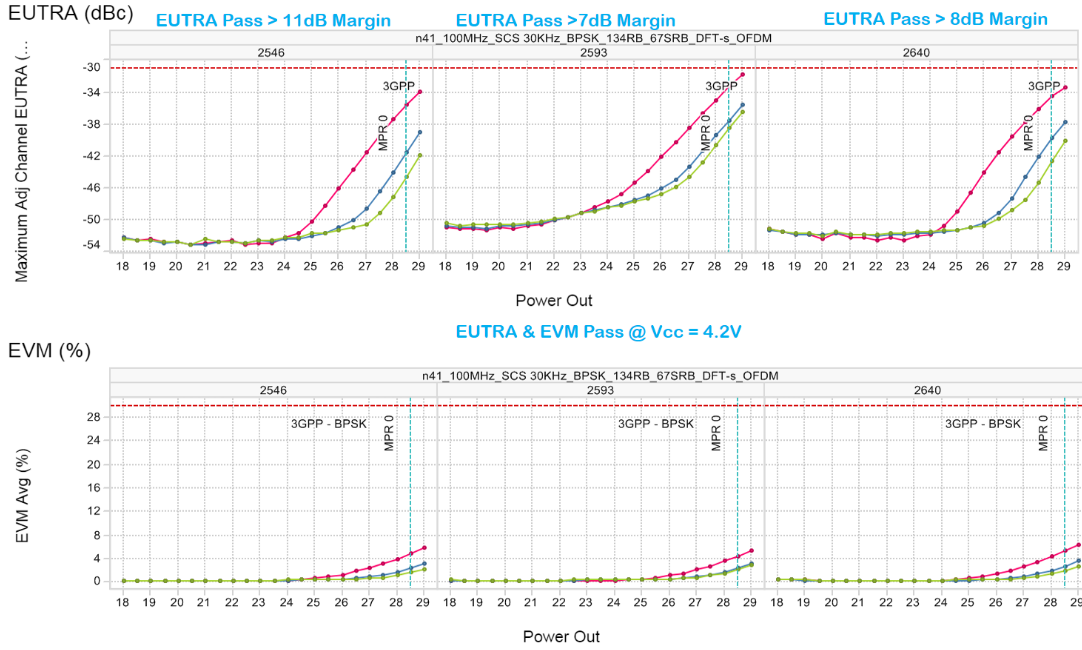


Figure 6-16b 100MHz_SCS 30KHz_Pi/2-BPSK_134RB_67SRB_DFT-s_OFDM – PC2

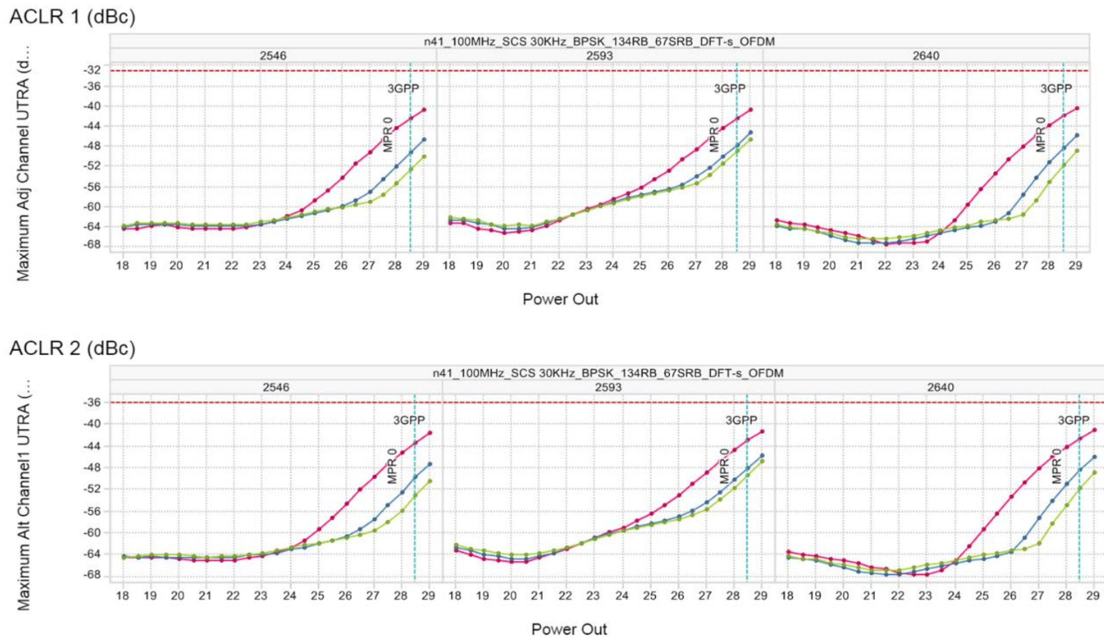


Figure 6-16c 100MHz_SCS 30KHz_Pi/2-BPSK_134RB_67SRB_DFT-s_OFDM – PC2

6.1.2.4 Picture and product information in chapter 2) Source: Qorvo

3) System Diagram of Sub-6GHz 5G NR PA

Vanchip is developing a 5G RFFEM (RF Front End Module) supporting 3.3GHz-4.2GHz. figure 6-17 below is the system diagram.

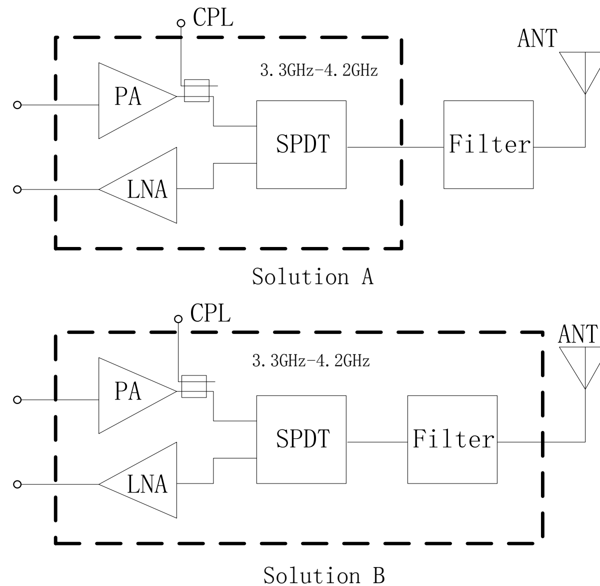


Figure 6-17 5G NR RF Front End Module Diagram

In Solution A, a 3.3GHz-4.2GHz PA, a coupler, a LNA (low noise amplifier) and SPDT switch are integrated in a single module. Customers can place the filter on PCB to meet their requirements on performance and cost.

In Solution B, filter is placed into the module to optimize the module performance and to achieve the maximum integration for customers.

Both solutions support requirements as below:

a) PC2, PC3 in 5G NR and LTE

b) QPSK/16QAM/64QAM Modulation

c) CP-OFDM and DFT-s-OFDM Waveform

d) Maximum 400MHz 4 Carrier Aggregation

e) APT and ET

6.2 Sub-6GHz 5G Filter

6.2.1 Existing Mobile Device Commercial Filter

The rapid growth in mobile wireless data and 4G LTE networks has created an ever-increasing requirement for new spectrum bands to accommodate wireless traffic. Whereas 3G networks used only about five bands, there are already over 20 4G LTE bands and this number could rise to more than 40 in the near future.

Though it's not practical to support all worldwide bands in a single smartphone, a feature-rich

model for international use may need to filter transmit and receive paths for 2G, 3G, and 4G in up to 15 bands, as well as Wi-Fi, Bluetooth, and global navigation satellite system (GNSS). Such a phone may require as many as 30 to 40 filters. The situation is likely to become even more complex with next-generation high-end smartphones requiring even more filters.

6.2.1.1 Common Types of Filter

A filter removes unwanted frequency components from a signal while preserving desired frequency components. There are four basic types of filters that accept or reject signals in different ways (see figure 6-29). The different types are defined as

- Low pass: Allows all frequencies below a certain frequency to pass while rejecting all others (opposite of high pass)
- High pass: Allows all frequencies above a certain frequency to pass while rejecting all others (opposite of low pass)
- Band pass: Allows all frequencies between two frequencies to pass while rejecting all others (opposite of band stop)
- Band stop (or band reject): Rejects all frequencies between two frequencies while passing all others (opposite of band pass)

Band stop and band reject filters are also known as notch filters.

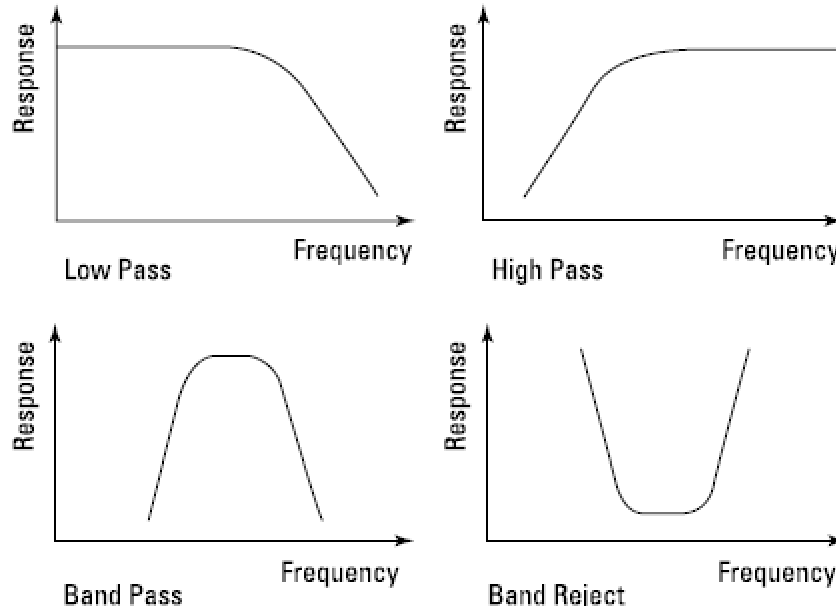


Figure 6-18 Basic Filter Types

Filter construction varies by application, with size, cost, and performance the major variables. Here are some example filter constructions:

- Discrete inductor-capacitor (LC) filters are low-cost structures of moderate performance

and size. The LC elements are sometimes implemented as printed structures on substrates called an integrated passive device (IPD).

- Multilayer ceramic filters are low to moderate cost and have similar performance to LC filters. Their footprint is generally reasonable, but their thickness is becoming an issue as mobile applications emphasize thinner and thinner designs.
- Monoblock ceramic filters are much higher performance than multilayer ceramics and also more expensive. They're also physically larger and usually aren't suitable for mobile applications.
- Acoustic filters have the capability to meet both low and high frequencies up to 6 GHz, are small in size, and offer the best performance and cost for complex filter requirements. Acoustic filters are the most common filter construction for mobile devices.
- Cavity filters are used in infrastructure applications only. They can achieve good performance at reasonable cost but are large.

6.2.1.2 Key Parameters and Influence Factors

Filters can be designed to meet a variety of requirements. Although they use the same basic circuit configurations, circuit values differ when the circuit is designed to meet different criteria. In-band ripple, fastest transition to the ultimate roll-off, and highest out-of-band rejection are some of the criteria that result in different circuit values. Filters allow only particular frequencies or bands of frequencies to pass through and are, thus, an essential tool for RF design engineers. Typical filter response curve is shown in figure 6-19.

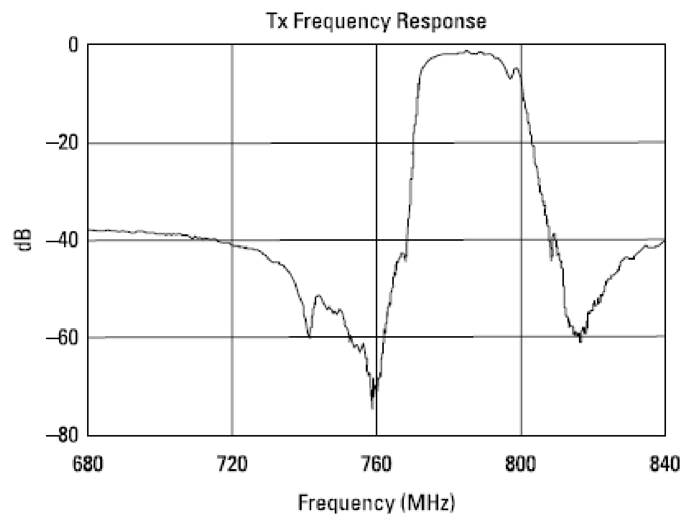


Figure 6-19 Typical Filter Response Curve

In case your knowledge of electronics is a bit rusty, here's a brief tutorial on some of the more important terms and concepts to help refresh your memory.

1) Attenuation: An amplitude loss, usually measured in decibels (dB), incurred by a signal after passing through an RF filter.

2) Cutoff: Normally taken to be the point at which the response of the filter has fallen by 3 dB.

3) Group delay: The derivative of a filter's phase with respect to frequency. Group delay, measured intime (in seconds), can be thought of as the propagation time delay of the envelope of an amplitude modulated signal as it passes through an RF filter.

4) Insertion loss: Loss of signal power resulting from the insertion of a component.

5) Isolation: Separation of one signal from another to prevent unintentional interaction between them (for example, transmit and receive interaction).

6) Q factor: The "quality" factor is a measure of the selectivity of a resonant circuit described as the ratio of stored versus lost energy per oscillation cycle.

7) Passband: The region through which the signal passes relatively unattenuated.

8) Ripple: The variation of insertion loss in the passband.

9) Selectivity: A measurement of the capability of the filter to pass or reject specific frequencies relative to the center frequency of the filter. Selectivity is usually stated as the loss through a filter that occurs at some specified difference from the center frequency of the filter.

10) Stopband: A band where the filter has reached its required out-ofband rejection, defined as a required number of decibels.

The figure shows some clear trends:

1) Loss increases as the Q factor drops and increases more rapidly for lower values of resonator Q.

2) The edges of the passband become more rounded and the passband narrower as the Q decreases. Note how each successively lower Q plot fits inside the previous.

3) The loss at the passband edges increases more than loss in the middle of the band. This poses a serious problem for modulations that go right to the edge of the passband.

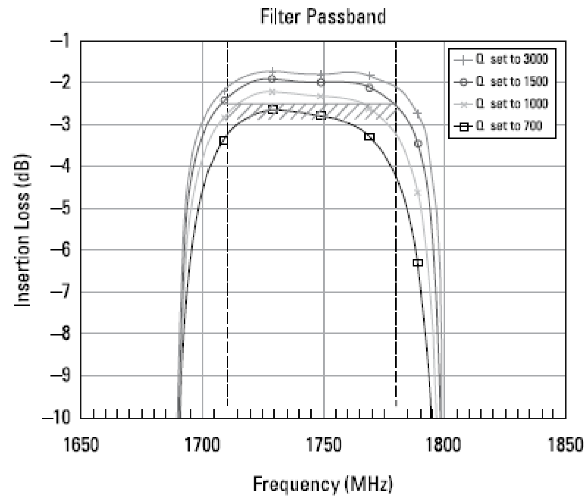


Figure 6-20 Acoustic Filter Attentuation based on different Q

Narrow modulations such as GSM (200 kHz) and CDMA (1.25 MHz) will suffer the most sensitivity loss at the band edge due to this effect, while WCDMA (3.84 MHz) will suffer less. LTE results depend on the system bandwidth, with narrower bandwidths more affected.

6.2.1.3 Acoustic filter

Acoustic filter technologies continue to evolve to meet the challenges of the global transition to 4G networks. In this chapter, you find out about surface acoustic wave (SAW) and bulk acoustic wave (BAW) filter technologies, which are used to solve many of today’s toughest mobile device filtering problems.

1) SAW: Mature But Still Growing

SAW filters are widely used in 2G and 3G receiver front ends, duplexers, and receive filters. SAW filters combine low insertion loss with good rejection, can achieve broad bandwidths, and are a tiny fraction of the size of traditional cavity and ceramic filters.

Because SAW filters are fabricated on wafers, they can be created in large volumes at low cost. SAW technology also allows filters and duplexers for different bands to be integrated on a single chip with little or no additional fabrication steps.

The piezoelectric effect that exists in crystals with a certain symmetry is the ‘motor’ as well as the ‘generator’ in acoustic filters. When you apply a voltage to such a crystal, it will deform mechanically, converting electrical energy into mechanical energy. The opposite occurs when such a crystal is mechanically compressed or expanded. Charges form on opposite faces of the crystalline structure, causing a current to flow in the devices and/or voltage between the devices. This conversion between electrical and mechanical domains happens with extremely low energy loss, achieving exceptional efficiency inboth directions.

In solid materials, alternating mechanical deformation createsacoustic waves that travel at velocities of 3,000 to 12,000 meters per second. In acoustic filters, the waves are confined to

create standing waves with extremely high-quality (high-Q) factors of several thousand. These high-Q resonances are the basis of the frequency selectivity and low loss that acoustic filters achieve.

In a basic SAW filter (see figure 6-32), an electrical input signal is converted to an acoustic wave by interleaved metal interdigital transducers (IDTs) created on a piezoelectric substrate, such as quartz, lithium tantalite (LiTaO3), or lithium niobate (LiNbO3). Its slow velocity makes it possible to fit many wavelengths across the IDTs in a very small device.

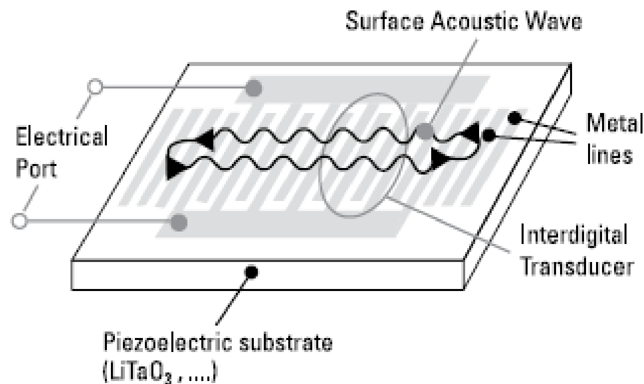


Figure 6-21 SAW Filter Architecture

A key advantage of SAW is its capability to optimally meet standard filter applications up to 1.9 GHz, including several standard bands such as GSM, CDMA, 3G, and some 4G bands.

Additionally, techniques such as wafer level packaging (discussed in Chapter 6) are being used to shrink SAW filters, allowing the integration of filters and duplexers for multiple bands onto a single chip. This is becoming increasingly important as smartphones incorporate more functions.

SAW filters, however, have limitations. Above about 1 GHz, their selectivity declines, at about 2.5 GHz.

The use of SAW is limited to applications with modest performance requirements SAW is also very temperature sensitive, this issue is better handled by temperature compensated SAW technology (TC-SAW). The stiffness of the substrate material tends to decrease at higher temperatures and acoustic velocity diminishes. A SAW filter's response may shift downward by as much as 4 MHz as temperature increases. This limitation has become more significant as guard bands become narrower and consumer devices are specified to operate across a wide temperature range (typically, －20°C to 85°C).

2) BAW: High Performance

BAW filters generally deliver superior performance (higher Q) with lower insertion loss at higher frequency levels. With BAW technology, it is possible to create narrowband filters with exceptionally steep filter skirts and excellent rejection. This makes BAW the technology of choice for many challenging interference problems. BAW delivers these benefits at

frequencies above 1.5 GHz, making it a complementary technology to SAW (which is most effective at lower frequencies). BAW can address frequencies up to 6 GHz and is used for many of the new LTE bands above 1.9 GHz. BAW is also highly effective for LTE/Wi-Fi coexistence filters.

BAW filter size also decreases with higher frequencies, which makes these filters ideal for the most demanding 3G and 4G applications. In addition, BAW design is far less sensitive to temperature variation even at broad bandwidths.

Unlike SAW filters, the acoustic wave in a BAW filter propagates vertically (see figure 6-33). In a BAW resonator using a quartz crystal as the substrate, metal patches on the top and bottom sides of the quartz excite the acoustic waves, which bounce from the top to the bottom surface to form a standing acoustic wave. The frequency at which resonance occurs is determined by the thickness of the slab and the mass of the electrodes. At the high frequencies in which BAW filters are effective, the piezo layer must be only micrometers thick, requiring the resonator structure to be made using thin-film deposition and micro-machining on a carrier substrate.

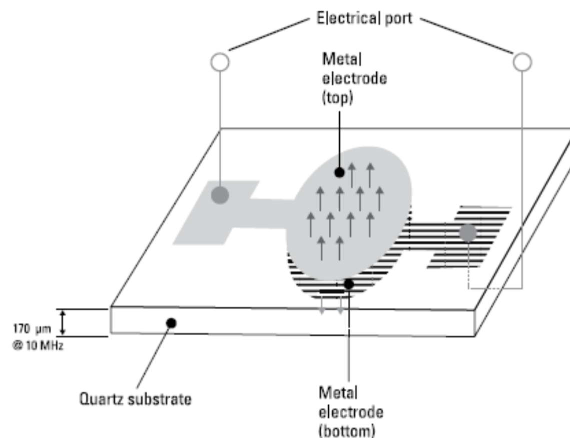


Figure 6-22 BAW Filter Architecture

To keep the waves from escaping into the substrate, an acoustic Bragg reflector is created by stacking thin layers of alternating stiffness and density. The result of this approach is called a solidly mounted resonator BAW (BAW-SMR). A Bragg reflector is a structure formed from multiple layers of alternating materials with varying refractive index.

An alternative approach, called a film bulk acoustic resonator (FBAR), etches a cavity underneath the active area, creating suspended membranes. Figure 6-34 compares BAW-SMR and FBAR filter designs.

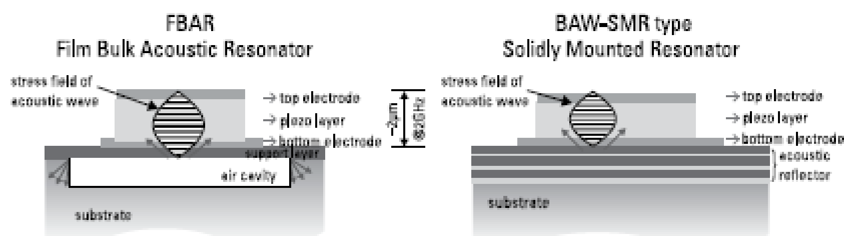


Figure 6-23 FBAR Vs BAW-SMR Architecture

Both types of BAW filters can achieve very low loss because the density of their acoustic energy is very high and the structures trap acoustic waves very well. Their achievable Q is higher than any other type of filter of reasonable size employed at microwave frequencies: 2,500 at 2 GHz. This results in superb rejection and insertion loss performance, even at the critical pass band edges.

The fundamental difference between FBAR and BAW-SMR is in how acoustic energy is trapped. For FBAR, the air/crystal interface on both faces of the resonator ensures that the main mode of interest is appropriately trapped. In BAW-SMR, Bragg reflectors underneath the resonator effectively trap this mode. Another major difference between FBAR and BAW-SMR is the thermal path for heat generated in the device. In BAW-SMR, the heat has a conduction path into the substrate from which it can be spread. In FBAR, because there is an air gap on each side of the resonator, the thermal conduction path is weaker.

Because BAW filters offer low insertion loss, they help compensate for the higher losses associated with the need to support many bands in a single smartphone. Besides improving signal reception, lower loss also contributes to longer battery life. BAW excels in applications where the uplink and downlink separation is minimal and when attenuation is required in tightly packed adjacent bands.

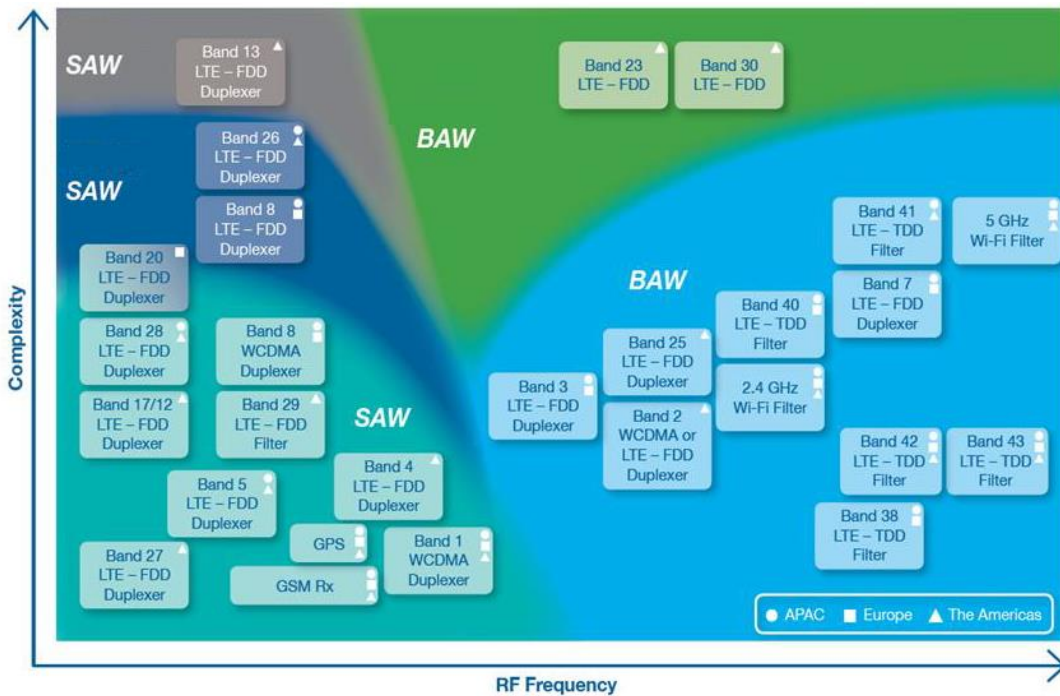


Figure 6-24 2G/3G/4G Filter Technology from Qorvo

6.2.1A 2.4GHz-2.7GHz 5G Filter Design

6.2.1A.1 Design Challenges

These products had been originally developed for TD-LTE. Assuming these products can also be used for n41 while new conditions and/or requirements are under investigation.

6.2.1A.2 Alternative Processes

According to present information, we believe that SAW or FBAR process products can meet the requirements of 5G n41 characteristics.

6.2.1A.3 Existing 2.4GHz-2.7GHz 5G Filter Products

The following is the TAIYO YUDEN filter product for n41 band based on SAW or FBAR technology. The main performance has been shown at below tables and figures. table 6-4, figure 6-36, table 6-5, figure 6-37:

Table 6-2A SAW Filter for 5G Band n41 (120MHz) HPUE

Pass band Frequency	2535-2655MHz	
Insertion Loss(Type)	1.7dB	
Attenuation(Type)	2400-2483MHz	38dB
	2750-4900MHz	33dB
	4900-6000MHz	45dB
	6000-8000MHz	32dB
Power Capability*	+31dBm at 2535-2655MHz, 5000Hr +32dBm at 2535-2635MHz, 5000Hr	
Size	1.1mm x 0.9mm x 0.44mm MAX	

* The power handling test condition for 5G NR (CBW: 100MHz) is under investigation.

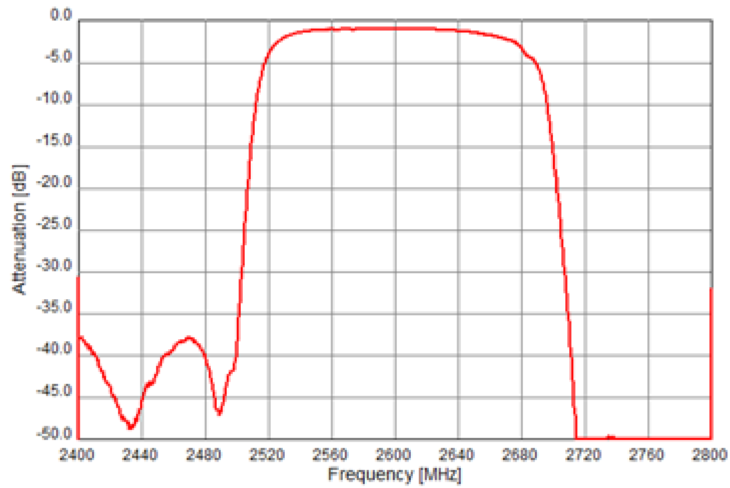


Figure 6-24A Frequency Performance of SAW Filter for 5G Band n41 (120MHz) HPUE

Comments: Above actual test data is provided by TAIYO YUDEN.

Table 6-2B FBAR Filter for 5G Band n41 (194MHz) HPUE

Pass band Frequency	2496-2690MHz	
Insertion Loss(Type)	2.4dB	
Attenuation(Type)	2401-2483MHz	35dB
	2775-4992MHz	14dB
	4992-5380MHz	34dB
	7488-8070MHz	23dB
Power Capability*	+32dBm at pass band frequency, 5000Hr	
Size	1.8mm x 1.4mm x 0.57mm MAX	

* The power handling test condition for 5G NR (CBW: 100MHz) is under investigation.

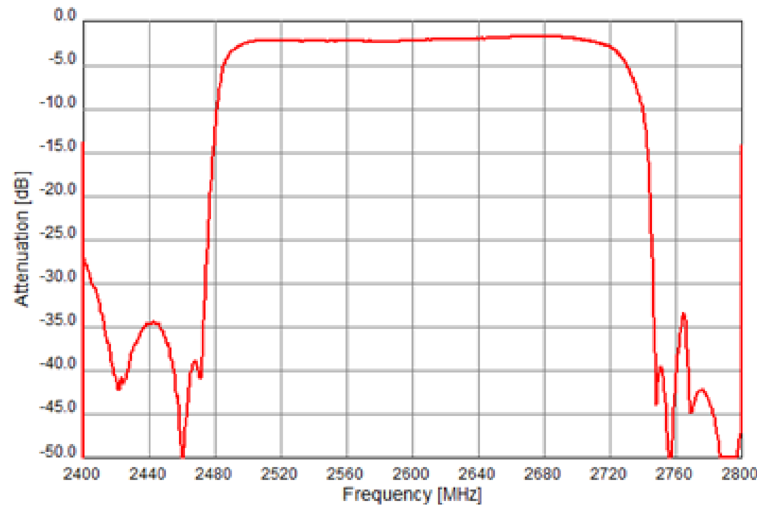


Figure 6-24B Frequency Performance of FBAR Filter for 5G Band n41 (194MHz) HPUE

6.2.2 Comments:Above simulation data is provided by TAIYO YUDEN.3.3GHz-4.2GHz 5G Filter Design

6.2.2.1 Design Challenges

Upcoming RF architecture for 5G to be introduced in 2020 and beyond would further require higher frequency and wider frequency bandwidth as it is being standardized under 3GPP Release 15. Filtering devices would be required to cover rather much higher relative bandwidth ratio as opposed to current 4G requirement as well as the compatibilities to HPUE requirement which is considered to be standardized within Release 15 while filtering devices are expected to provide rather lower insertion loss as well as decent attenuation level. Furthermore, when initial 5G implementation is done by NSA (Non-Standalone) mode, this may possibly generate IMD issue which would require filtering devices to provide lower passive inter-modulation characteristics. Therefore, upcoming new filtering RF devices must consider satisfying these potential issues.

6.2.2.2 Alternative Processes

Combine with 6.2.1.3 introduction of SAW filter, as the following chart 6-25, at the present the technology of filters have been divided to 3 series: ONE is SAW technology, it has always been utilized for main bands of cellular phone standard and this should continue to be the case as 5G will be using existing LTE bands after refarming by 3GPP. But it is difficult to meet the requirement of 5G high frequency and wider frequency bandwidth; TWO is FBAR/BAW technology, it has mainly been utilized for satisfying rather stringent attenuation and somewhat higher frequency requirement especially for the solution of coexistence with adjacent systems. This technology is capable of covering up to approximately 3800MHz ranges while the company has been working to push the envelope toward even much higher frequency ranges especially to satisfy upcoming 5G requirement. THREE is LTCC (Low

Temperature Co-fired Ceramic) technology. It is capable of meeting wider frequency bandwidth and higher frequency requirement. Similar to LTCC, LC structures on IPD technology, while a bit lower Q, are essential for integration in modules covering PA, switch, LNA and filters for frequencies above 3.3GHz, thanks to its miniaturization capabilities.

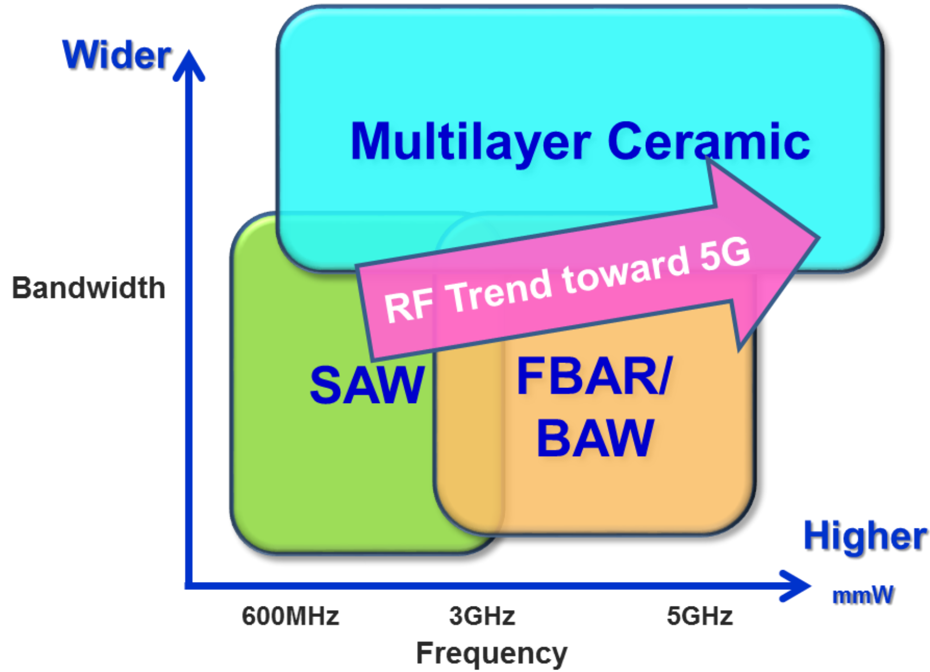


Figure 6-25 Common Filter Technologies

6.2.2.3 Existing 3.3GHz-4.2GHz 5G Filter Products

1) Technological advantages of multilayer ceramic filters (LTCC)

With the utilization of multilayer ceramic technologies, it can provide extremely low insertion loss for Sub-6GHz while covering entire required bandwidth. The relative bandwidth that can be covered with multilayer ceramic filters is approximately from 5 to 50%. It also contributes to the downsizing and lower profile requirements with significantly stable performance and relatively low cost. This technology also provides rather high power handling capabilities in comparison with SAW technologies and this should be another advantage as HPUE should be required by 5G Sub-6GHz standard. On the other hand, multilayer ceramic filters provide rather relaxed skirt characteristics as opposed to SAW filter technology. This concept should directly be applied to 5G Sub-6GHz requirement including Band n77, n78 and n79.

At the present, there is 5G LTCC filter already can support the HPUE device of Band n77 and Band n78, the main performance has been showed at below sheets and table 6-6, figure 6-26 table 6-7, figure 6-27.

Table 6-4 Multilayer Ceramic Band Pass Filter for 5G NR Sub-6GHz Band n77 HPUE

Pass band Frequency	3.3GHz – 4.2GHz

Insertion Loss(Type)	1.13dB	
Attenuation(Type)	600-2700MHz	44.4dB
	4900-5900MHz	32.4dB
	6600-8400MHz	44.1dB
	9900-12600MHz	32.4dB
Power Capability	+33dBm at pass band frequency, 10000Hr	
Size	2.0mm x 1.25mm x 0.65mm MAX, LGA Package	

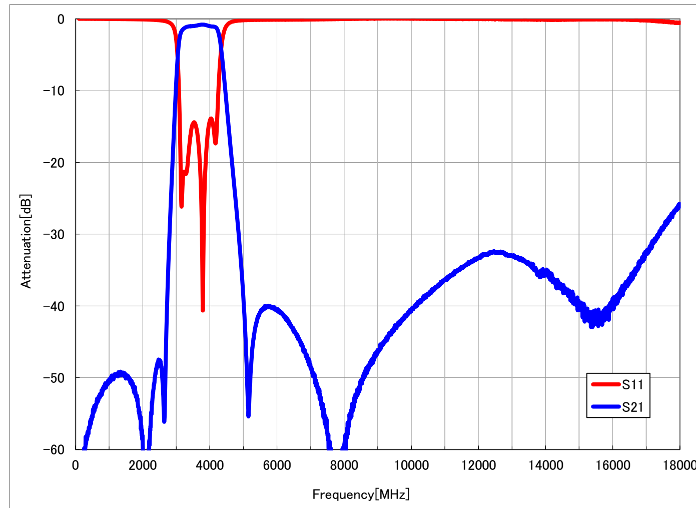


Figure 6-26 Frequency performance of LTCC BPF for 5G NR Sub-6GHz Band n77 HPUE

Note: Above actual test data is provided by TAIYO YUDEN.

Table 6-4 Multilayer Ceramic Band Pass Filter for 5G NR Sub-6GHz Band n78 HPUE

Pass band Frequency	3.3GHz – 3.8GHz	
Insertion Loss(Type)	1.24dB	
Attenuation(Type)	600-2700MHz	42.3dB
	4900-5900MHz	39.1dB
	6600-8400MHz	44.7dB
	9900-12600MHz	36.5dB
Power Capability	+33dBm at pass band frequency, 10000Hr	
Size	2.0mm x 1.25mm x 0.65mm MAX, LGA Package	

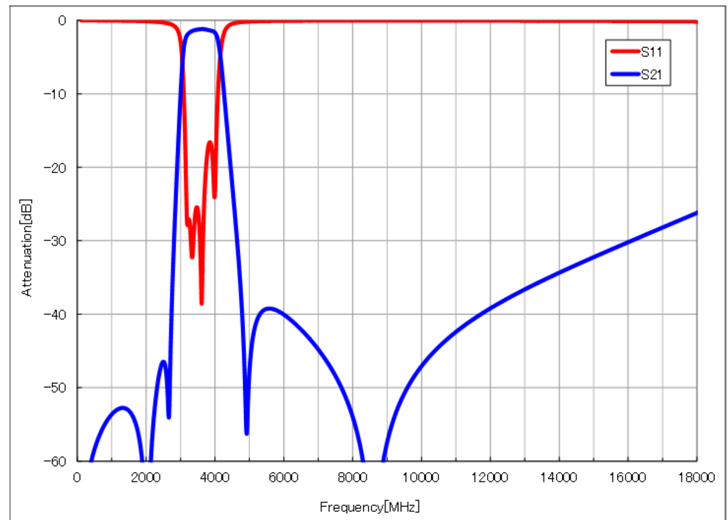


Figure 6-27 Frequency Performance of LTCC BPF for 5G NR Sub-6GHz Band n77 HPUE

Note: Above simulation data is provided by TAIYO YUDEN.

2) Integrated n77 filte

Below is integrated filter supporting 5G Band n77

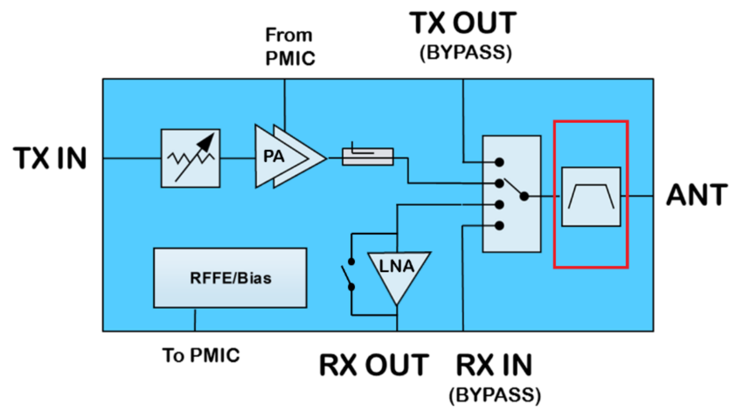


Figure 6-28 n77/n78 5G RF FEM Block Diagram

Tx chain gain data is as below

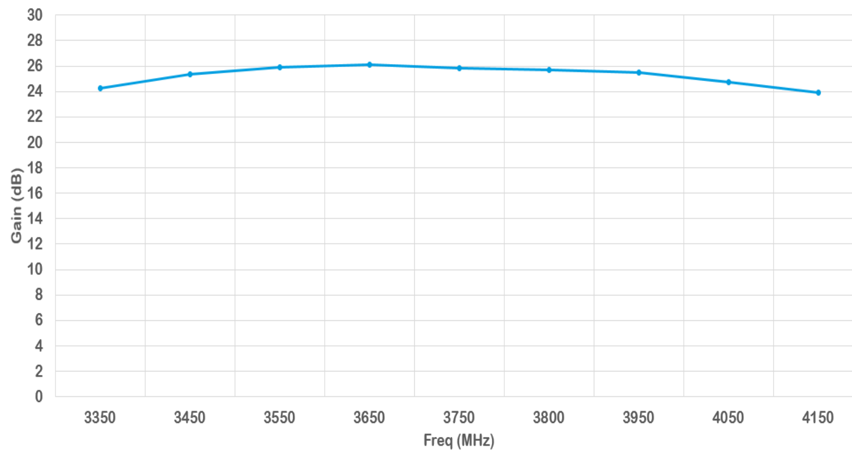


Figure 6-29 RF FEM Tx Gain Data

6.2.3 4.4GHz-5GHz 5G Filter Design

6.2.3.1 Design Challenges

3GPP RAN4 members have come to the agreement to choose the band from 4.4GHz to 4.99GHz earlier, on the other hand, as China MIIT (Ministry of Industry and Information Technology) published additional frequency ranges for 5G trial, including 4.8-5GHz. This was also proposed within 3GPP RAN4 and it has been approved that the upper edge of Band n79 was extended from 4.99GHz to 5GHz to support the spectrum demand in China. Within 3GPP, Band "n79" was newly assigned for "4.4-5GHz". Same as the filter for sub-6GHz 5G NR, the filters for 4.4-5GHz need to support wider frequency bandwidth and higher frequency. Other technology or integrated technologies shall be utilized depending upon the attenuation requirement of adjacent systems such as WiFi 5GHz and/or LAA/eLAA which starts at 5.15GHz.

6.2.3.2 Alternative Processes

Same as 6.2.2.2, LTCC technology is capable of meeting wider frequency bandwidth and higher frequency requirement.

6.2.3.3 Existing 4.4GHz-5GHz 5G Filter Products

1. Introduction of LTCC filter and related performance

Technology background of this Band n79 LTCC filter is same as previously explained in the article of Band n77 filter. LTCC based filter design is rather flexible and the design can be applied to other type devices including low pass filter, band pass filter, diplexer for Sub-6GHz in the light of upcoming 5G requirement. At present, Taiyo Yuden has been working on series of different band pass filters for 5G Band n79 and the following is the example from the variations and the size is 2.0mm x 1.25mm x 0.65mm Max with LGA (Land Grid Array) package and performance is as shown as below table 6-5, figure 6-30.

Table 6-5 Multilayer Ceramic Band Pass Filter for Sub-6GHz 5G NR Band n79 HPUE

<table>
<tr><td>Pass band Frequency</td><td colspan="2">4.4GHz – 5GHz</td></tr>
<tr><td>Insertion Loss(Type)</td><td colspan="2">0.55dB</td></tr>
<tr><td rowspan="4">Attenuation(Type)</td><td>2400-2500MHz</td><td>50.6dB</td></tr>
<tr><td>2500-2690MHz</td><td>39.9dB</td></tr>
<tr><td>8800-10000MHz</td><td>22.1dB</td></tr>
<tr><td>13200-15000MHz</td><td>31.7dB</td></tr>
<tr><td>Power Capability</td><td colspan="2">+33dBm at pass band frequency, 10000Hr</td></tr>
<tr><td>Size</td><td colspan="2">2.0mm x 1.25mm x 0.65mm MAX, LGA Package</td></tr>
</table>

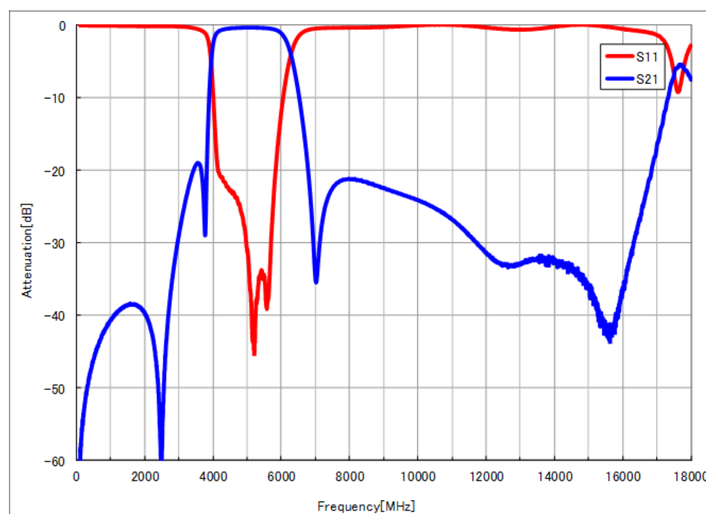


Figure 6-30 Frequency Performance of LTCC BPF for Sub-6GHz 5G NR Band n79 HPUE

Note: Above simulation data is provided by TAIYO YUDEN.

2. Integrated n79 filter

5G bands have higher frequency and wider band width, which requires filters provide more steep conversion bandwidth, these new requirements and characteristics bring great challenges to the existing acoustics based filters. The integrated passive filter which can be used in N79 device design provides a balance in performance, size and cost. Integrated n79 filter is still under development.

6.3 Sub-6GHz 5G Low Noise Amplifier

6.3.1 Existing Mobile Device Commercial Low Noise Amplifier Products

Broadband LNA is a critical component in radar, communication, electronic countermeasures, telemetry and remote areas. In wireless communication, the higher data transmission speed requires the higher of channel capacity. For RF receiver, the noise figure and linearity of LNA

directly affects and decides the sensitivity and dynamic range of a RF receiver, which requires LNA's low noise to improve the sensitivity and power gain, to reduce the noise of next level circuit.

6.3.2 Sub-6GHz 5G Low Noise Amplifier Design

6.3.2.1 Design Challenges

Wideband LNA design challenges are to keep high gain, low noise finger and high IP3 in the full band.

6.3.2.2 Alternative Processes

The processes for LNA include GaAs pHEMT, SiGe HBT and CMOS. SiGe HBT and CMOS with good compatibility and low cost, GaAs pHEMT has excellent noise and gain performance. GaAs pHEMT (E-mode) has the 2-D characteristic of the heterojunction, in order to get high carrier mobility and low noise figure.

1) 0.15um E-mode GaAs pHEMT

(E-mode) 0.15um GaAs pHEMT (E-mode) contains 17 masks and over 200 process steps. Each of these steps needs repeatable experiment, to ensure the whole process reliable and commercial

The domestic foundries are developing 6-inch 0.15um GaAs pHEMT technology, one choice of 5G's PA. The main performances of this technology are given in table 6-9.

Table 6-6 main performances of 6-inch 0.15um GaAs pHEMT technology

Item	Unit	Performance	Condition
TFR	ohm/sq	50+/-5	
Lg	um	0.150 +/- 0.02	
Rs (Epi)	ohm/sq	150 +/- 20	
Idss	mA/mm	<0.05	@Vgs=0V Vds=1.5V
Gm max	mS/mm	1000 +/-150	
Imax	mA/mm	420 +/- 100	@Vgs=+0.9V
Vp	V	0.3 +/- 0.15	@1mA/mm
BVgd	V	10 +/- 3	@1mA/mm
ft	GHz	110+/-25	
Psat	mW/mm	> 700 mW/mm	@29 GHz

The key parameters in table 6-6 are explained as follow:

- TFR: thin film resistor, produced by TaN.
- Lg: gate length, the smaller Lg , the higher Ft.
- Rs(Epi): epitaxy active layer resistor.

- Idss: the drain current.
- Gm_max: the maximum value of the transconductance.
- Idmax: the maximum value of the drain current.
- Vp: the gate threshold voltage. The gate voltage is larger than Vp, the transistor is switched on;the gate voltage is smaller than Vp, the transistor is switched off.
- BVgd: the drain-source breakdown voltage.
- ft: the cut off frequency.

2）0.25um E-mode GaAs pHEMT

The domestic foundries have their own IP on 0.25um GaAs pHEMT process technology, include material, device, integration, producing process, yield control, modeling and process design kit(PDK). 0.25um GaAs pHEMT technology has been finished and reached the mean level of the industry.

0.25um GaAs pHEMT is applied for LNA and PA. And also provides E/D mode logic devices, 0.5um GaAs pHEMT (D-mode) for switch, ESD devices, resistor and capacitor.

Table 6-7 The main performances of the 0.25um GaAs pHEMT technology

Item	Unit	Performance	Condition
Idss	mA/mm	<0.01	@Vgs=0V
GM_max_E	mS/mm	800±100	
I_max_E	mA/mm	500±80	@Vgs=+1.4V
Vp_E	V	0.3±0.15	@1mA/mm
BVgd_E	V	12±4	@1mA/mm
ft_E	GHz	75±15	
Psat	mW/mm	>370	@10 GHz

The key parameters in table 6-7 are explained as follow:

- Idss: the drain current.
- Gm_max_E: the maximum value of the transconductance.
- Idmax: the maximum value of the drain current.
- Vp_E: the gate threshold voltage,.
- BVgd_E: the drain-source breakdown voltage.
- ft_E: the cut off frequency.

In addition to above mentioned technologies, the existing SOI technology could also provide designers a cost-optimized platform to improve PPAC of LNA. With the help of SOI technology, LNAs can be realized in the RF front end modules of 4G and sub-6G 5G components.

6.3.2.3 Existing Sub-6 5G Low Noise Amplifier Products

LNA is integrated into module design as below to support n77 3.3-4.2GHz.

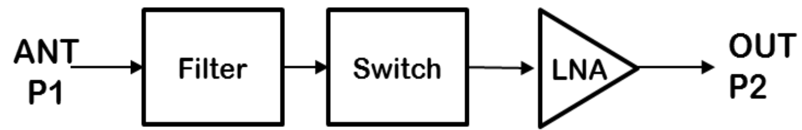


Figure 6-31 Band n77 LNA in RF FEM

7 mmWave 5G Device RF Component

7.1 mmWave 5G Power Amplifier

RF PA plays a very important role in wireless communication system. With the development of communication technology, the requirement of RF PA is increasing, especially for broadband, high linearity and high efficiency. While amplifying the signal, PA must reduce the distortion of the signal as much as possible. Therefore, linearity is a very important index in the design of the power amplifier, and other indexes include gain, flatness, efficiency, distortion and so on. GaAs E-mode pHEMT technology inherits many advantages of D-mode pHEMT technology, and has the characteristics of single power, high span and high linearity. The current development trend of the mobile phone market has been extending the time of call and improving the function of the mobile phone so that it needs to keep enough performance to reduce the voltage. The E-mode pHEMT device has a very low switching voltage, so there is no limit on the offset margin.

1) 0.15um E-mode pHEMT

(E-mode) 0.15um GaAs pHEMT contains 17 masks and over 200 process steps. Each of these steps needs repeatable experiment, to ensure the whole process reliable and commercial

The domestic foundries are developing 6-inch 0.15um GaAs pHEMT technology, one choice of 5G's PA. The main performances of this technology are given in table 7-1.

Table 7-1 main performances of 6-inch 0.15um GaAs pHEMT technology

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TFR	ohm/sq	50+/-5	
Lg	um	0.150 +/- 0.02	
Rs (Epi)	ohm/sq	150 +/- 20	
Idss	mA/mm	<0.05	@Vgs=0V Vds=1.5V
Gm max	mS/mm	1000 +/-150	
Imax	mA/mm	420 +/- 100	@Vgs=+0.9V
Vp	V	0.3 +/- 0.15	@1mA/mm
BVgd	V	10 +/- 3	@1mA/mm
ft	GHz	110+/-25	
Psat	mW/mm	> 700 mW/mm	@29 GHz

- TFR: thin film resistor, produced by TaN.
- Lg: gate length, the smaller Lg, the higher Ft.
- Rs(Epi): epitaxy active layer resistor.
- Idss: the drain current.

- Gm_max: the maximum value of the transconductance.
- Idmax: the maximum value of the drain current.
- Vp: the gate threshold voltage.the gate voltage is larger than Vp, the transistor is switched on;the gate voltage is smaller than Vp, the transistor is switched off.
- BVgd: the drain-source breakdown voltage.
- ft: the cut off frequency.

2) InP

Currently, GaAs device has dominated most of the market because of its mature technology in the microwave frequency band. However, InP device has higher breakdown voltage, higher average electron velocity, larger discontinuity in the bandgap at the interface of InAlAs/InGaAs heterojunction, higher 2DEG concentration, and higher electron mobility in channel, making it more suitable for high frequency applications.

For low voltage applications, InP HBT is expected to replace GaAs HBT. InP HBT is made of narrow bandgap material InGaAs. The bias voltage is as low as 0.5V~0.6V. In addition, InP HBT also exhibits better heat conduction characteristics, better heat dissipation capability (about 1.5 times of GaAs substrate) and higher peak electron velocity, allowing higher performance at lower voltages.

Although InP/InGaAs HBT with lattice matching on the InP substrate has superior high frequency and high speed characteristics, and lower turn-on voltage than GaAs HBT, it suffers from small substrate size, high cost, and fragility of the InP substrate, limiting its large-scale and low lost production. The capability to obtain high quality and large size semi-insulating InP substrate is key to lower cost. Therefore, to meet the ever increasing demand of InP devices, fundamental task is to grow high quality and large diameter InP single crystal substrate.

3) GaAs mHEMT

Benefiting from the cost, fragility and process compatibility issues of InP substrate, more and more research on GaAs mHEMT technology has been conducted. GaAs mHEMT technology is to grow a relatively thick InAlAs layer between the channel and the GaAs substrate. The composition of In changes from a certain value X to 0, so the mismatch of the lattice is alleviated. After the adding of a buffer layer with graded component, the component X of In in the channel layer can be chosen almost arbitrarily between 30%~60%, and the device performance is optimized with a great degree of freedom. mHEMT can be considered as InP HEMT technology on GaAs substrate. It shows superior performance to InP in terms of low noise, allowing GaAs to solidify its position at the low-end of millimeter wave, and further its way into the high-end territory of millimeter wave.

In 2008, 220GHz-320GHz mHEMT MMIC amplifier was reported using high In composition in InGaAs as channel to achieve high carrier density and mobility. Double InAlAs barrier layers and bilateral delta doping are designed to increase channel electron confinement and reduce

contact resistance, and the buffer layer with linear component change is used to achieve lattice matching. The Ft and Fmax are 515GHz and 700GHz, respectively, for the device with 35nm gate length and 20um gate width. The linear gain of the two stage amplifier is more than 10.5 dB in the 220GHz-320GHz frequency band, and the small signal gain is 13.5dB at 330GHz. In 2011, the device with 20nm gate length was reported, and the Ft was 660GHz for the mHEMT with 2*10um gate width. GaAs mHEMT has been able to work into the H band and enter the low-end of the terahertz. It has become an important component of the sub-millimeter wave application, with a cost advantage.

Chapter 4.1 data sources: Hiwafer.

7.2 mmWave 5G Filter

mmWave devices are supposed to have large-scale and high density distribution to meet the requirements of multi frequency and high frequency characteristics, which is bound to bring an explosive growth of mmWave filter.

1) SAW filter

Under the existing framework, the SAW filter is the main force of 2G, 3G and 4G communication technologies, and has the advantages of high design flexibility, good frequency selection characteristics and small size, and can adopt the same production process as the integrated circuit. The frequency characteristic of the SAW filter is closely related to the pitch of the IDT electrode. The higher the frequency, the smaller the distance between the electrodes is required. In fact, the spacing is not too small. The SAW filter drops rapidly after the frequency exceeds 2.5 GHz. Therefore, the SAW filter is mostly used below 2.5 GHz.

2) BAW filter

Beyond 2.5GHz, BAW began to show the advantage. Compared to SAW, it is insensitive to temperature changes, with low insertion loss and high out-of-band rejection, making its share of 3G / 4G smartphones grow rapidly. However, most BAWs are used below 6 GHz and can reach a maximum of 20 GHz, which is applicable to 5 GHz systems below 6 GHz and can't be applied in the 5 GHz frequency band yet.

3) MEMS filter

Millimeter wave MEMS filter on the semiconductor substrate, the use of semiconductor manufacturing process constitutes a filter structure, with high Q and low loss characteristics, in the millimeter band has good performance. However, whether it is using gallium arsenide substrate or silicon substrate, the cost is relatively high. Under the conditions of ensuring a high degree of consistency, mass production is still more difficult.

4) Semiconductor chip filter based on MMIC process

The semiconductor chip filter based on the MMIC process can be integrated with the 5G system chip or integrated with the microwave multi-chip module. At the same time, due to

the adoption of the semiconductor process, the batch consistency of the electric performance is good, and the application is suitable for large-scale applications. Of course, due to its circuit form can only be integrated by plane, the circuit transmission waveform for the quasi-TEM wave inevitably surface waves, space radiation, dielectric and metal loss and other natural defects.

The domestic foundry has developed GaAs IPD process for the passive circuit design. The typical parameters of GaAs IPD process are given in table 7-2.

Table 7-2 The typical parameters of GaAs IPD process

Typical parameters	
Metal layer	Metal 1:1 μm
	Metal 2:2μm or 4μm
Metal1-metal2 Via	PBO or Air-bridge
MIM capacitance density	300pF/mm2 or other
TaN thin film resistor	50Ω/□
Inductor	High Q
Background via diameter	40μm
passivation	SiN or PBO
Wafer thickness	100 or 75μm

The LC low-pass filter and high-pass filter MMICs made by IPD process have covered 2-20GHz in 0.5GHz step, the typical MMIC area is 1mm*0.75mm*0.1mm with a insert loss of 2dB.

Moreover, there are many customized band-pass filter products. The table 7-3 gives a typical 27.5GHz~29.5GHz high Q band-pass filter.

Table 7-3 The performances of a typical 27.5GHz~29.5GHz high Q band-pass filter

27.5GHz-29.5GHz band-pass filter
Central frequency:28.5GHz; Band width:2000MHz; Insert loss:≤ 3 dB; In-band flatness: ≤1 dB （Fluctuation range＜1dB for any 1GHz, and＜0.5dB for any 500MHz; Input/output return loss: ≥13dB; Out-band compression:70dBc@＜6GHz 50dBc@6~20GHz 35dBc@20~26GHz 30dBc@31~34GHz 37dBc@34~40GHz 30dBc@＞40GHz Group delay flatness: ≤5ns@25 ℃ Area:5.2mm ×2mm ×0.1mm

The data in chapter 7.2 come from HiWafer

7.3 mmWave 5G Low Noise Amplifier

The research of MMwave LNA, abroad companies start very early, some companies had made good samples or products. The international semiconductor companies such as M/A-COM, Hittite, Qorve, TRW and UMS develop various kinds of MMwave LNA and have got many achievements. Compared with these companies, the domestic research Started relatively late. Haoquan Hu in University of Electronic Science and Technology of China developed a Ka LNA with a 4.5dB noise figure and 20dB gain in 2006. A group in Microelectronics Institute of the Chinese Academy of Sciences developed a 4-stage MMIC LNA in 2007, which works in 26.5-36GHz with a 3dB noise figure and 20dB gain. In 2008, the Shanghai Institute of Microsystem and Information Technology of Chinese Academy of Sciences developed a 4-stage LNA using 0.15um GaAs pHEMT process, the LNA has a 18+/-1.5dB gain, an input VSWR smaller than 3, an output VSWR smaller than 2.3, DC power of 96mW in 45GHz-65GHz. In 2008, the 38th institute of CETC developed a X-band 3-stage LNA using negative feedback technology based on the 0.25um GaAs pHMET process of UMS, this LNA has a 29.5dB gain with a noise figure below 1.7dB.

GaAs pHEMT has excellent noise and linearity performance. Owning to its high insulation rate, GaAs substrate leads to the improvement of chip inductor quality factor (Q), which helps to reduce the overall noise figure of the terminal. GaAs pHEMT has excellent noise and gain performance, and has not been widely used in the early years due to price. Now, with the progress of the process, GaAs pHEMT has become the mainstream for the development of LNA. For cost and performance considerations, the mainstream process is the gate length of 0.25um. GaAs pHEMT has implemented the gate length 0.1um level. For example, the noise and gain of the PH10 process developed by UMS in Europe is 1.3dB and 7dB at 40GHz. LNA developed by Qorvo in USA is 0.13um gate long, cut-off frequency of 110GHz with TQP13 technology, and the noise figure at X frequency band is lower than 0.5dB.The Thirteenth and Fifty-fifth Research Institute of China Electronic Science and Technology Group and also developed 4 inch, 0.1um gate length pHEMT technology for high performance LNA. At present, Hiwafer are also actively developing the 6 inch, 0.15um gate length GaAs pHEMT technology, the development of single process has been completed, and it is in the stage of integration testing.

Chapter 4.4 data sources: Hiwafer

7.4 Switches for mmWave

Switches, the smallest active electronic components, play a critical role in the overall performance and effectiveness of wireless communication systems. Switches route the transmit and receive signals at different frequencies, enable monitoring and calibration and are the base component for functions such as phase shifting and step attenuation. 5G, the fifth generation wireless system, will continue this reliance on solid-state switching. But with 5G on the horizon, what are the switching requirements, and what makes a “great” 5G switch?

This chapter will explore a few basic specifications for 5G switching, discuss the use of SOI technology and showcase a few critical functions for switches in 5G communications systems.

7.4.1 What makes a ‘Great’ 5G Switch?

Switch performance is evaluated by a number of different specifications. In general, a “good” switch has low insertion loss, high linearity, high port-to-port isolation, high power handling and a fast switching time. In massive-MIMO architectures, each frequency bucket, sub-6 GHz and mmWave, will stress each of these parameters.

In mmWave systems, broadband frequency operation becomes increasingly important. To ease the transition to mmWave, switches must be able to support multiple bands, such as dual bands (28 GHz and 39 GHz), or even triple bands (28 GHz, 39 GHz and 66 GHz). In addition to multiple bands, each band has rigorous requirements on frequency-response variation. For example, a 28 GHz mmWave application will have a wide bandwidth, and the system gain can have a problem not meeting the flatness of the waveform over the wide bandwidth. Real wideband support implies minimum variation across the supported frequency band.

Due to the complexity of 5G system architectures, outstanding RF switch operation is critical to enabling the new generation of devices. Specifications such as insertion loss, high linearity and fast switching time are paramount to system performance.

1) Insertion Loss

   Low insertion loss enables lower power amplifier drive, and thus lower energy consumption and higher output efficiency.

2) Linearity

   High linearity lends itself to support higher order modulation schemes without signal degradation. One measurement of a switch’s linearity is the third-order intercept point (IP3). A high IP3 means the device will add minimal distortion in the form of intermodulation and increased adjacent channel leakage ratio (ACLR) to the transferred signal, and it will be able to withstand more extreme blocker conditions.

3) Switching time

   Comparing with LTE and sub-6GHz system, mmWave systems require faster switching to meet the requirements of the standard.

4) Power consumption and size

   In mmWave system, the switch’s size and power consumption are two other key factors in emerging massive-MIMO systems. As the name indicates, massive MIMO adds RF and antenna content to the base station. Switches must be compact and feature low-power consumption to be considered for use in massive-MIMO systems.

7.4.2 SOI Technology for 5G Switching

While many semiconductor technologies yield good active devices, very few yield good switches. Silicon on insulator (SOI) is one semiconductor technology that has demonstrated its effectiveness in switching.

CMOS is recognized for its manufacturing repeatability, which reduces end-product performance variability. SOI technology leverages the economic benefit of a mainstream complementary CMOS process to deliver a number of benefits, including manufacturability, performance and integration. In regard to switch performance, SOI technology delivers low insertion loss, high isolation and high linearity. In addition, SOI has the ability to integrate analog, digital and mixed-signal capabilities on a single chip. Integration of mm-wave PA, LNA, phase shifters and up/down mixers have also been achieved using fine geometry SOI (45nm), making such technology a good candidate for fully integrated Transmit/Receive phase arrays for 5G NR above 24GHz. This superior level of integration results in a smaller form factor, higher flexibility/configurability, higher reliability and better system performance.

8 Related 'Black Technologies'

8.1 Engineered Substrate

8.1.1 What is 'Engineered Substrate'?

Engineered substrate defines a material most of the time dedicated to semiconductor industry which is commonly made out of multiple raw materials. Its position in the supply chain is presented in figure below (Figure 8-1).

Figure 8-1 Engineering substrate in the supply chain, Soitec

Silicon On Insulator (SOI) is the most popular Engineered Substrate. It represents 6% of the silicon substrates industry and forecast to enjoy high growth. Compound materials market value is around 2%.

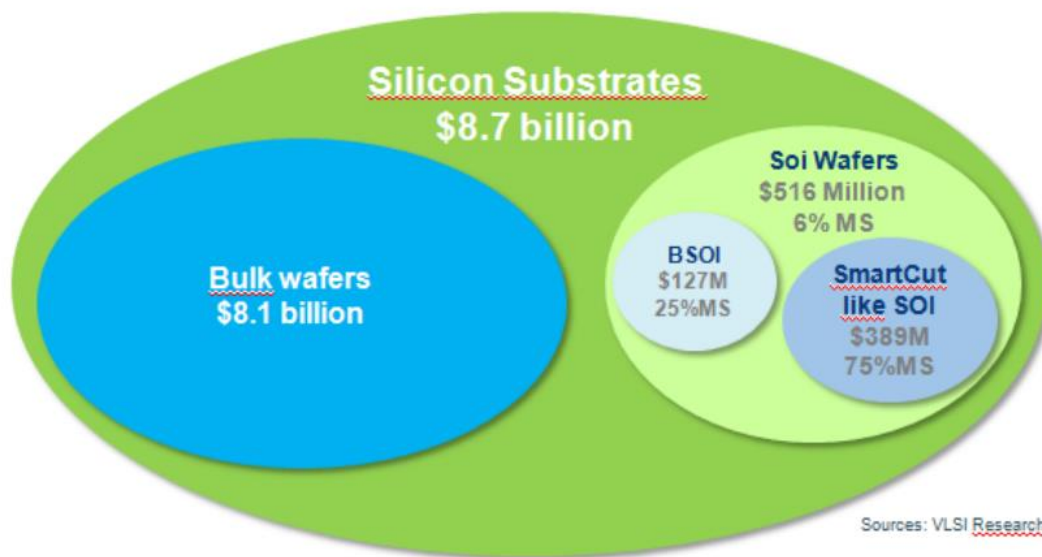


Figure 8-2 SOI substrate market in silicon substrates industry, Soitec

SOI history started 40 years ago. CMOS SOI was initially adopted in 1980's in space applications for its radiation hard properties. In 1998, IBM adopts SOI in large scale for its mainframe processors 'Power Cell' powering its Power PC, followed by Apple which did choose Motorola SOI processor for its G4 power station. Graphics processors derivatives were then designed on SOI for well known game console PS3, Wii and X-Box. At the same time, AMD did develop all its product line micro processor on SOI (Athlon, Turion, Opterion ....) moving SOI to high volume manufacturing using state of the art CMOS 300mm foundries. In 2000's, Philips Semiconductors was the second major adopter of SOI for its high voltage IVN (In Vehicle Networking) transceivers. In the last ten years, more and more applications are using SOI substrate as presented in following parts.

8.1.2 Why do we need 'Engineered Substrate'?

Engineered substrates are today at the heart of the RF Front End Module. CMOS bulk is not much used till lossles and source of distortions. Future generations' phone will use even more SOI as SOI may find its way in transceivers RFIC and beyond.

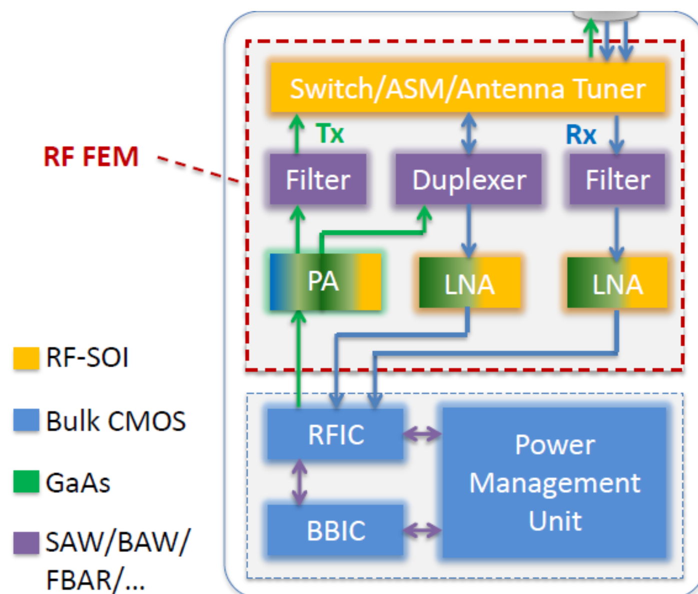


Figure 8-3 Types of substrates in mobile phone, CMCC

There are two main motivations for China Mobile and end application leading companies to learn about Engineered Substrate:

- **Awareness about new technologies in term of competitive advantage, supply chain**. There are many players between end users and engineered substrate suppliers due to the supply chain complexity. Those players have not the expertise to give proper visibility to end users and could hide unintentionally key information or even hide engineered substrate as an option of differentiation;

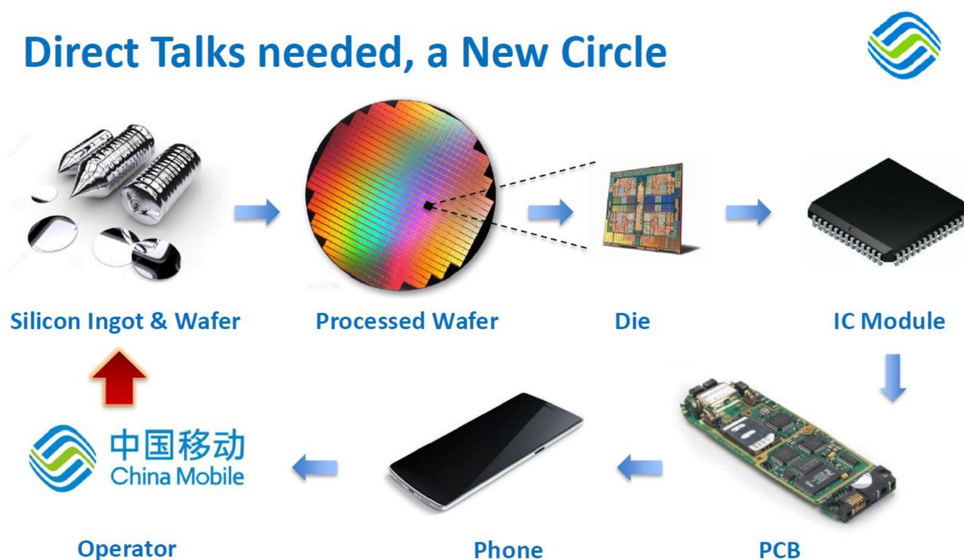


Figure 8-4 Cellular device industry chain, CMCC

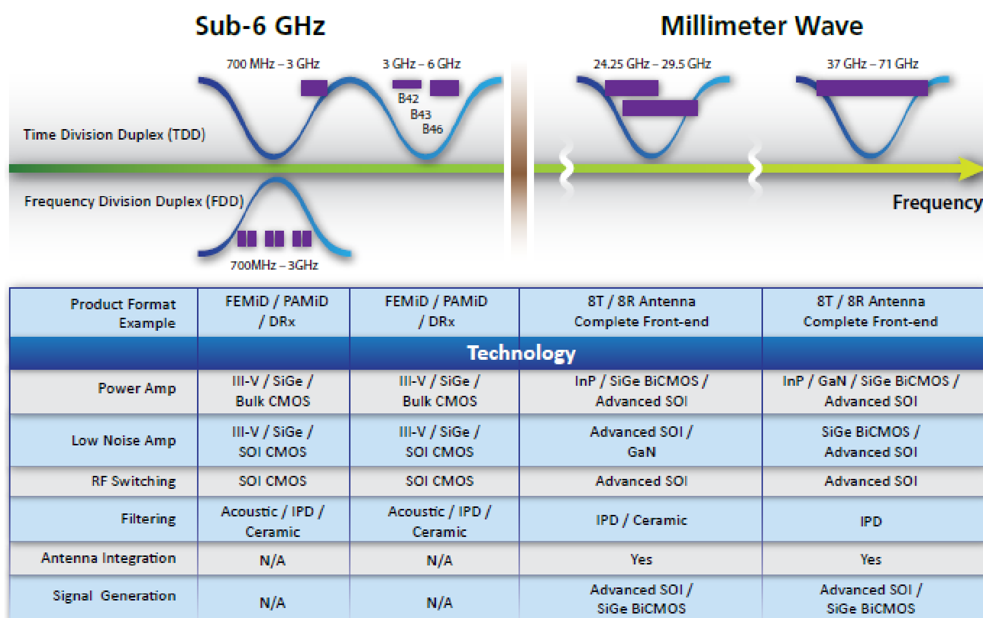
- **Shorten time to market of new technology introduction**. Sooner end user understands the value of a new technology and faster he will enable it in its application. In some case, decision can be taken to shorten supply chain by making a vertical

integration to limit the number of interfaces and then get closer to engineered substrate suppliers. Leading SmartPhone companies are moving in this direction and are making themselves some key differentiating parts of their product. As an example, the automotive industry is actively working to enable new technologies defined in reference technology roadmaps one year after its market introduction and not three years as it is today. SmartPhone industry is a benchmark for automotive industry in that respect.

- RF-SOI is today in 100% of SmartPhone with growing content at each generation whereas it wasn't even introduced in this market in 2011.

Figure 8-5 RF-SOI content in Smartphone, Soitec

Looking at 5G, substrate technologies choice for RF is a key topic as presented in Skyworks reference white paper (Figure 8-6). SOI is clearly the preferred technology in most of key RF building blocks.



Product Format Example	FEMiD / PAMiD / DRx	FEMiD / PAMiD / DRx	8T / 8R Antenna Complete Front-end	8T / 8R Antenna Complete Front-end
		Technology		
Power Amp	III-V / SiGe / Bulk CMOS	III-V / SiGe / Bulk CMOS	InP / SiGe BiCMOS / Advanced SOI	InP / GaN / SiGe BiCMOS / Advanced SOI
Low Noise Amp	III-V / SiGe / SOI CMOS	III-V / SiGe / SOI CMOS	Advanced SOI / GaN	SiGe BiCMOS / Advanced SOI
RF Switching	SOI CMOS	SOI CMOS	Advanced SOI	Advanced SOI
Filtering	Acoustic / IPD / Ceramic	Acoustic / IPD / Ceramic	IPD / Ceramic	IPD
Antenna Integration	N/A	N/A	Yes	Yes
Signal Generation	N/A	N/A	Advanced SOI / SiGe BiCMOS	Advanced SOI / SiGe BiCMOS

Figure 8-6 Product and Technology per Front-End modules range, Skyworks

For more direct customers such as foundries, fabless and IDM (Integrated Device Manufacturer), there are two main motivations to engage in engineered substrate:

- Improve Performance, Power, Area, and Cost (PPAC acronym is commonly used in the semiconductors industry). In 2010, GaAs was incumbent technology for RF antenna switch. RF-SOI enables same performance and power consumption, more than 30% cost reduction and 50% die area. As consequence, RF-SOI has gradually replaced GaAs for switch in less than 5 years.
- Enable new applications. For the iPhone's 10th anniversary, Apple has started using 3D sensing and integrated near infrared (NIR) camera sensor with high-precision depth sensing. This camera sensor is the first imager to feature SOI substrate provided by SOITEC. This type of SOI technology allows having higher quantum efficiency with very low noise.

Engineered substrates are in most case significantly more expensive than raw bulk material because it requires process steps before moving to foundries and is often a major hurdle for foundries and fables to consider engineered substrate. But comparing cost between bulk material and engineered substrate doesn't make sense. The value proposition needs to be evaluated by end user inn final application. For this reason, it is a major motivation for engineered substrate company to work and cooperate across supply chain.

8.1.3 Application

By changing the different specifications of the SOI wafer, multiple applications can be addressed.

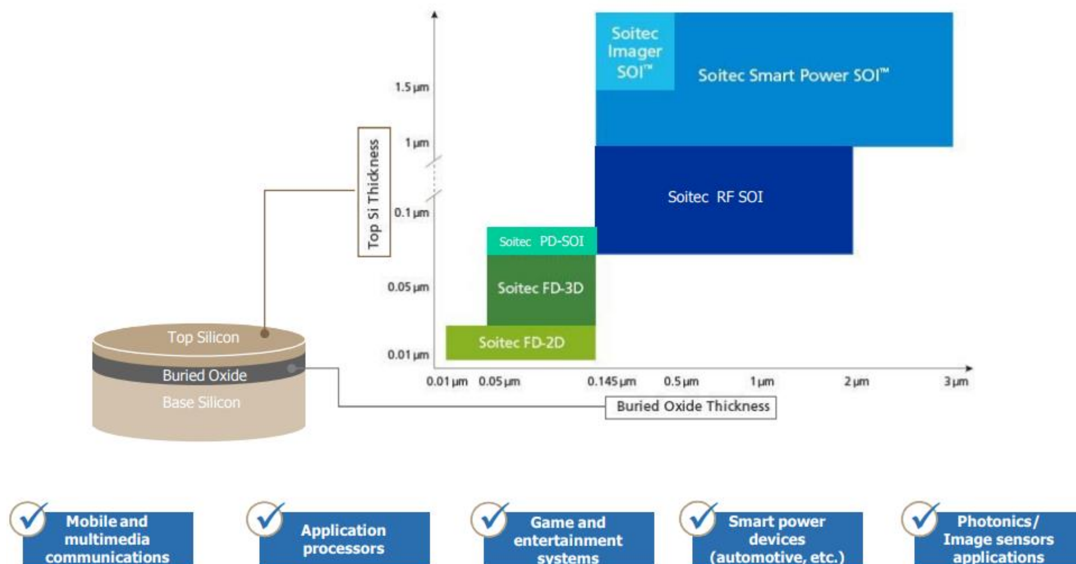


Figure 8-7 Various SOI wafer specifications, Soitec

In following chapters, RF-SOI, PD-SOI and FD-SOI for RF will be presented in details. Meanwhile SOI technologies can address other various applications:

- SmartPower SOI is typically dedicated to high voltage analog applications beyond 80V. It is the case for In Vehicle Transceivers which are used in 50% of automotives today.
- Imager SOI was used in the 2010's for Back Side Image sensors before it was replaced by silicon bulk. Today, SOI imager sensors are considered since they can enable better dark noise performance and infrared capability (vision in low light condition).
- SOI is also becoming the mainstream technology for silicon photonics. It is made with two layers of silicon with oxide in between. The first layer is used as a light waveguide and top layer for active devices like modulator, couplers, etc.

Applications are not limited to silicon CMOS on SOI. Compound materials, even polymer (plastics) can be used. As illustrated on Figure 8-8, World record efficiency for solar cell has been achieved by four junctions that convert full light spectrum into energy. Using same type of material, LED market can be addressed. Sensors are another wide range of applications that can be addressed.

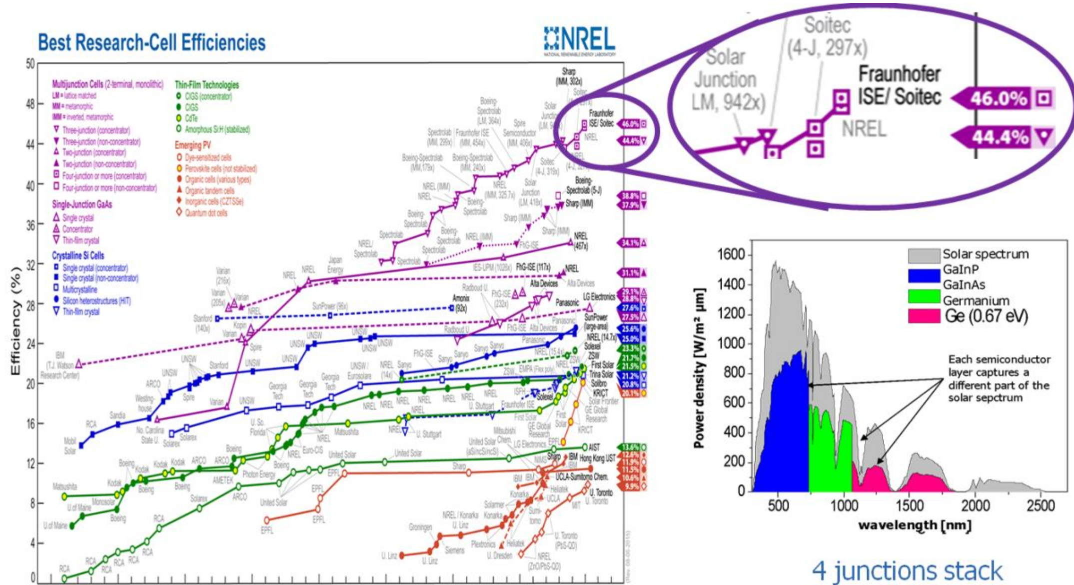


Figure 8-8 Sate of the art for solar cell efficiency, Soitec

Applications are almost infinite for engineered substrates as long as they bring advantage on Power, Performance, Area and cost, or they enable new applications.

Availability in large volume through multiple sources is a major point to address for making a new engineered substrate successful adoption on the market. To address this properly, a global eco-system need to work together to guarantee all supply is in place. Having China Mobile in this eco-system is of great value.

8.2 Engineered Substrate: 'Anything on Anything'

Engineering substrate is a combination of multiple material stacks. In principle, anything can

be stacked on anything, even on nothing. There are three main expertises that are required to build those engineered substrates: Smart Cut™, Smart Stacking™, Epitaxy. They are described in following sub-chapters.

Fourth expertise is in the DNA of engineered substrate engineers: material sciences. Silicon is the most well known material. Compound materials such as Gallium Arsenide (GaAs), Gallium Nitride (GaN), Indium Phosphide (InP), etc… are particularly interesting for RF and High Power applications as well as photonics and lighting. For companies willing to play in those applications, compound semiconductors expertise is also required.

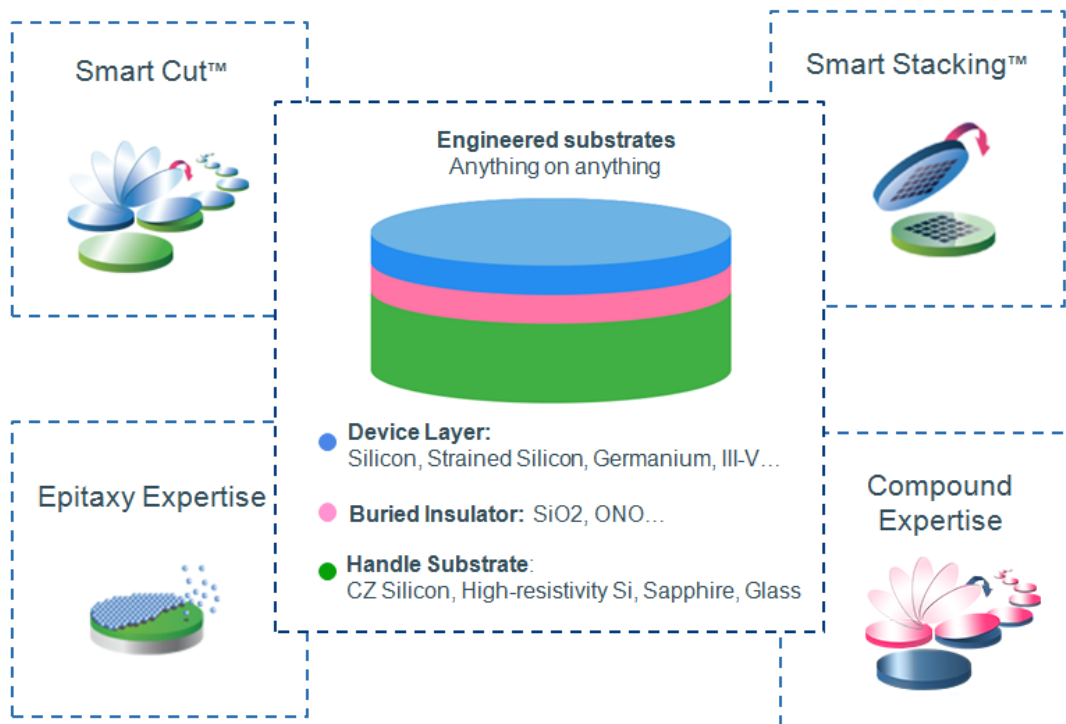


Figure 8-9 Technologies involved in engineered substrates, Soitec

There are two other critical expertises:

- Metrology: in most cases, all materials stack properties need to be preserved and are guaranteed by specifications and hence they need to be measured. Interfaces between layers are also very critical. They have to remain without defect, in order to support mechanical and thermal budget treatment during foundry processing, wafer dicing and die packaging. Flatness of the wafer also needs to be under control for standard equipment to handle them. Specific metrologies are developed to guarantee all parameters over full wafer surface (center to edge).
- Manufacturing expertise: Engineered substrates do not behave like standard bulk wafers during processing since materials in the stack are different. They have different crystallography, different thermal expansion, etc… To move engineered substrates into final processing, foundries requires often support by engineered substrate companies to provide them with best practice as well as metrology recipes.

8.2.1 Smart Cut™

8.2.1.1 SIMOX

SIMOX was the first SOI technology produced for thin SOI. Process is based on oxygen ion implant into silicon base wafer (Figure 8-10). After a high temperature anneal, final SOI was achieved. This technology disappeared in late 90's when Smart Cut™ moved to production. This technology was not capable to compete in term of performance, cost and manufacturability.

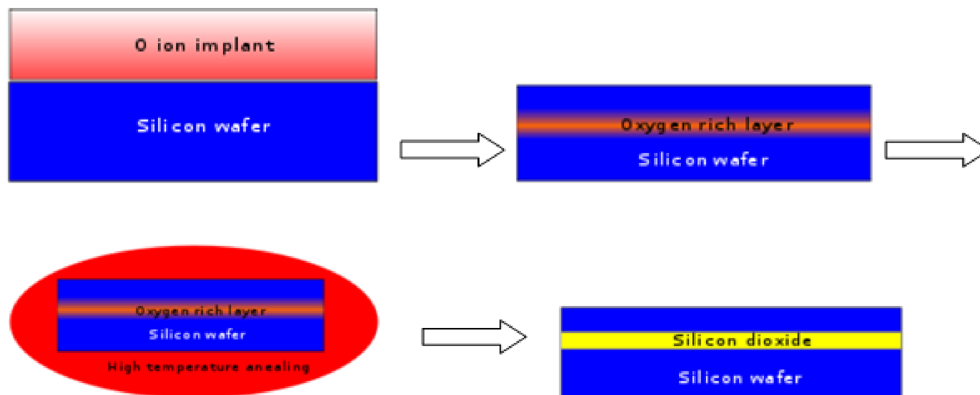


Figure 8-10 SIMOX process steps, RFMD

8.2.1.2 Smart Cut™

Smart Cut™ was invented by Michel Bruel from CEA-LETI laboratory in France. Mr Auberton Hervé and Mr Lamure created Soitec in 1992 as a spin-off from CEA-LETI. This technology is now mainstreams for thin film SOI. This technology is licensed by Soitec to Shin Etsu Handotai (SEH) and Global Wafers. All three companies deliver 99.9% of all thin film SOI.

Smart Cut™ process starts with an oxidation of a wafer (wafer A). This oxide will be the final oxide layer of the SOI wafer. This oxide layer is called buried oxide (BOX). Then hydrogen implantation is done through the BOX and through a well determined silicon layer thickness representative of the final top silicon layer on the SOI wafer. Implanter energy is usually capable to implant through up to 1.5um. Then the implanted wafer is bonded onto a so called handle wafer (wafer B). Then splitting happens when doing a high temperature anneal that grows the hydrogen atom to create a very clean fracture that propagate across the donor wafer. Handle wafer is re-used (Refreshed) multiple times. A final finishing is done before final SOI wafer delivery.

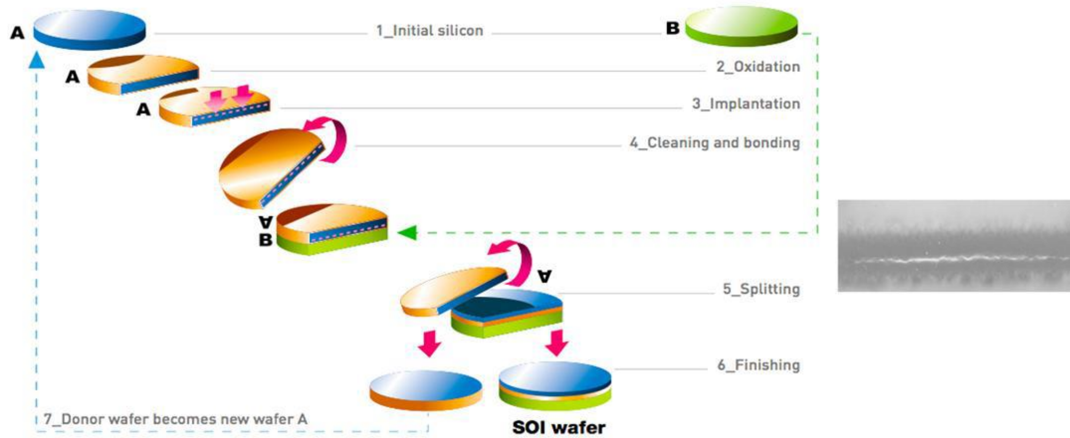


Figure 8-11 Smart CutTM process steps, Soitec

8.2.2 Smart Stacking™

There are cases when Smart Cut™ is not applicable or not preferred technology. Soitec created Smart Stacking™ using the bonding and thinning of two wafers, those wafers being potentially partially or fully processed.

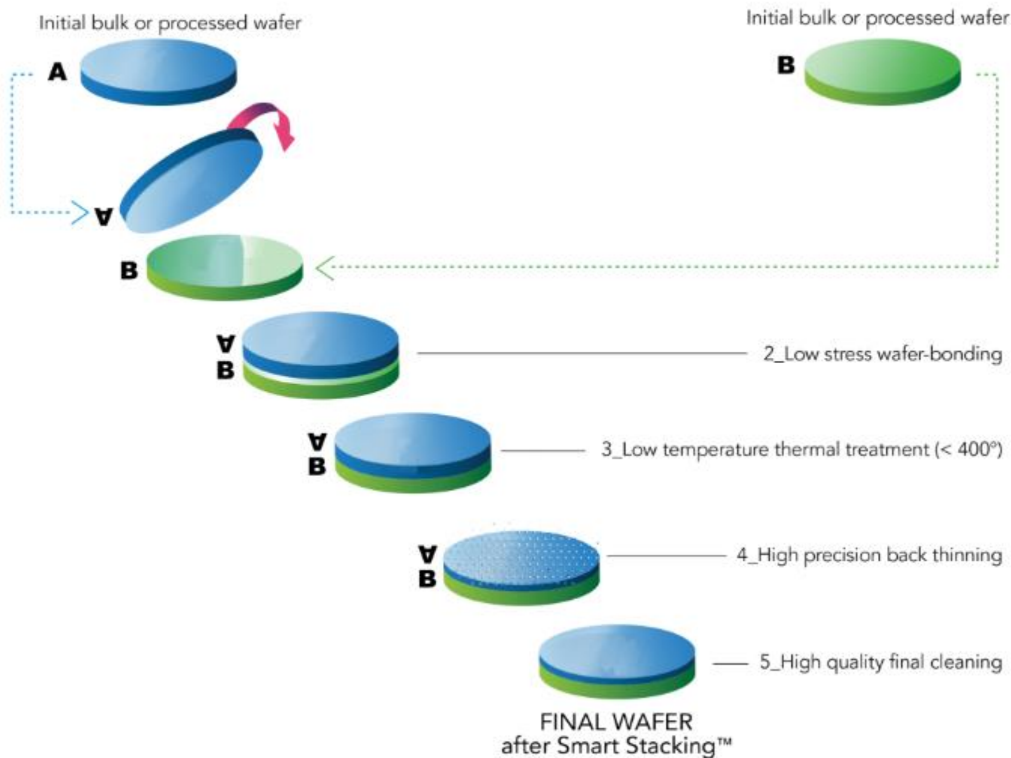


Figure 8-12 Smart StackingTM process steps, Soitec

8.2.2.1 B-SOI (Bonded SOI)

This technique is used for making thick (>2um) silicon layer. This is the simplest case when two silicon wafers are bonded with an oxide. Due to thinning techniques limitations, silicon film thickness and uniformity (Flatness of the silicon film) control is one fold worse than in the case of Smart Cut™. When thick SOI is required with accurate thickness and uniformity, Smart Cut™ wafers are used and then run through silicon epitaxy to increase top silicon thickness.

8.2.2.2 Thin Layer Transfer

When two different materials to be bonded have very different thermal expansion or crystallography properties, there are cases where Smart Cut™ is not applicable as the structure may break during splitting process step. In that case, wafer A will be an SOI wafer and wafer B made from another material than silicon. As an example, Silicon on Sapphire (SOS substrate) wafers produced by Soitec and designed by Peregrine for high end antenna switch was integrated into famous Smartphones (Figure 8-13).

Figure 8-13 Bonded Silicon on Sapphire, Soitec

8.2.2.3 Circuit layer transfer

Circuit layer transfer is a more complex usage of Smart Stacking™ technology. The target is to transfer a fully processed layer onto a base wafer, this base wafer being silicon or non silicon substrate. Processed wafers metallization cannot support in most case the thermal budget required for wafer bonding. In some cases, the base wafer is not compatible with CMOS process either for non compatibility with foundries contamination rules or thermal budget, then circuit layer transfer is also applied. In all those cases, customized bonding techniques are developed. Doing a single layer transfer, transferred circuit will be upside down. When this case is not applicable, a double layer transfer will be done. See below example of a circuit transferred on glass (Figure 8-14). An insulator such as glass is ideal for RF since it is a lossless material. Silicon RF circuit performances will be improved once transferred onto glass.

Figure 8-14 SOI devices transferred onto 200mm fused silica wafer, Soitec

8.2.3 Epitaxy

Epitaxy is a technique to deposit molecules of a material onto a base material. Deposition can be done either by vapor deposition, beam…. Epitaxy in most case is used to stack multiple layers onto a material, this material having crystal properties close to the epitaxial layer. When materials are different, buffer epitaxial layer is required to avoid major defectivity and undesired effects. Epitaxy is a mainstream technique in compound semiconductors. As an example, GaAs transistors are built from a bulk GaAs wafer that has been grown by an Epi vendor before going into the foundry for lithography.

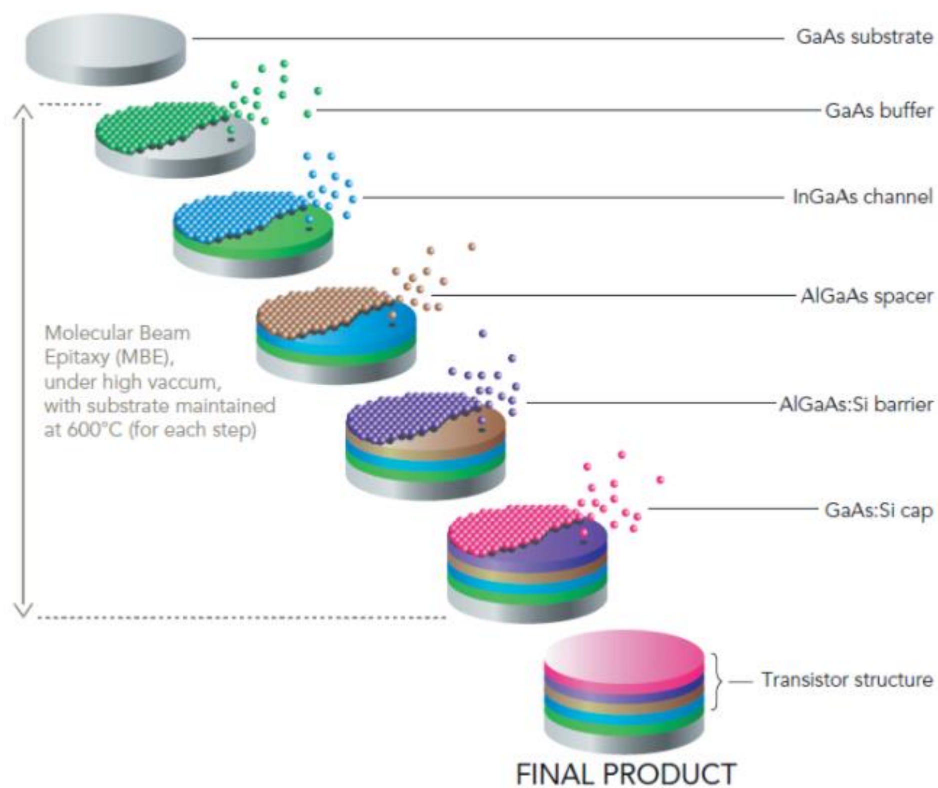


Figure 8-15 Molecular Beam Epitaxy Flow example, Soitec

8.3 CMOS on SOL

As mentioned in introduction, since 40 years, CMOS industry has been using CMOS SOI. The following subchapters develop the different SOI CMOS technologies with focus on RF and mixed signal applications. The Figure 8-16 illustrates the overview of SOI technologies in GlobalFoundries lithography nodes.

	200mm				300mm						
	0.5µm	0.25µm	0.18µm	0.13µm	90nm	65nm	45nm	32nm	22nm	14nm	7nm
Patterning Performance & area	KrF 248nm				ArF 193nm			ArF immersion		2xPatt	3xPatt EUV
Thermal Junct Eng. & Activation					spike		msec anneal				
Etch Device architectures						Stop on silicon Dimension control					
Epitaxy Device architectures						SiGe S/D	SiCP S/D		SiGe channel		
Materials											
Device architectures			PDSOI				Strain	FinFET	FDSOI		
Low resistance	PtSi	CoSi				NiSi					
Gate stack								High K			
Wafer type			SOI	HR/TR SOI							

Figure 8-16 Process and materials overview of GlobalFoundries CMOS SOI technologies, Global Foundries

8.3.1 CMOS on SOI basics

CMOS on SOI have each NMOS and PMOS transistor fully isolated by an oxide wall whereas on bulk, NMOS and PMOS transistor are isolated by reverse PN or NP junctions. As a consequence, as a rule of thumb, stray capacitances on SOI versus bulk are divided by 10 (Figure 8-17 (1)).

The following sub chapters develop the impact for RF and mixed signal circuits. We commonly admit that digital circuits on SOI run over 30% faster than on bulk or consume over 30% less than bulk using same lithography node. We can also consider that CMOS on SOI allows the use of one older lithography generation and get same performance as the newer one. In the 2010's, AMD microprocessors were having same performance as Intel's even Intel was using one generation of CMOS node ahead of AMD.

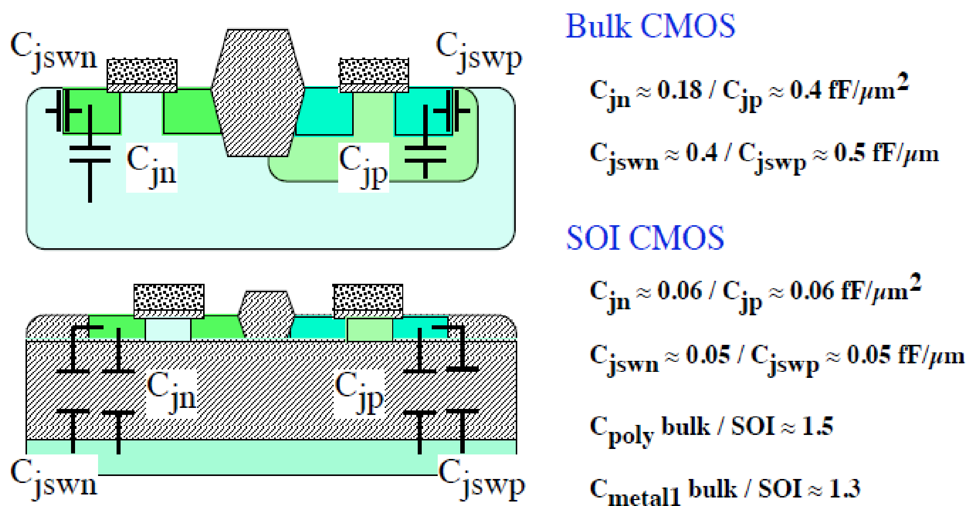


Figure 8-17 (1) Intrinsic MOSFETs parasitic capacitances bulk versus SOI, UCL

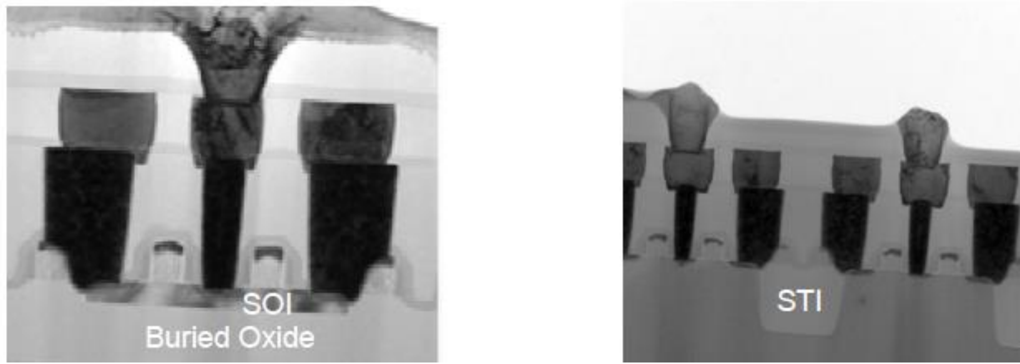


Figure 8-17 (2) Transmission Electron Microscopy (TEM) cross section bulk versus SOI, STM

8.3.2 Basic SOI Advantages

8.3.2.1 Low Power

SOI technology is ideal for Low Power CMOS applications. On top of digital active low power performances mentioned in introduction (over 30% better than bulk CMOS is same conditions), SOI digital circuits also benefit when in inactive mode or sleep mode since there is no leakage current through junction to substrate. Last but not least, CMOS SOI transistor can run at extreme low voltage thanks to its well controlled channel electrostatic and low threshold voltage variation. Library running down to 0.4V are now available.

Below graph represents the power saving in different market segments versus silicon bulk. Improvement is up to 1000% for ultra low power applications. Even further improvement is achieved when applying body back-bias (BB).

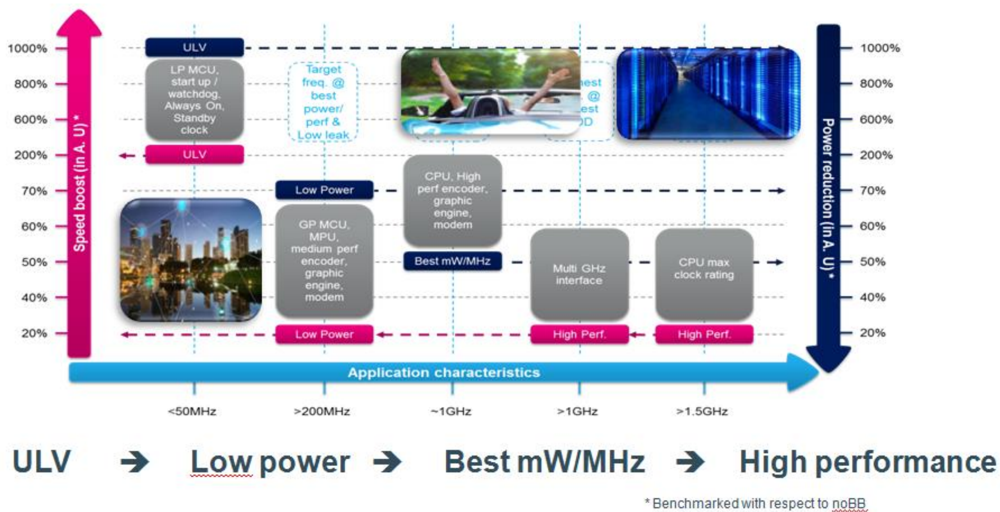


Figure 8-188 Power saving FDSOI versus bulk in different market segments, Soitec

8.3.2.2 Better Isolation - no Latch-Up

1) Isolation: transistors on SOI are isolated by oxide capacitances which are 10 times lower

than junction capacitance on bulk. Default, isolation performance are at least 20dB better on SOI. System integration is an historical trend in microelectronic. Combining sensitive small signal circuits like receivers with high voltage high power circuits such as power amplifier and digital processing will benefit of SOI isolation. Combining very different supply domain on single die is not a concern on SOI whereas it requires specific design rules and extra deep isolation trench on bulk.

2) Latch-Up: For critical analog circuits having high voltage pulse than can create peak voltage below ground, current is injected into the substrate and can enable a latch-up effect. Latch-up happens when a bipolar structure made with NMOS and PMOS wells which is normally OFF gets ON and short-circuits the transistors making the circuit malfunctioning. Latch-up can happen in CMOS System-On-Chip integrating a RF power amplifier if design margin are not sufficient. Latch-up cannot happen on SOI since this well structure does not exist. For application requiring positive and negative voltage, CMOS on SOI is the preferred technology. As shown in figure 8-19, Latch-up will not happen on SOI.

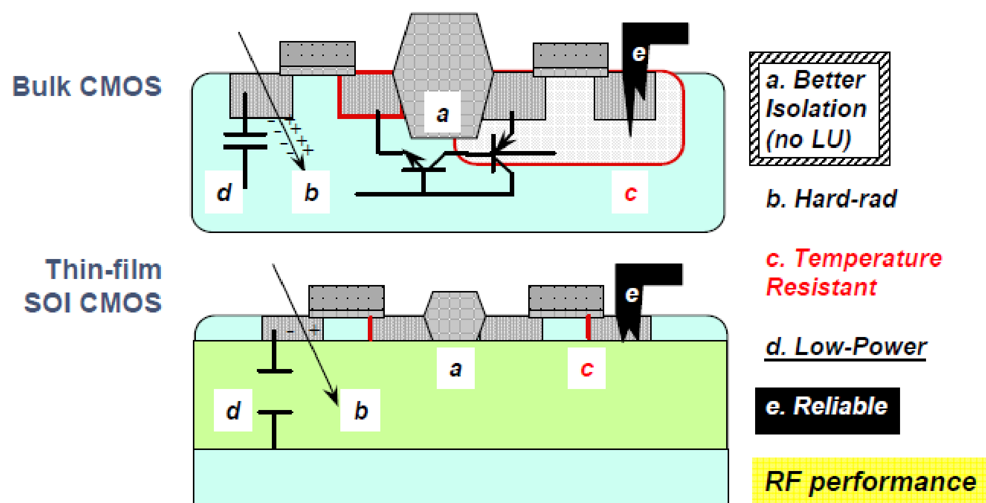


Figure 8-19, Latch-up will not happen on SOI

8.3.2.3 Hard Radiation tolerant

Historically, SOI first application was in space electronics. SOI is by default space particles tolerant since those particles mainly go through the BOX and do not interact with the active layer. Soft error rate in SOI are few fold better than on bulk. Current satellite constellation programs like SpaceX should take advantage of SOI. Beyond space applications, aeronautics and automotive electromagnetic sensitive circuits take advantage of SOI.

8.3.2.4 High temperature operation

Junction leakage current increases exponentially with temperature. It makes bulk circuit not functional and reliable in most case above 125 degree Celsius whereas they are till 250 degree Celsius or more on SOI. It makes SOI the technology of reference for harsh condition electronics like mining, space, aeronautics, automotive….

8.3.3 PD-SOI and FD-SOI – Definition

FD (Fully Depleted) and PD (Partially Depleted) SOI is often a subject of confusion because there are two levels of definition: technical and market definitions. A previous article has been published in 2015 on this topic. The reference link is :

https://soiconsortium.eu/2015/10/28/rf-soi-vs-fd-soi-with-rf-whats-the-differenceTechnical Definition

8.3.3.1 Technical Definition

The drawing below (Figure 8-19) simply shows the difference. The channel in one case is completely depleted (fully depleted) and is not in the partially depleted case. Deep physics understanding and electrostatics equations are required to go beyond this simple definition. To make channel fully depleted, a certain gate voltage over silicon thickness ratio is required. It explains why in most cases fully depleted mode is achieved using a silicon layer thickness much smaller than on partially depleted. Since channel tends to be symmetrical in fully depleted mode, an ultra thin BOX (~ 20nm) can be used as a second transistor gate. It is the so-called back-bias FD-SOI feature. Lithography node does not define if the technology is fully depleted or not.

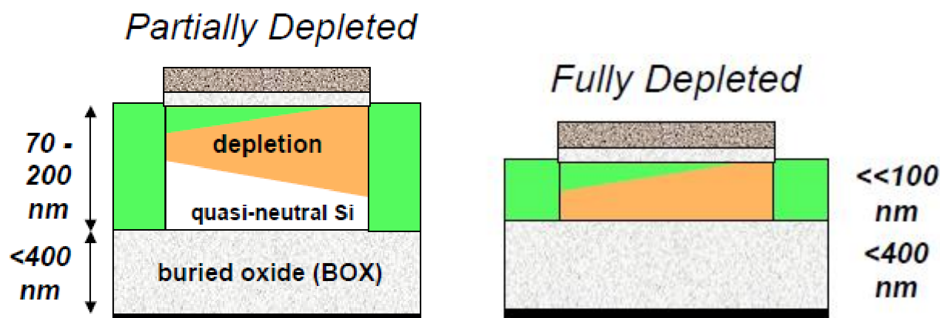


Figure 8-19 Partially versus Fully Depleted SOI technical point of view, UCL

8.3.3.2 Market Definition

RF-SOI targets Front End Module application mainly today. The lithography is typically 130nm in 200mm, moving to 90nm and below on 300mm in coming new RF-SOI generations. In following chapter on RF-SOI, we will see that both partially and fully depleted transistors are used.

PD-SOI target either legacy digital microprocessors and ASICs circuits, either mixed signal millimeter wave circuits both using 45nm kind of lithography.

FD-SOI target System-On-Chip highly digital and mixed signal ICs. As for RF-SOI, digital transistor can also be used either in partially or fully depleted mode. By the way, during the last five years, the roadmaps have all moved to fully depleted, partially depleted being in most cases a legacy process.

To avoid confusion, when talking about PD-SOI or FD-SOI, it is important to make sure what topic is addressed: technical or market.

8.3.4 Floating body and Body contact

In case of PD-SOI, in normal operation, $V_B \sim V_S$ as in bulk CMOS. Body is floating. It is called 'floating body'. When going far in saturation, impact ionization creates holes current in NMOS, making $V_B > V_S$ which makes transistor threshold voltage drop and then increases drain source current. It is called the Kink Effect.

Kink effect by definition happens in digital circuit and boost speed performance. In analog, this non linear effect is often non desirable and designer will design under $V_{DS} < \sim 0.6V$ (Figure 8-20).

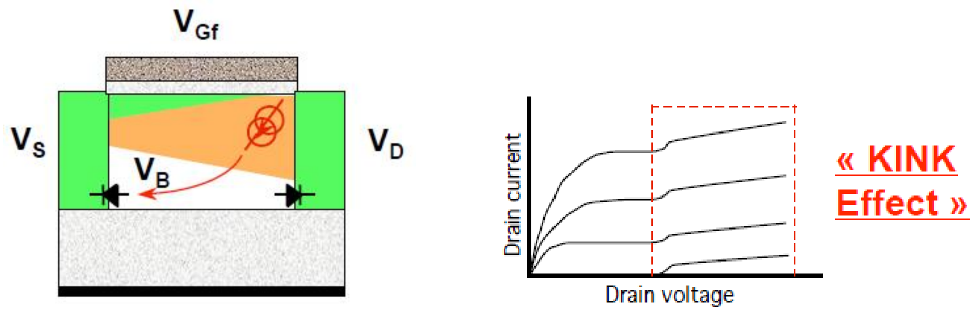


Figure 8-20 Kink effect, UCL

An alternative is to contact the body to keep its voltage constant. It is called 'body contact'. In certain case like on RF-SOI antenna switch, body is put under ground, typically 2.5V, to further reverse the junction capacitance and then reducing their value and non linearity effect. In case of FD-SOI, there is no Kink Effect (Figure 8-21). Body contact can be still used to improve linearity for example in case of RF-SOI antenna switch.

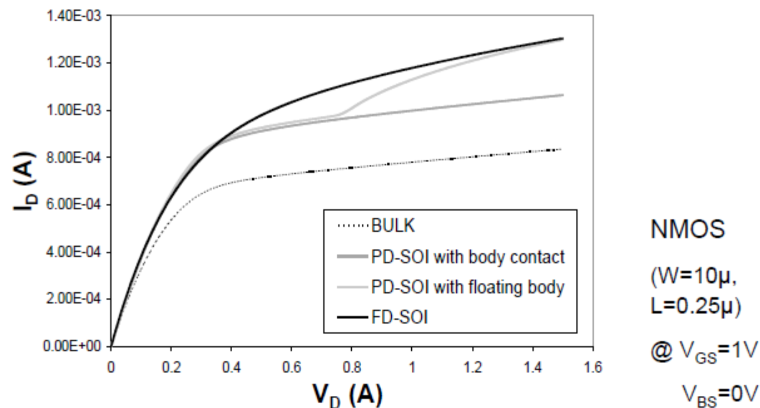


Figure 8-21 Kink effect bulk, PD-SOI and FD-SOI, UCL

8.4 CMOS on SOI for RF

Purpose of this chapter is to review the SOI technologies and value for RF, from 4G Front End Modules to 5G, transceivers and beyond.

8.4.1 RF-SOI

RF-SOI targets Front End Module application building blocks: switch, tuner, power amplifiers, low noise amplifiers, passives. Simple definition of RF-SOI could be silicon CMOS compatible layer on quasi lossless substrate.

Performances can be limited by design, back-end of line process (also named metallization), Front-End of line (also name diffusion) and substrate (Figure 8-22). RF-SOI substrate target is to not be a limiting RF performance factor, ideally be a quasi lossless substrate with a high thermal conductivity enabling lower application cost and smaller footprint.

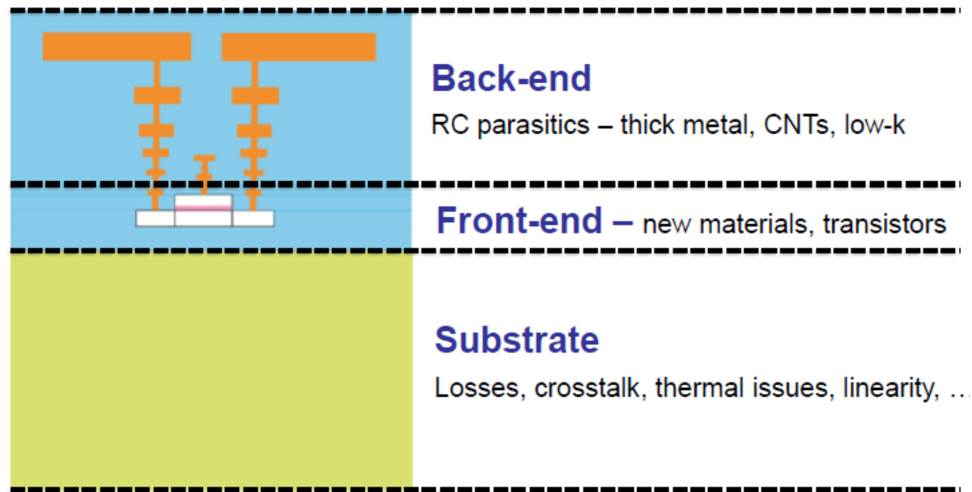


Figure 8-22 RF-SOI process cross section, UCL

RF-SOI has already 25 years of history (Figure 8-23). HR-SOI and Trap Rich RFeSI™ are the key inventions that make this technology mainstream for switch and tuner with 90% market share according to market analyst Navian.

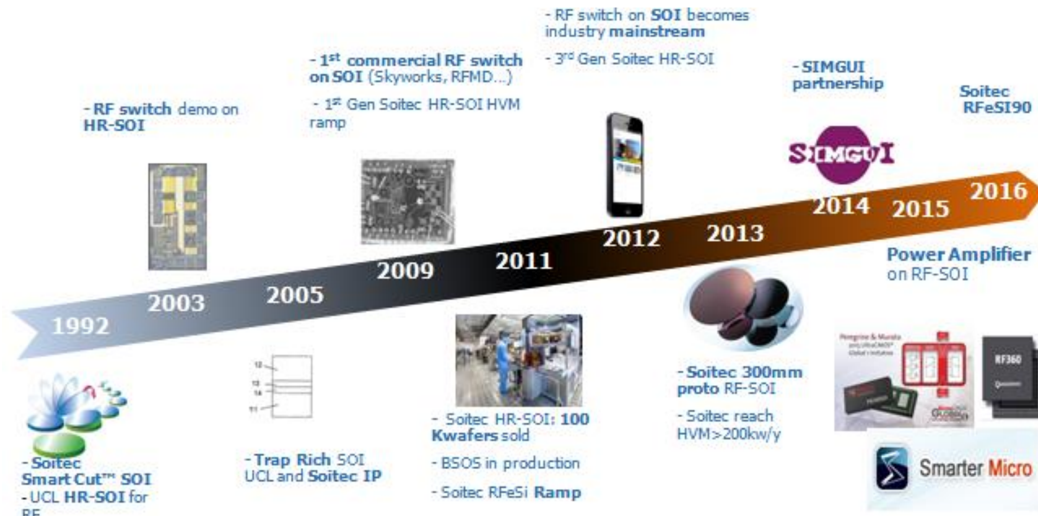


Figure 8-23 History of RF SOI, Soitec

8.4.1.1 HRSOI

HR-SOI (Figure 8-24) is made with Smart Cut™ on high resistive handle substrate (> 1kΩ.cm).

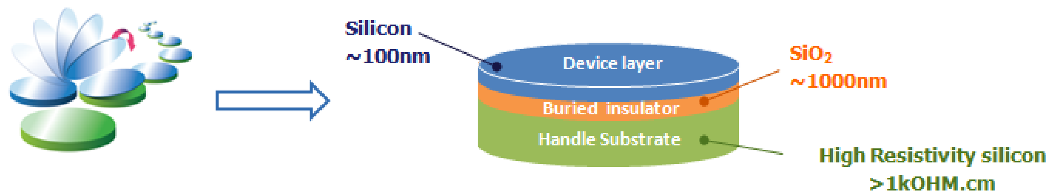


Figure 8-24 HR-SOI process, Soitec

Despite using high handle substrate resistivity before SmartCut™, the HR-SOI effective resistivity under AC signal falls down to around 100Ω.cm. BOX is done with silicon oxide. Although an insulator, this oxide is positively charged. In response to these charges, a 'parasitic surface conduction' (PSC) layer is formed under the BOX. This conductive layer (Figure 8-25) highly degrades the expected RF performances (insertion loss, linearity, isolation) but still remains better than bulk.

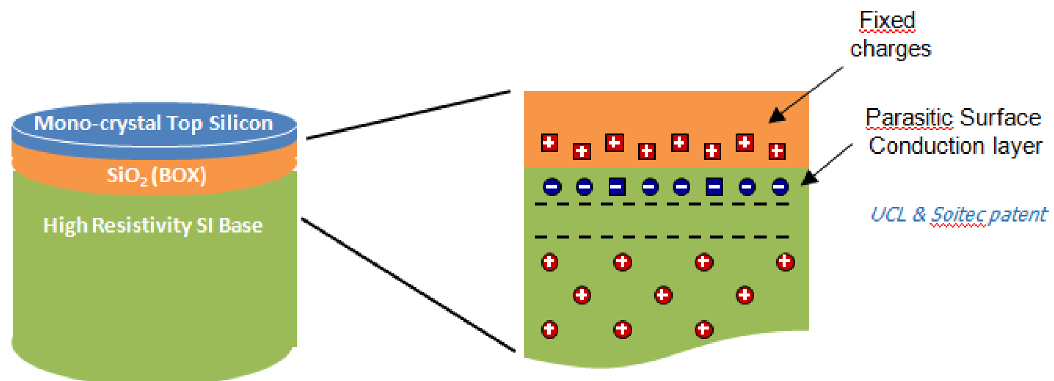


Figure 8-25 Parasitic conductive layer on HR-SOI process, Soitec

8.4.1.2 Trap Rich SOI - RFeSI™

To avoid this parasitic surface conduction, two techniques were invented:

1) HSP (Harmonic Suppression Process) developed by IBM (now Global Foundries) using lithography.

First, the process etches vias through the BOX, then implants heavy ion to damage the silicon surface below the BOX and refills the via with oxide. The damaged silicon area has traps that significantly reduce charge mobility. Beside is also added a contact (poly contact) to bias the region around the heavy ion implant to further reduce the parasitic surface conduction effect. This technique cannot be used under transistors. Transistor process needs to be done before since a high temperature process would cure the damage done by the implant. This technology requires a thick BOX (>1um).

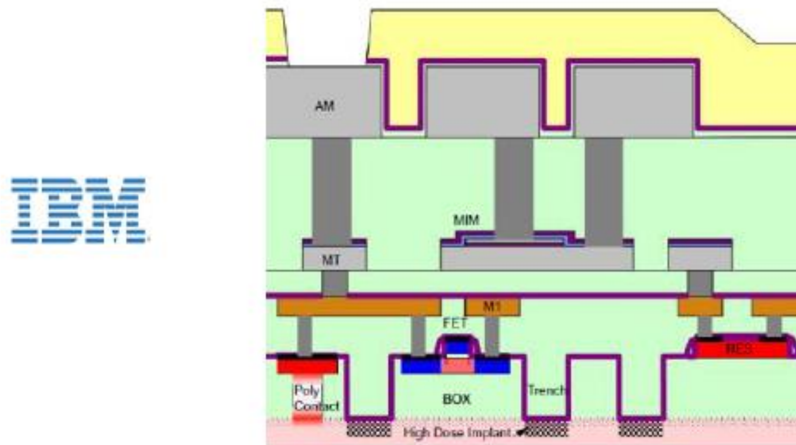


Figure 8-26 Cross section of HSP process, IBM (now Global Foundries)

2) Trap Rich layer developed by Soitec and UCL.

This layer is done before the Smart Cut™ bonding process. The trap rich layer is spread across the entire wafer whereas it is only under passives with HSP techniques. Charge mobility under the BOX is highly reduced by this high density traps layer. BOX as thin as 200nm can be used without impacting performances. It enables easier wafer process at both engineering substrate and foundry side, improving throughput, yield and cost of the manufactured devices. Soitec branded this technology RFeSI™ (RF enhanced Signal Integrity).

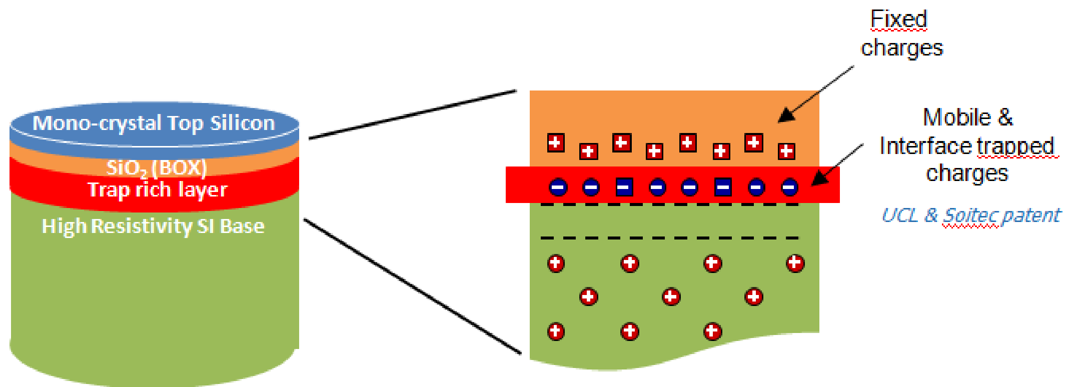


Figure 8-27 Parasitic conductive layer on HR-SOI process, Soitec

Both technologies moved initially in volume production. Most foundries latest generation processes are now using RFeSI™.

RFeSI™ improves all critical parameters required for RF Front End Module devices. Effective resistivity of the last generation RFeSI™ is above 8kΩ.cm and measured performances are getting close to an insulator such as quartz. Further improvements are still expected on linearity and insertion loss in order to meet the most stringent cases supporting dual transmission either for carrier aggregation or dual 4G and 5G connectivity cases. Although performance limitation may mainly comes from transistors.

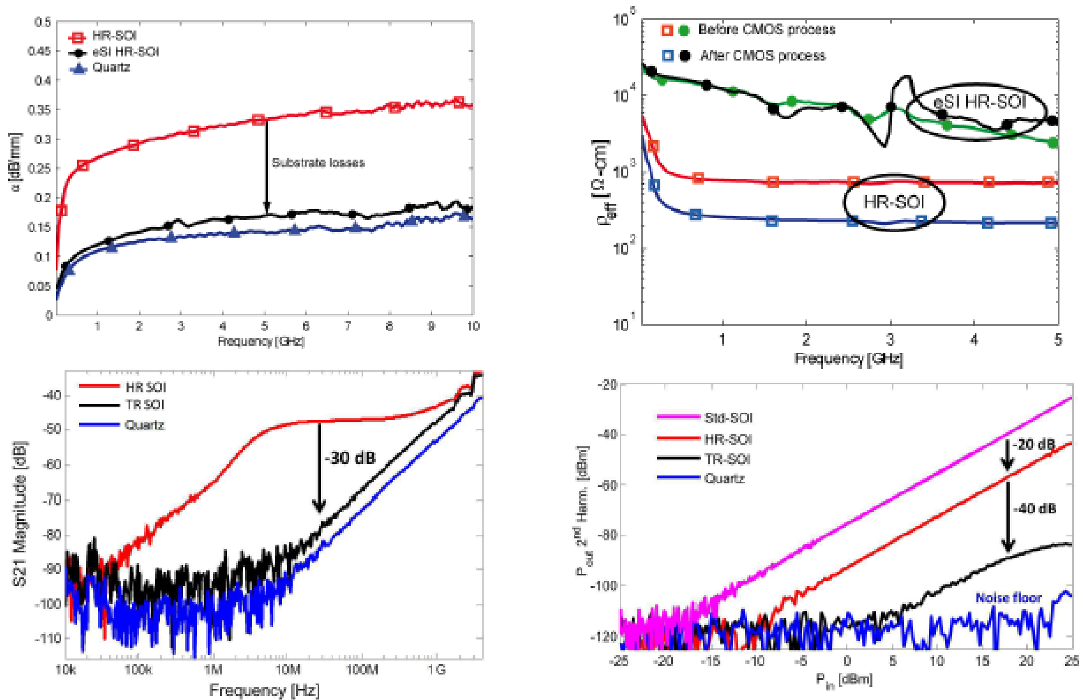


Figure 8-28 Electrical characteristics on HR-SOI, Trap Rich SOI and Quartz substrates, UCL

In term of RF-SOI roadmap, the trend is to move to fully depleted to improve switch Ron*Coff

figure of merit. Fully depleted transistors have less stray capacitance thanks to thinner film. Ron*Coff has been reduced from over 350fs to around 100fs and more reduction are expected while keeping breakdown voltage constant.

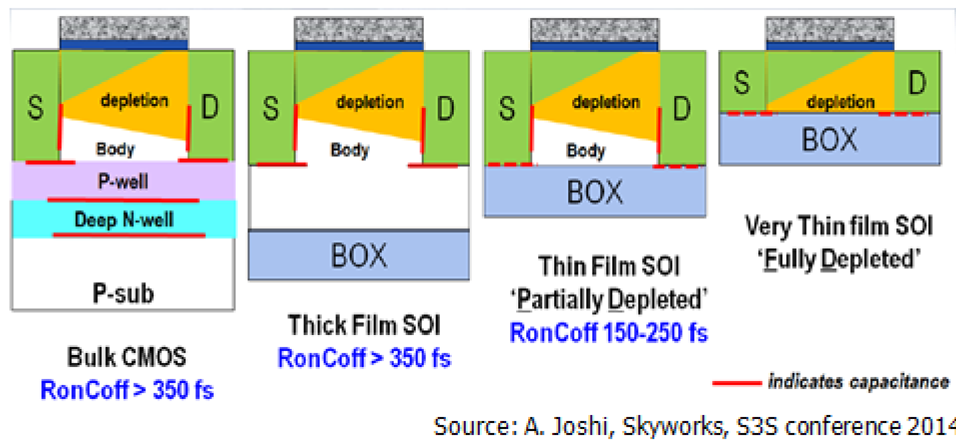


Figure 8-29 Ron*Coff trend versus substrate type, Skyworks

8.4.1.3 RF-SOI for Switch, Tuner, LNA, PA

1) RF-SOI for Switch and Tuner

From an RF-SOI substrate perspective, 90% of switch and tuners are built on RF-SOI as illustrated on Figure 8-30.

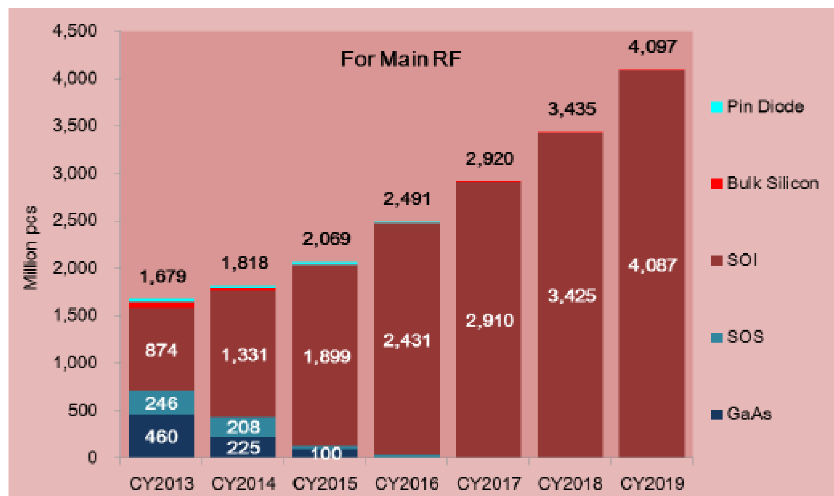


Figure 8-30 Main RF Front-End modules market, Navian Report 2016

RF-SOI has all key merits to remain the mainstream technology for switch. It is by far the best tradeoff between performance (meet LTE A PRO specifications), price (Bulk only is cheaper), area (more and more analog integration (LNA, Tuner, passives …) with digital (MIPI bus, control logic …)). MEMs have been perceived for years as a potential player for high end devices. Due to its high cost, low reliability, it remains a challenger.

2) RF-SOI for LNA

For most advanced carrier aggregation case and MIMO, LNA is becoming a key function. RF-SOI presents three key advantages.

- Inductor high quality factor (see next on PA)
- Access to 300mm and lithography equal or below 90nm
- Integration with switch

Most recent data show that LNAs on RF-SOI are equivalent to SiGe which cannot compete in integration as it enables poor switch performance.

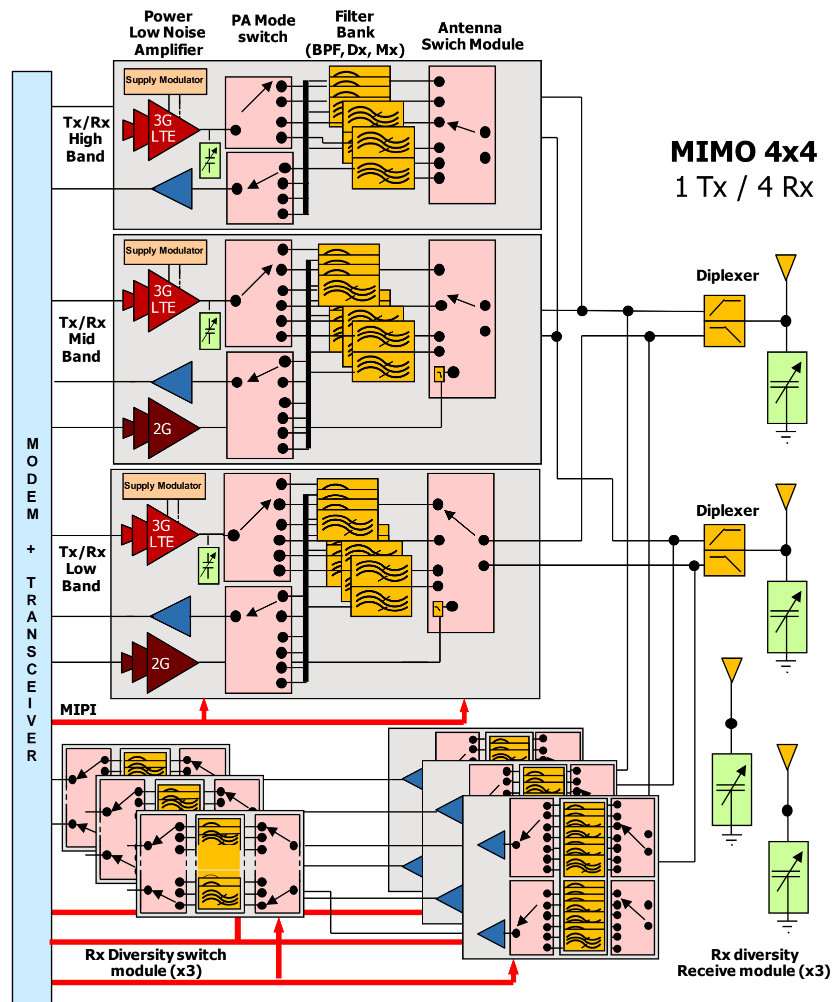


Figure 8-31 LNA + SWITCH in advanced FEM architectures, Soitec

Power Amplifier remains the last devices in the RF Front End Module to broadly adopt RF-SOI.

3) RF-SOI for PA

Power Amplifiers on RF-SOI have major advantages versus bulk:

- Inductors quality factor improvement on RFeSI™

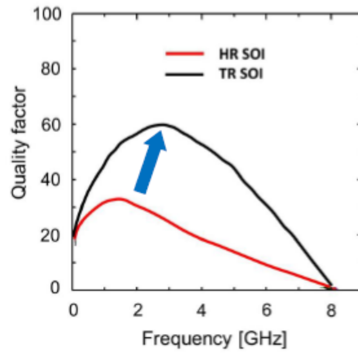


Figure 8-32 Inductor quality factor HR-SOI versus Trap Rich SOI, UCL

- Transistor stacking enabling voltage handling beyond single transistor breakdown voltage

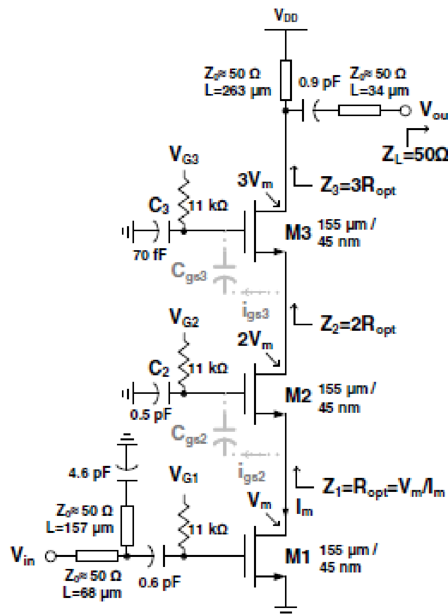


Figure 8-33 Stacked MOSFET Power Amplifier, UCSD

- Specific extended drain devices developed by foundries with high BV * Fmax product

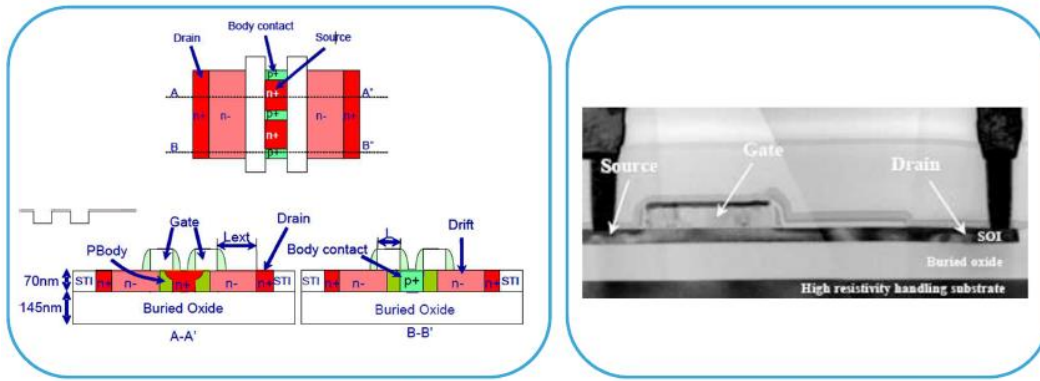


Figure 8-34 RF power NLDMOS on SOI, STM

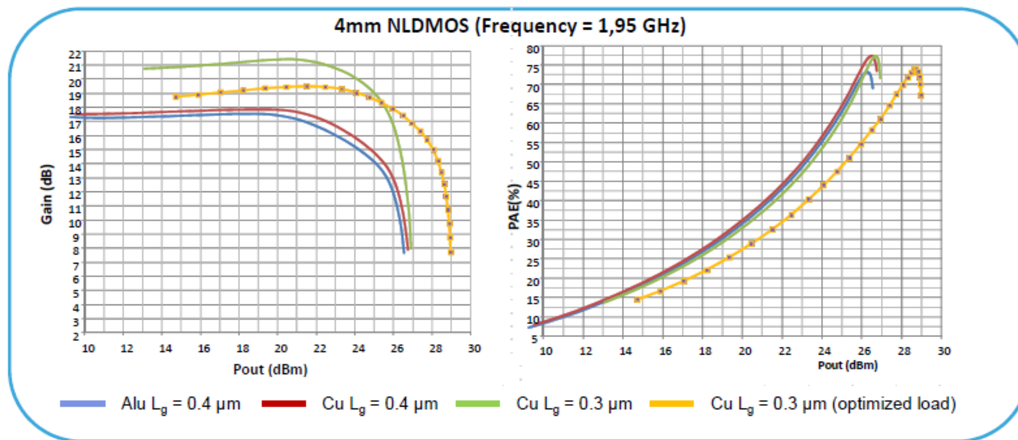


Figure 8-35 Electrical characteristics on SOI, STM

RF-SOI AP is adapted and its embedded digital CMOS can be used for tuning at specific band. Owing to the power density and mobility, the PAE performance of GaAs is so well has to the main material used for 4G components. While RF-SOI is mainly used towards middle and low-end smartphone market. In order to expanding the application of RF-SOI for PA, the foundries and fabless semiconductor companies take great efforts in developing RF-SOI.

As shown in follow figure, RF-SOI is a unique platform which can be fully integrated, and it is a alternative choice when needed.

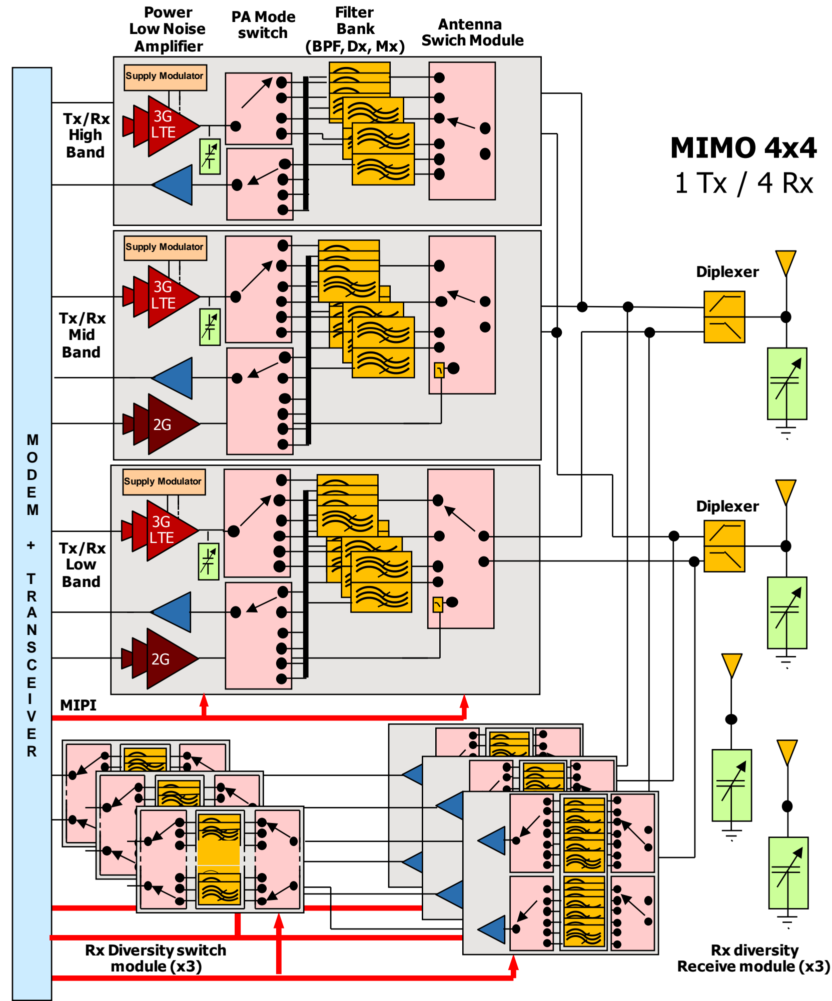


Figure 8-36, Soitec

8.4.1.4 RF-SOI eco-system

A technology needs a strong eco-system to become mainstream. All leading foundries have strong roadmaps to further develop RF-SOI, in both 200mm and 300mm. According to Soitec estimates, worldwide RF-SOI production in 2017 was 1.3 million wafers 200mm equivalent moving to 2 millions in 2020.

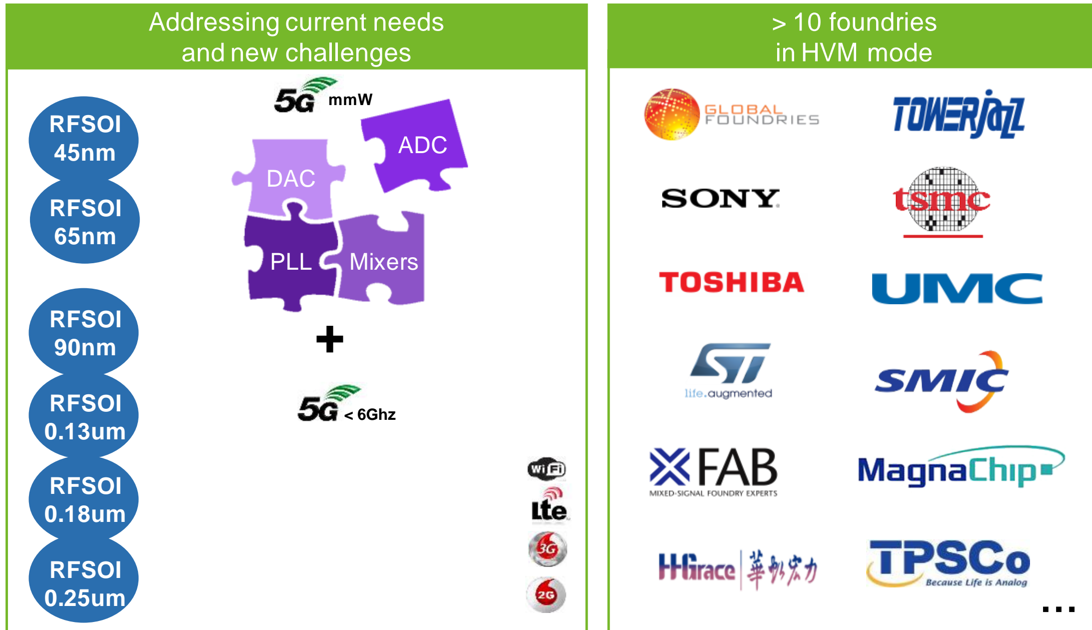
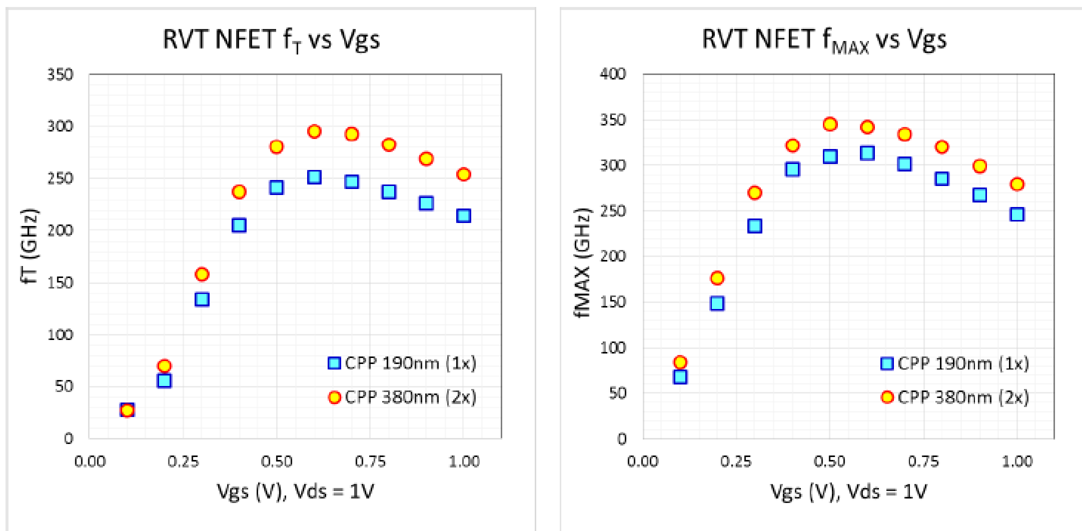


Figure 8-37 RF-SOI industry ecosystem, Soitec

8.4.2 PD-SOI for RF

When talking about PD-SOI for RF, target market is mainly related to microwave to mm wave circuits. As mentioned in the introduction, SOI was mainly used for digital applications like AMD microprocessor, game console, ASICs till around 2010. Those applications did follow Moore's low down to 45nm. IBM now Global Foundries has developed a complete new RF back end and analog options to adress mmW applications like Low Earth Orbite transceivers, 5G, Automotive radar, etc... A specific SOI substrate was designed re-using same options used in RF-SOI: high resistivity substrate and trap rich layer.

This technology offers un-matched performance with NMOS Ft/Fmax > 300GHz and PMOS Ft/Fmax > 250GHz (Figure 8-38).



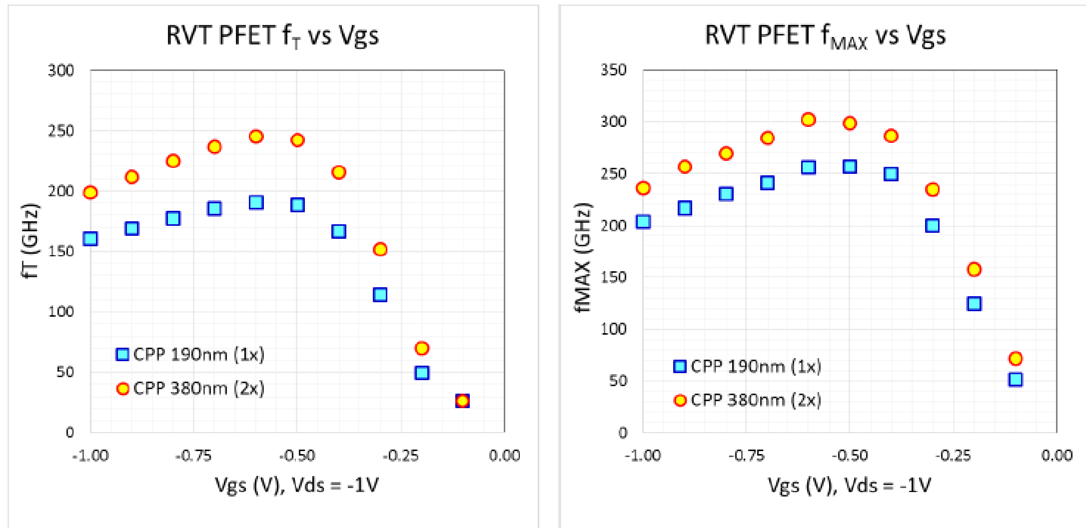


Figure 8-38 Ft/Fmax electrical characteristics on PD-SOI technology, Global Foundries

This technology has been available during around 5 years. University and academics have largely published on all building blocks required for mmW radio: ADC, DAC, mixers, VCO, PLL, phase shifters, couplers, LNA, PA.

This technology is ideal for mmW full radio implementation, particularly when using a heterodyne architecture (Figure 8-39). For mmW, it is important to have the antenna and the mmW radio devices as close as possible to avoid any path and package losses. There is no alternative technology today that can enable monolithic integration down to the antenna.

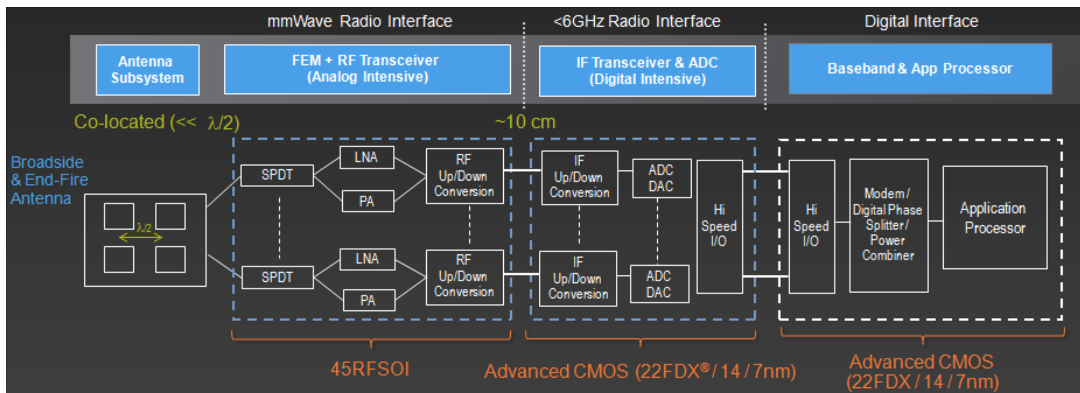


Figure 8-39 45nm RF-SOI for 5G mmW Front-End Module, Global Foundries

Skyworks demonstrates 45nm RF-SOI capability for mmW radio devices as illustrated on Figure 8-40 below.

	ISSCC '16	ISSCC '15	ISSCC '14	JSSC '13	SiRF '14	SWKS '17
Technology	28 nm CMOS	28 nm FD-SOI	40 nm CMOS	40 nm CMOS	120 nm SiGe	45 nm SOI
Frequency	28	60	60	60	28	28
Supply (V)	1	1	2x 0.9	1	3.6	4.8
# of Stages/PAs	2/1	3/4	3/2	3/2	1/1	1/1
Gain (dB)	15.7	15.4	22.4	17	15.3	**21**
P_{sat} (dBm)	14	18.8	16.4	17	15.3	**21.5**
P_{1dB} (dBm)	13.2	18.2	13.9	13.8	15.5	**19.5**
PAE_{max} (%)	35.5	21	23	30.3	35.3	32
PAE_{1dB} (%)	34.3	21	18.9	21.6	31.5	26
$PAE_{psat\ -9.6\ dB}$	10	7	5	6.5	10.5	9

Figure 8-40 45nm RF-SOI mmW Power Amplifier design (not optimized design, trade off linearity / PAE), Skyworks

PD-SOI eco-system is not yet as developed as RF-SOI. ST Microelectronics has a PD-SOI offering for mmW devices using 65nm lithography as well.

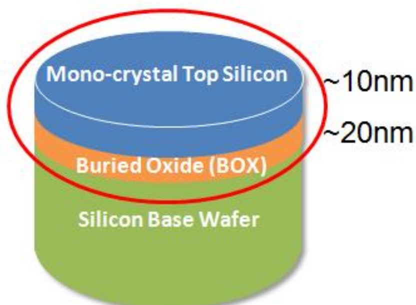
8.4.3 FD-SOI

8.4.3.1 FD-SOI wafer capability

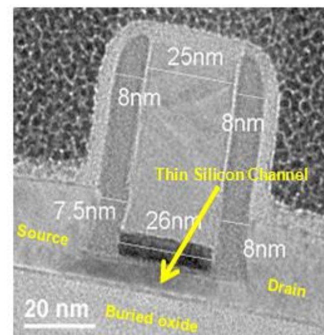
For 28nm lithography and beyond, the FD-SOI technology that has been developed is called UTBB, standing for Ultra Thin Body and Box. Body stand for the silicon layer typically around 10nm. Box is around 20nm.

UTBB-FDSOI

- FDSOI = Fully Depleted SOI.
- UTBB = Ultra Thin Body & BOX



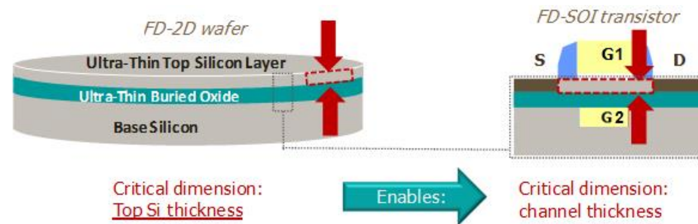
At **28nm** node and beyond



Source: STM, 2012

Figure 8-41 UTBB-FD-SOI technology, Soitec and STM

In fully depleted mode, transistor threshold voltage is dependent of the silicon layer thickness. During many years, the eco-system didn't engage into this technology fearing that meeting silicon uniformity specification would not be feasible as Moore's Law continues. Volume production having uniformity capability of +/-5Å wafer to wafer has been realized, all wafer (Figure 8-42). This uniformity is equivalent to few atoms of silicon. Research laboratory CEA-LETI did demonstrate FD-SOI transistors at 7nm lithography.



Silicon thickness uniformity is guaranteed to within just a few atomic layers:

Top Si uniformity = +/-5 Å at all points on all wafers, equivalent to **+/- 1.5cm over Paris-Chengdu**

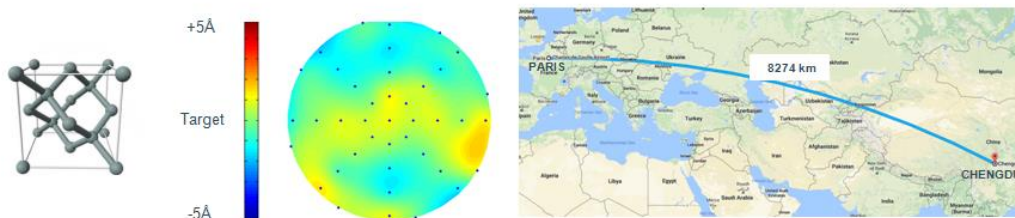
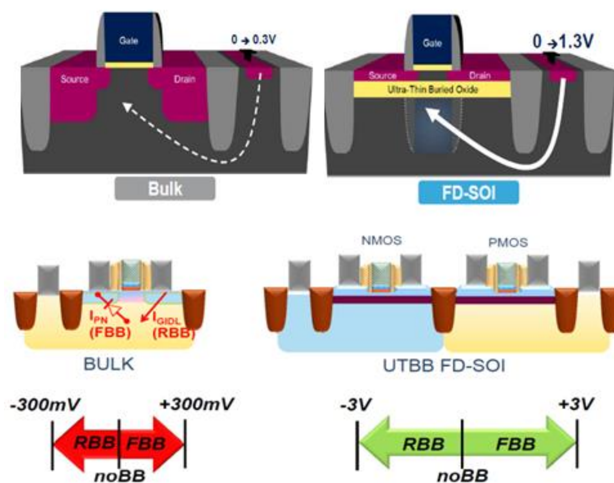


Figure 8-42 FD-SOI Silicon thickness uniformity, Soitec

8.4.3.2 Back-Bias

FD-SOI UTBB wafers are designed with ultra thin Box to enable back-bias. Box is used as a second transistor gate. It enables Vt modulation. Such a technique is also use in Bulk CMOS but Vt tuning capability is 10 times lower (Figure 8-43).



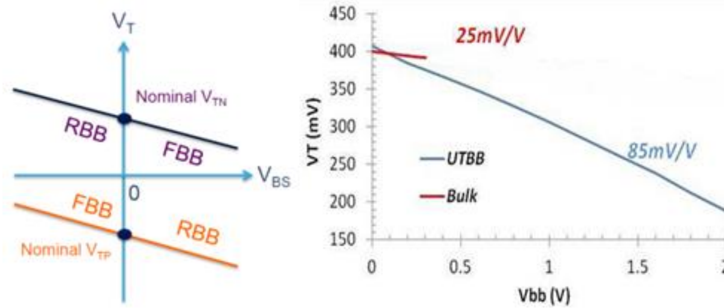


Figure 8-43 Forward and reverse back-bias in FD-SOI

In digital applications, transistor can be put in ultra low leakage current mode when idle or in high performance mode when maximum operating frequency is required (Figure 8-44).

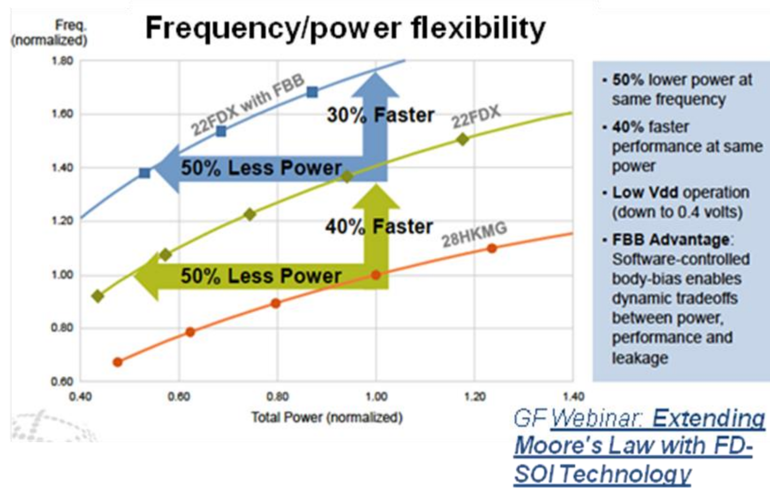


Figure 8-44 Frequency/power flexibility 22nm FD-SOI, Global Foundries

Back-bias is also used to compensate process variation improving circuit yield, performance spread, minimum operating voltage, etc..., as presented below.

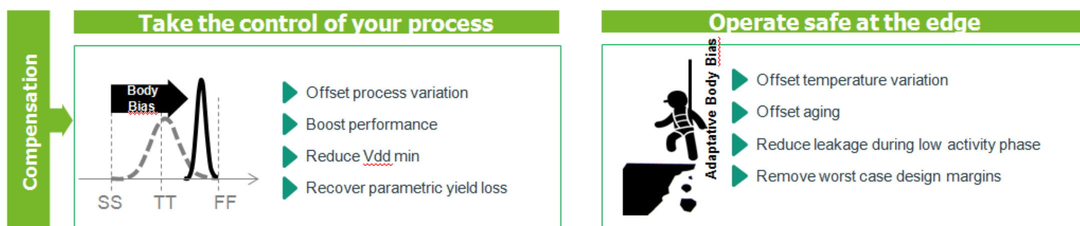


Figure 8-45 Design compensation with FD-SOI, Soitec

As an example, see trimming results on a 60mm^2 28nm processor circuit today in volume production.

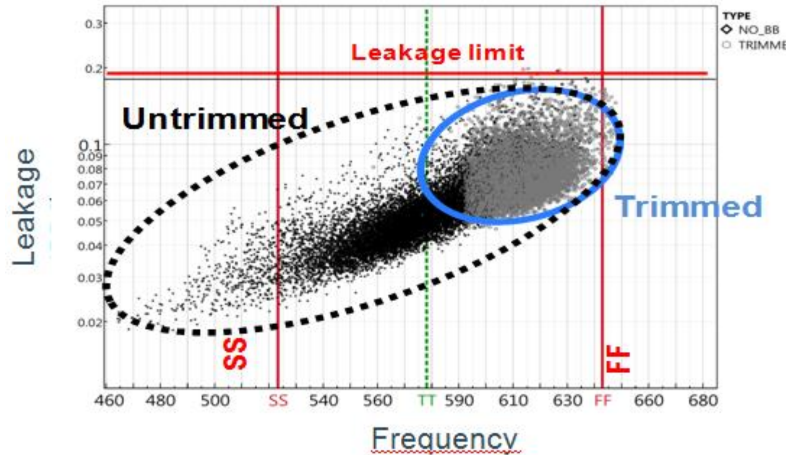


Figure 8-46 Trend Leakage/Operating frequency with FD-SOI, Soitec

In analog, back-bias technique opens the door to new circuit topology since two gates with two different transconductances are available.

8.4.3.3 FD-SOI for analog

As mentioned in the previous chapter, we can take advantages of FD-SOI material with back-bias control. Meanwhile, FD-SOI can be used and valuable compared to bulk only with native devices (no back bias technique). The active device benefits for analog applications are the following:

- Mismatch reduction due to undoped channel and no halo implants compared to bulk (>30%)

AΔvtsat (mV-µm)			
	40LP	22fdx	Diff
N	4.45	1.65	-63%
P	2.89	1.61	-44%

σ(Δvtsat) (mV)			
	40LP	22fdx	Diff
N	42	23.6	-44%
P	28	23.1	-18%

AΔidsat (%-µm)			
	40LP	22fdx	Diff
N	0.94	0.47	-50%
P	0.77	0.49	-36%

σ(Δidsat)/idsat (%)			
	40LP	22fdx	Diff
N	9.2	6.16	-33%
P	7.5	6.87	-8%

Figure 8-47 Vth and Idsat mismatch 22nm FD-SOI versus bulk, GlobalFoundries

- Higher intrinsic voltage gain than bulk gm/gds (Figure 8-48)
- Higher gm/Ids (Figure 8-48)
- Lower gds (as much as 1.8X on bias) than bulk
- Lower parasitic capacitance

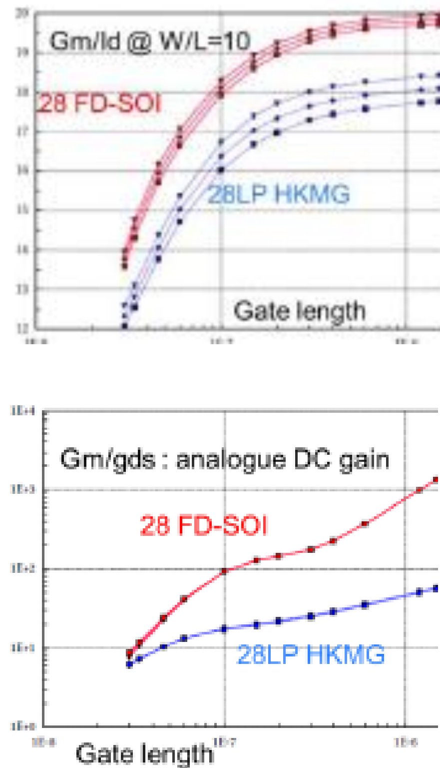


Figure 8-48 MOSFET DC gain FD-SOI versus bulk, STM

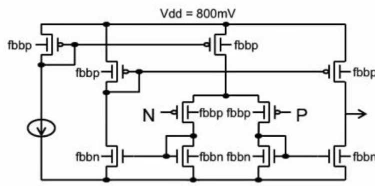
Meanwhile, the use of back bias technic allows PPA (Performance Power Area) advantages:

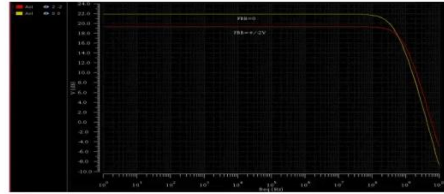
- FBB (Forward Back Gate bias)
    - Lower vth, increase gm
    - Increase performances for a given area
    - Reduce area
- rBB (Reverse Back Gate bias) less commonly used
    - Useful for low speed and low power designs to reduce leakage, bias currents and standby currents

Issues for back bias to address analog design are illustrated with Figure 8-49 and Figure 8-50.

Moreover back bias techniques should allow performances trimming: Gain, Bandwidth, Delay …

22FDX® FBB Analog Methodology
Back Gate driven by Back Bias Generator
Example: OTA Bandwidth & Phase Margin improvement





- General trend is Bandwidth improves as forward back gate bias increases
- Device sizes may be reduced if circuit is optimized to function with a predetermined back gate voltage

	*fbbn=0 *fbbp=+0.8V	fbbn=0 fbbp=0	fbbn=0.4V fbbp=-0.4V	fbbn=0.8V fbbp=-0.8V	fbbn=1.2V fbbp=-1.2V	fbbn=2.0V fbbp=-2.0V
BW	273MHz	447MHz	500MHz	546MHz	596MHz	802MHz
Gain	23.3dB	21.9dB	21.8dB	21.7dB	21.4dB	19.4dB
Phase Margin	45 deg	~no change				

MORE FBB →

*Conventional-style Well connections

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Figure 8-49 Amplifier bandwidth improvement in 22nm FD-SOI, Global Foundries

Application Categories

Device Parameters	Circuit Benefits	Example Circuits in Typical Analog SoC
IDSat/Ion/Ioff	Dynamically adjusting logic time delay, rise/fall time, clock speed, area Dynamically power vs. performance tradeoff	Digital logic and signal processing Clock and LO buffer Ring Oscillator Time-to-digital converter (TDC) Delay line Inverter based –gm for VCO and DCO
RON/ROFF	Switch with low ON resistance and high OFF resistance ratio	Programmable capacitor such as C-DAC Programmable DCO capacitor array Programmable resistor such as R-String-DAC and R2R-DAC Switched-capacitor sampling network for ADC Switched-capacitor filter Switched-capacitor charge-pump generator Passive mixer Chopper stabilization circuit Switches and analog muxes RF Front-end Switch
DC operating point adjustment	Optimizing headroom Common-Mode	Linear regulator Amplifier Comparator Current mirror/source/sink
GM/GM-C	Calibration and tuning	Inverter-based gm/C filter Inverter-based gm/C sigma-delta modulator
Mismatch	Offset correction	Comparator and amplifier Mixer and amplifier HD2

Figure 8-50 Analog circuits benefits with back bias in FD-SOI, Global Foundries

For lithography below 22nm, the CMOS roadmap has moved to FinFET. FinFET is a 3D CMOS structure using thin (Figure 8-51). Gate is around a fin, allowing better electrostatic control whereas it wasn’t possible anymore on planar CMOS.

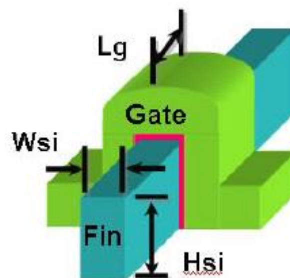


Figure 8-51 FinFET architecture

When comparing FD-SOI UTBB against FinFET without strain, the transistor gain remains larger, even more when going to narrow channel. Due to lithography constraint, the fin height and width are fixed which means that designers are losing significant flexibility for design.

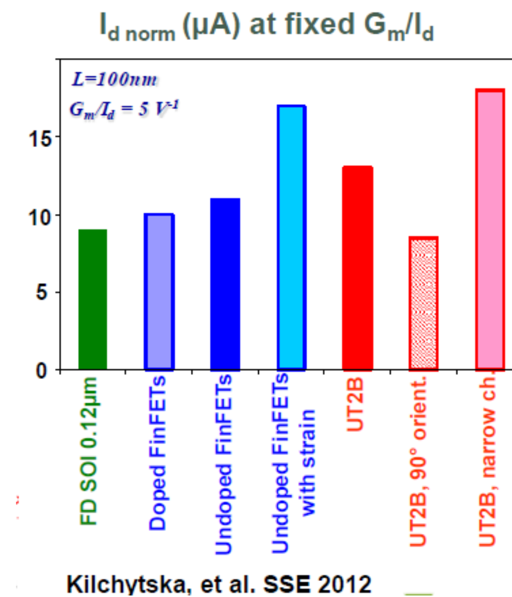


Figure 8-52 Gain MOSFET transistor FD-SOI versus FinFET, SSE 2012

More important, FinFET process is significantly more complex and expensive than SOI CMOS and also requires more design resources.

8.4.3.4 FD-SOI for System-On-Chip Wireless IC

Based on performance and cost data presented, FD-SOI is the ideal platform for highly integrated mixed signal system like transceivers integrated with Modem and MCU.

As an example, Sony has launched on the market a fully integrated GPS circuit (receiver + demodulator + signal processing) claiming that it consumes 5 times less current than the competition. This circuit is used in Xiaomi SmartWatch and other Tier #1 brand wearable.

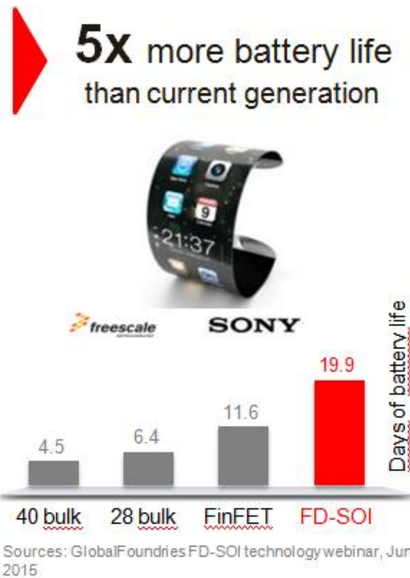


Figure 8-54 Sony GPS circuit in FD-SOI, Global Foundries

8.4.3.5 FD-SOI for mmW

FD-SOI is the logical roadmap following planar CMOS bulk for mmW. FinFET cannot be effectively used for mmW due to its 3D structure and then large stray capacitance. Ft/Fmax of FinFet is around half of FD-SOI at same node.

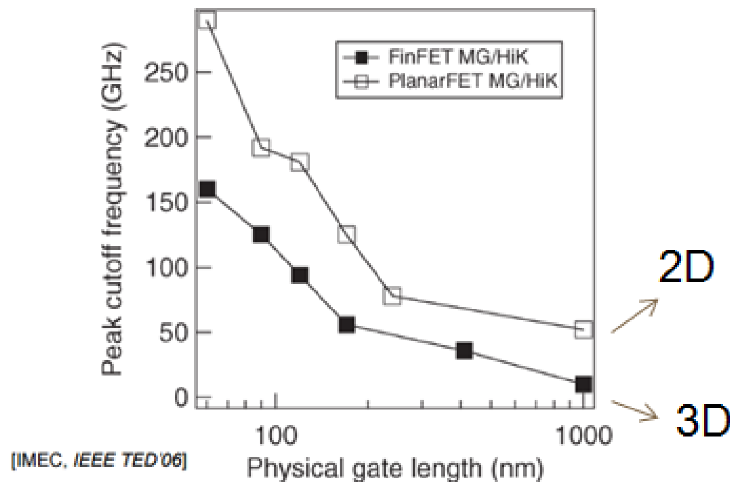


Figure 8-55 MOSFET Cutoff frequency FinFET versus planarFET

Whereas FD-SOI is primary targetting advanced digital signal processing with transceivers, it keeps intrinsic capabilities of SOI for power amplifiers and switch with reduced output power capability compared to PD-SOI 45nm (< 20dBm). In case of complex phase array where single power amplifier output power remains below 20dBm, FD-SOI allows a full 5G system integration from antenna to digital baseband and application processor using direct conversion architecture (Figure 8-56).

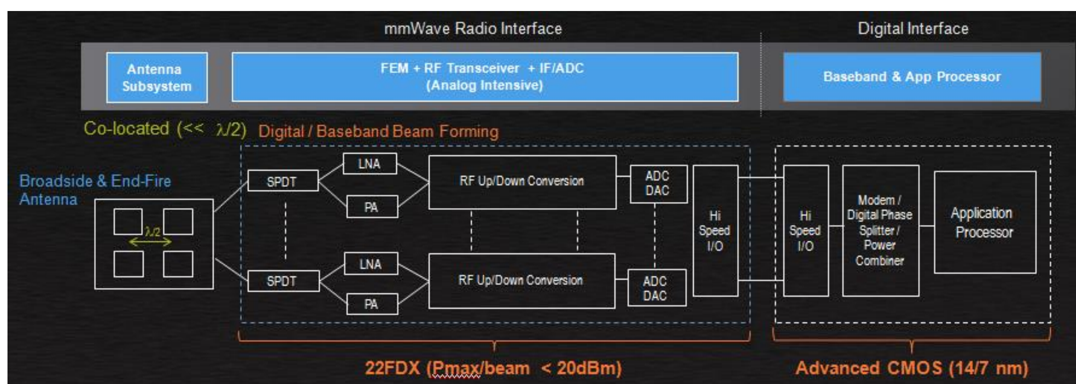


Figure 8-56 FD-SOI for 5G mmW Front-End Module, Global Foundries

Using back-bias, some novel architecture can be designed. As an example, the use of back-bias allows to revisit classical PA architecture (Figure 8-57). The contribution of wide range FBB bias drives to have a gradually change the overall class of Power Amplifier. In the same time, efficiency and linearity was optimized.

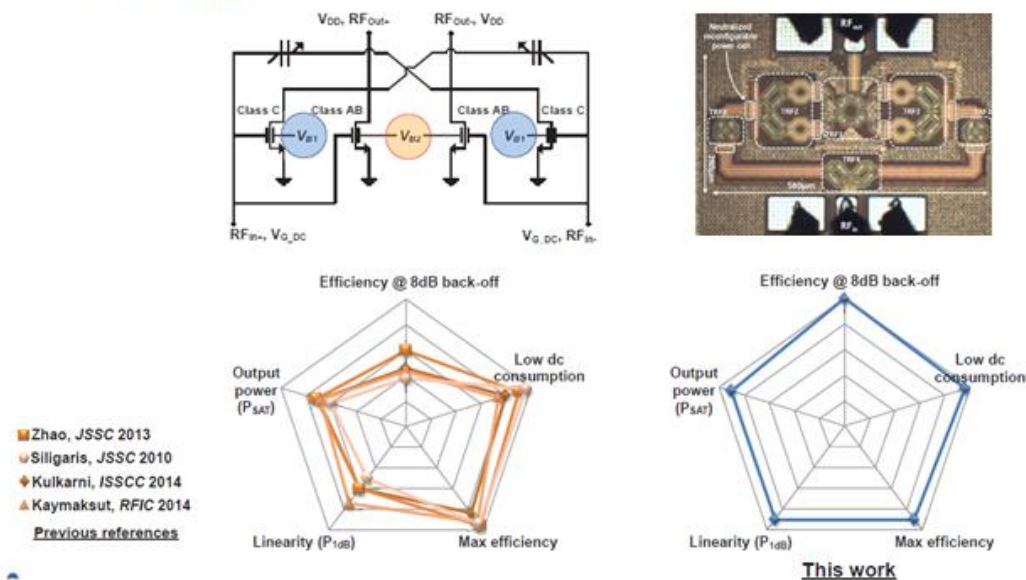


Figure 8-57 mmW Power Amplifier using back bias in FD-SOI

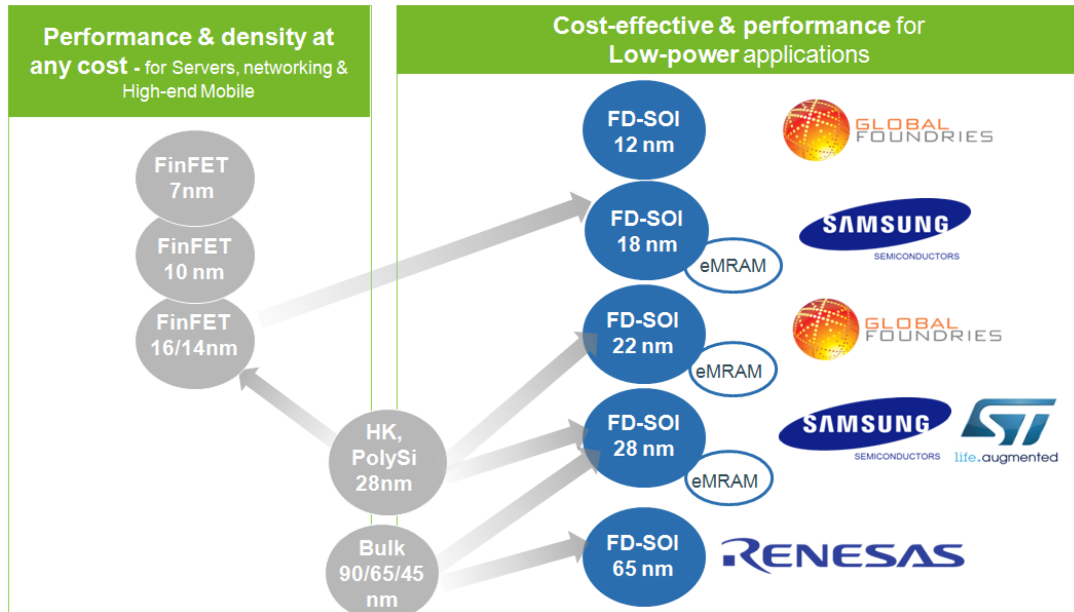
As of today, FD-SOI has no high resistive bulk options.

8.4.3.6 FD-SOI eco-system

A technology needs a strong eco-system to become mainstream. In early 2010s, ST Microelectronics and ST-Ericsson were the first to develop and ship cellular microprocessors on FD-SOI at 28nm. On dual cortex A9 running at 1.85GHz, they demonstrated FD-SOI 28nm was outperforming versus 28nm Bulk (Figure 8-).

Figure 8-58 cellular microprocessors power saving FD-SOI versus bulk, STM

In 2017, FD-SOI eco-system is in place with process offering from 65nm down to 12nm from four different foundries as well as IP and design services. Global Foundries has decided in 2017 to open a new 300mm foundry dedicated to FD-SOI in Chengdu as well as a global IP design center (figure 8-59).



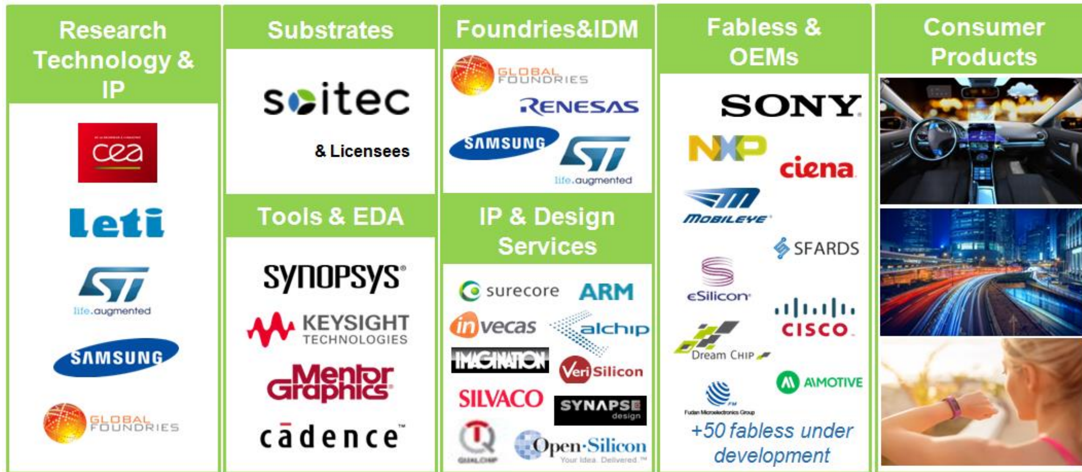


Figure 8-59 FD-SOI ecosystem, Soitec

8.5 Non Silicon Engineered Substrate

8.5.1 Non Silicon materials for RF

Silicon (bulk and SOI) is today mainstream in semiconductors industry with 98% of volume. It doesn't mean that non silicon materials are not of interest. As presented in this chapter introduction, when state of the art performances are required like in Front End Module, silicon is not dominant anymore.

Ideal characteristics of RF materials are:

- Loss less: high resistivity, low permittivity

  High resistivity means above 10kΩ.cm: it is at the limit of silicon capability. Low permittivity means by definition below silicon ($\varepsilon r < 11.3$). As an example, glass and ceramic are ideal. They are used for high end passive device, printed board circuit.

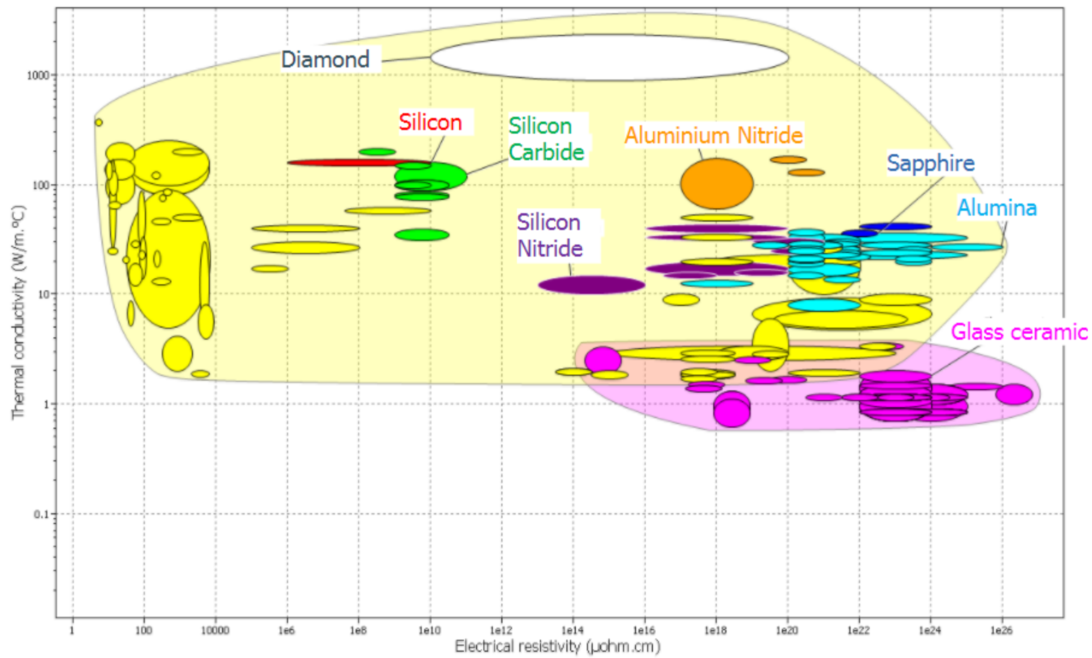


Figure 8-60 Sate of the Art materials electrical resistivity and thermal conductivity, Soitec

- High frequency capable: high electron and hole mobility
  High mobility means above 3000 cm2 V-1 s-1 for electron. Compound semiconductors are ideal, especially because mobility is not so much degraded under high current density. It makes GaAs an ideal substrate for cellular power amplifiers.

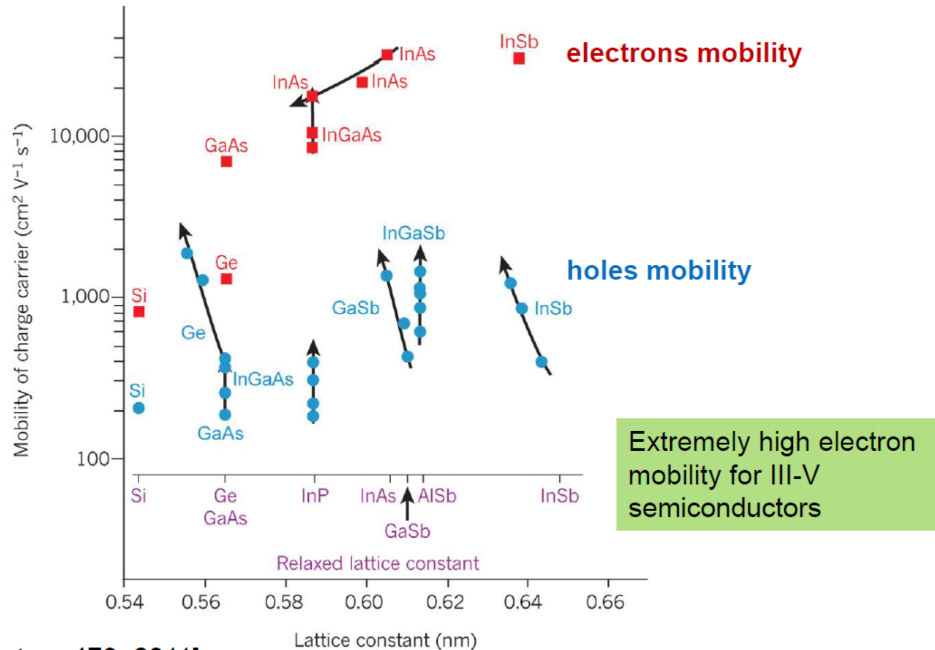


Figure 8-61 Sate of the Art materials' mobility, UCL

- High power and high voltage: high bandgap voltage and thermal resistance

  Silicon has 1.22V bandgap voltage. High bandgap material has >3V. For example: GaN, Silicon Carbine, Aluminum nitride, Diamond.

Silicon has thermal resistance of 148 $W.m^{-1.}K^{-1}$. Silicon Carbide and Diamond are much higher. Heat dissipation can be improved with proper packaging. For example, GaN has not state of the art properties whereas it is reference material for power.

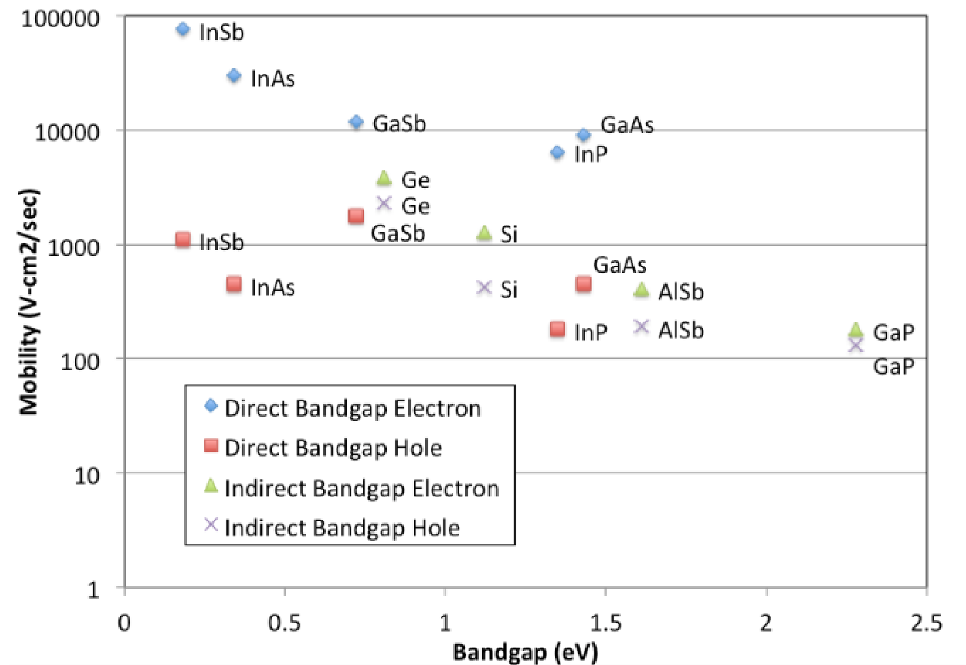


Figure 8-62 Sate of the Art materials' bandgap

In theory, there would be an infinite number of offers for engineered substrate materials to address dedicated RF applications. In practice, a strong eco-system is required in order to move new material into high volume production. Most of the time, integrated device manufacturers (IDM) are addressing those markets by developing their own IP and expertise on substrate, process and circuit design. As an example, Wolfspeed with CREE has developed a fully integrated supply chain from silicon carbide wafering to gallium nitride circuits (GaN on SiC) product lines. Part of the GaN market is then captive. GaN on Silicon is an alternative solution that has been developed. Most of GaN on silicon players are also developing proprietary process from wafers to end products. It limits then the development of pure play foundries offering and global eco-system serving high volume at competing cost. Except for Gallium Arsenide (GaAs), there is no real global eco-system on any other non silicon engineering substrate materials. As a result, GaAs ecosystem has pure foundries like Win Semiconductors, AWSC, new entrant like HiWafer and Sanan serving or on top of incumbent leaders like Skyworks, Qorvo, Broadcom.

This chapter of non silicon material for RF could be pretty exhaustive but since information are proprietary or addressing niche markets, we just present two examples in following sub-chapters.

8.5.2 Example 1: Indium Phosphide on Gallium Arsenide

In 5G mmW front end module roadmap, Indium Phosphide (InP) is often presented as the best material for power amplifier. As for 4G and 5G sub 6GHz front end module, it is interesting to note that standard silicon CMOS bulk is not seen as a process of choice.

The reason InP is the best material for 5G mmW power amplifier is that it has best Fmax* Breakdown voltage product figure of merit (FoM)(Figure 8-63). As presented in below figures, InP FoM outperforms GaAs and SiGe by 10x. State of the art one watt power amplifiers are today produced using InP bulk material (Figure 8-64).

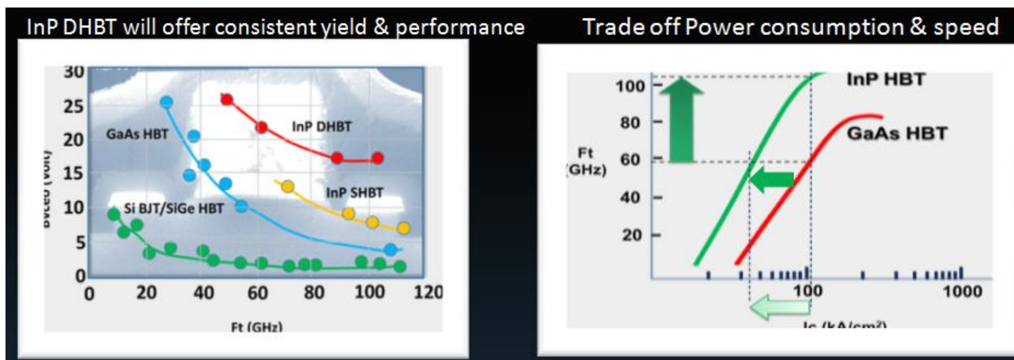


Figure 8-63 InP FoM, Skyworks

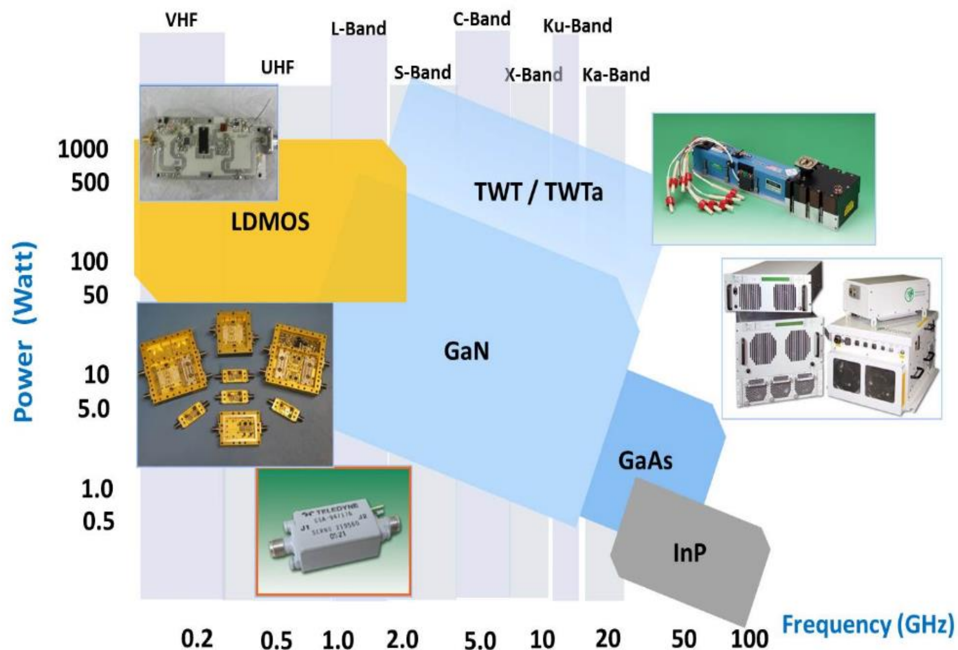


Figure 8-64 Power of PAs state of the arts

InP remains today dedicated to professional market. Main reason is that InP material supply doesn’t really exists. It is mainly available in 100mm size at extremely high price compared to 150mm GaAs wafer. For InP to become mainstream in 5G base station and handset, it is then

a must to have it available at competing price and in 150mm size. Using Smart Cut™, a new structure has been proposed: InP On GaAs (InPOGaAs). This structure removes all roadblocks of current InP to become mainstream. Affordable cost by re-using multiple time InP expensive bulk wafer, allows high volume manufacturing but also have low brittleness equivalent to GaAs and no InP waste. InPOGaAs wafers are fully compatible with GaAs epitaxy and process lines.

Figure 8-65 Why InP on GaAs, Soitec

InPOGaAs wafers prototypes were built and an epitaxy was performed. It shows excellent first time right DC transistors characteristics. A strong engagement of key players is now required to move InPOGaAs as a mainstream process.

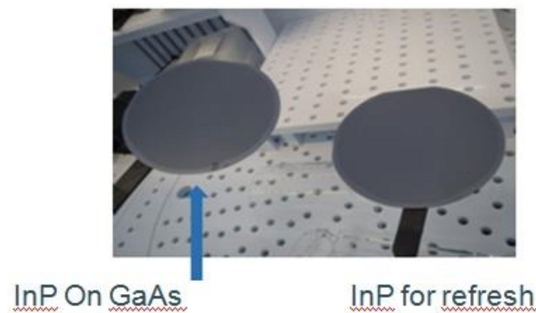


Figure 8-66 Soitec wafer prototypes InP On GaAs

8.5.3 Example 2: Piezo on Insulator

In handset front end module, filters content is dominating (Figure 8-67).

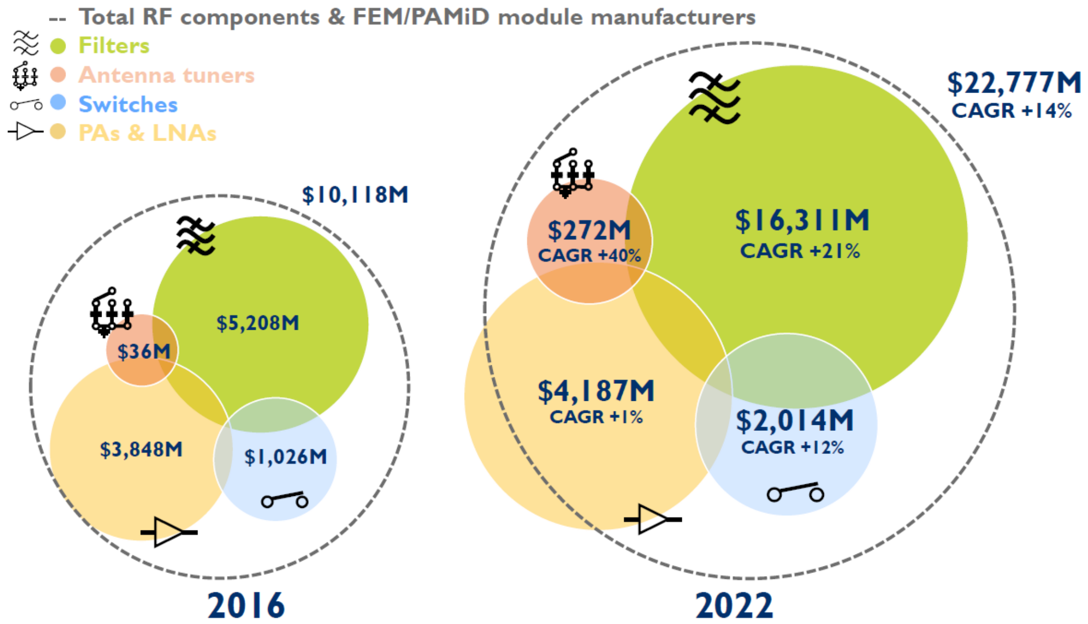


Figure 8-67 RF Front-End modules market, Yole

Filters are done with piezoelectric materials. Piezo materials allow exchange of electrical energy into mechanical energy and vis-versa. Filter market is the biggest in the MEMs market segment. There are two kinds of filter structures. Surface acoustic wave (SAW) filters and bulk acoustic wave (BAW) filters. In SAW, acoustic wave propagates on the surface of the material. Filter frequency is defined by the interdigital transducers (IDT) made with simple metal deposition. In BAW filters, acoustic wave propagate in the volume of the material. It is made of a piezoelectric material layer inserted between two metal layers. BAW structure is either above a cavity (FBAR – invented by Avago/Broadcom), or above a Bragg mirror (Figure 8-68).

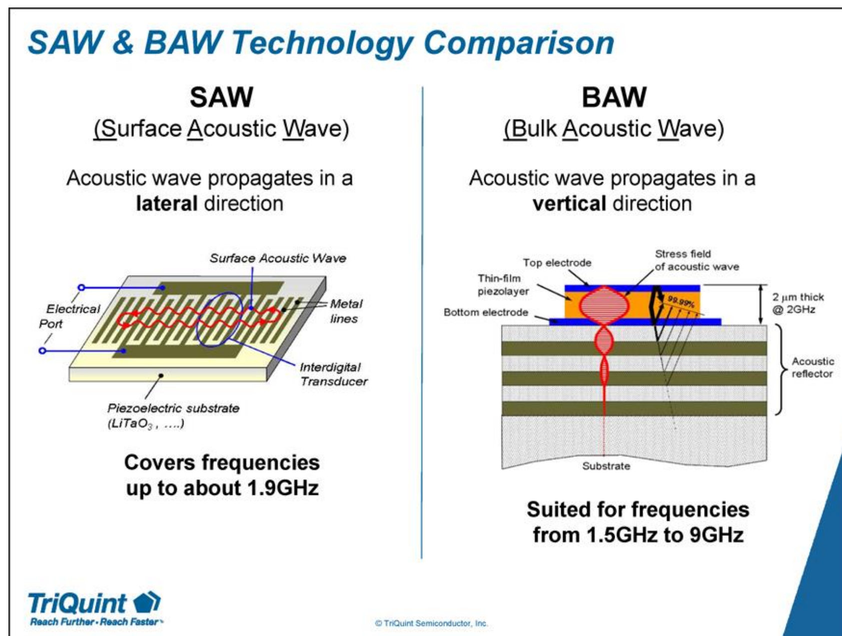


Figure 8-68 SAW versus BAW Technology comparison, Triquint (now Qorvo)

SAW filters address low – mid band and BAW addresses mid-high band frequencies (Figure 8-69). The temperature stability specifications of the filters are stringent in full duplex mode especially when guard band between Rx and Tx is limited or when other band are close by. If the specification of the temperature drift is below 20ppm/°C, the filters are said 'temperature compensated'. In extreme case, the requirement is to have a 'zero drift' frequency over the temperature range.

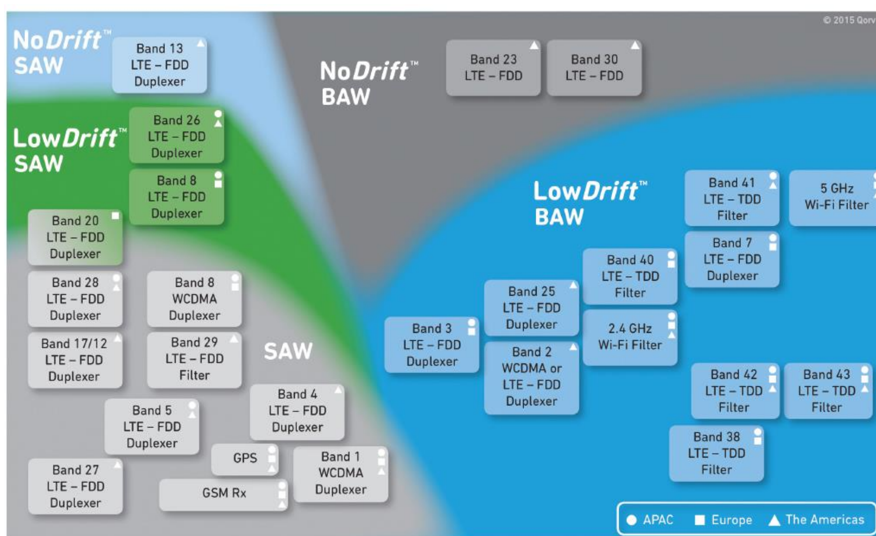


Figure 8-69 Type of filters versus Area Newtork bands, Qorvo

Piezo On Insulator (POI) defines a piezoelectric material on an insulator (Figure 8-70). For more than twenty years, theory has showed that new acoustic filters can be made using thin piezoelectric layers. Murata has announced and published in 2016 a new filter technology IHP standing for 'Incredible High Performance'. Murata claims that those filters are competing with BAW filters. The detail material stack used is not public.

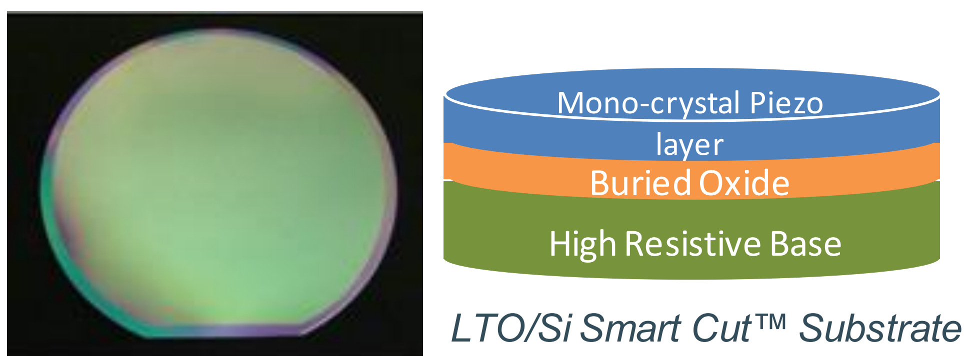


Figure 8-70 POI substrate, Soitec

Using Smart Cut™ and Smart Stacking™ technologies, complex engineered substrates for filters can be designed.